

AN ABSTRACT OF THE THESIS OF

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Title: DESIGN AND APPLICATION OF A MICROCOMPUTER AUTOMATED
MULTIELEMENT FLAME ATOMIC FLUORESCENCE INSTRUMENT

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J. U. Ingle, Jr.

An automated multielement flame atomic fluorescence (AF) spectrometer based on microcomputer control was constructed to determine four elements simultaneously. The instrument employs a multiple exit slit monochromator where the light from various exit slits is directed to a single detector with a mirrored funnel. Each element is excited to fluoresce with a single element hollow cathode lamp (HCL) and a time multiplex mode is used for pulsing the HCL's and data acquisition.

A SYM-1 microcomputer is the center of the system and controls the pulsing of HCL's, sample introduction into the flame, data acquisition, and other electronic components. Values for the experimental variables such as the HCL pulse rate, peak current, and pulse width are selected at the computer's terminal.

The HCL and background signals for each element are integrated for equal periods of time selected from 0.5 to 250 ms. The integrated background (lamp off) signal is subtracted from the HCL (lamp on) signal to correct for the non-lamp related portion of the

signal.

For most measurements, an air/H₂ flame sheathed with Ar was the atomizer. Numerous experimental variables were optimized including HCL current and fuel and oxidant flow rates.

For single element flame AF under optimum conditions, the following detection limits (in ng/mL) were obtained: Au, 2.2×10^2 ; Cd, 4.8; Co, 26; Cu, 3; Fe, 50; Mg, 0.8; Mn, 7; Ni, 36; Pb, 1.0×10^3 ; Zn, 21. For multielement flame AF under compromise conditions, the following detection limits (in ng/mL) were obtained: Cd, 10; Cu, 4; Mg, 1.5×10^2 ; Zn, 1.1×10^2 .

With a sheathed air/C₂H₂ flame in the multielement mode, the following detection limits (in ng/mL) were obtained: Cd, 7.7×10^2 ; Cu, 1.3×10^2 ; Mg, 18; Zn, 4.3×10^3 . The higher flame background emission noise degraded detection limits compared to the air/H₂ flame.

The system was studied briefly in a nondispersive multielement AF mode with a set of filters installed directly in front of the detector window. The following detection limits (in ng/mL) were obtained under multielement flame AF conditions with an air/H₂ flame: Cu, 33; Mg, 16; Mn, 76.

The relative standard deviation of measurements for single and multiple element determinations was typically 1% or better for concentrations well above the detection limit.

Design and Application of a Microcomputer
Automated Multielement Flame Atomic Fluorescence Instrument

by

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Typed by Marcy Brown for _____ Shahrokh Graffari Neyzari

DEDICATED TO

my wife

Gisla (Ghaemi) Ghaffari

Whom I (X)[∞] the most,

With special thanks to

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DESIGN AND APPLICATION OF A MICROCOMPUTER
AUTOMATED MULTIELEMENT FLAME ATOMIC
FLUORESCENCE INSTRUMENT

INTRODUCTION

Instrumentation which allows simultaneous determination of several elements provides important advantages compared to instruments which allow determination of only one element at a time in a sequential manner. These advantages include reduction of the sample size required and increased speed of analysis. These benefits can increase the simplicity, reliability, and cost effectiveness for analyses requiring determination of several elements in clinical, metallurgical, biological, industrial, and environmental samples.

Automation is an important attribute of modern analytical instrumentation. The availability of microcomputers has spurred the development of automated instruments. Automation with microcomputers enhances the basic advantages of multielement instrumentation. The amount of data produced per unit time is greater with a multielement instrument. Automated rather than manual data acquisition and manipulation frees the operator from tedious tasks. This reduces post analysis time and increases the overall sample throughput. The use of microcomputers also makes it easier to implement automated sample introduction and to control and to optimize the experimental variables.

Many methods for multielement analysis have been developed based on x-ray, nuclear, chromatographic and electrochemical methods of ana-

lysis. Single element spectrometric techniques have been proved to be easily adapted to multielement techniques. Most multielement spectrometric techniques are based on atomic spectrometric methods involving the formation of an atomic vapor of the analyte in the sample and the excitation of this atomic vapor. These techniques can be divided into three major categories: (a) atomic emission (AE), (b) atomic absorption (AA), and (c) atomic fluorescence (AF). At this time, AE is the most popular method for multielement analysis and the least popular method is AA. In AF, the subject of this thesis, photons from an excitation light source are absorbed by the atomic vapor and excited atomic states are produced. The photons emitted from these excited states are measured at 90 degrees to the excitation beam.

The multielement system that has been developed in our laboratory by Salin (1) is capable of flame AA or flame AF measurements. The research in this thesis is concerned with the improvement of this instrument with many modifications including incorporation of a micro-computer.

The instrument built by Salin is a time multiplex multiple slit (TMS) system which employs a multiple exit slit array in the focal plane that is manufactured from one piece and the position of each slit is selected to correspond to the resonance wavelength of one element. The light exiting from all slits is directed to a single detector with a mirrored light funnel. For each element being determined, a separate single element HCL is used to excite analyte fluorescence, and the different HCL's are sequentially pulsed (time multiplex arrangement).

For the work in this thesis, the instrument was modified only for use in the AF mode. Compared to the AA mode, the AF mode is simpler, requires fewer optical components and is easier to optically align. Moreover, manufacturing of the exit slit array is much simpler compared to the ones made for the AA system (1) because much larger slit widths are employed. Also, excess light problems are less severe than for the AA mode. Excess light is light from other HCL's that passes through the slit for the element of interest. In the AF mode, this arises only for wavelengths which are a resonance wavelength for another element and not for non-resonance lines from the HCL's if scattering is not significant. This problem of excess light can be eliminated or minimized by using a filter in front of a given slit to block unwanted wavelengths or an interference calibration curve can be made for correction of measured analytical signal.

Lamp pulsing and data acquisition were controlled by a hard wired digital circuitry in the Salin instrument. A major step in the improvement of the Salin instrument was incorporation of a single board SYM-1 microcomputer to control the operations available on the Salin instrument and also to provide many new options. These options allow the user to control by input at a terminal various HCL parameters (pulse rate, pulse width, peak current), data acquisition parameters (delay times, number of data points per pulse, and number of pulses averaged), and sample (blank and analyte solution) introduction into the flame.

To utilize the microcomputer, various electronic circuits were modified including the circuitry for pulsing the HCL's. Several new

circuits such as an analog-to-digital converter (ADC), and a digital-to-analog converter (DAC), power supplies, a two byte multiplexed up-down counter, and an automated start switch were built. Non-electronic hardware modifications include construction of an annular shaped HCL mount, expansion of the burner gas control system, addition of two telescopic tubes to shield room light and construction of two burner heads--capillary and Meker--for insertion into a Jarrell-Ash nebulizer. Additionally, provision was made for water cooling of the burners and gas sheathing of the flame, and a computer controlled automated sampler for introduction of sample into the flame was built.

Extensive software was also developed. The software coordinates the timing of the various operations such as lamp pulsing and data acquisition. Additionally, the software allows the user to communicate with the instrument and to change the magnitude of experimental variables. Data manipulation options include calculation of the mean and standard deviation of blank and analyte signals, and calculation of detection limits, shot noise, and signal to noise ratios (S/N). Data from standards are fitted to provide a calibration curve and automated reporting of the analyte concentration in unknowns.

The system was studied in the single element AF mode. All determinations in the single element mode were made with an air/H₂ flame sheathed by Ar gas and Meker type of burner head. For each element the instrument was optimized for maximum S/N. Variables optimized include wavelength, burner head position (x, y, and z axes), oxidant and fuel flow rates, Ar flow rate (sheathing gas), HCL peak current,

HCL position with respect to the flame, data acquisition parameters and HCL pulse rate and pulse width.

Calibration curves are linear over three orders of magnitude. Higher lamp current does not significantly degrade the linearity of the calibration curves at the higher concentrations in most cases.

Precision curves (plots of relative standard deviation (RSD) vs analyte concentration) show 1% or better precision for single element AF measurements at concentrations well above the detection limit. The detection limits obtained for ten elements, compared to those reported by Salin (1), are lower by factor of 3 to 7, except for Mg, for which the detection limit is lower by factor of 50.

For simultaneous multielement measurements, four elements, Cd, Cu, Mg, and Zn, were selected from the ten elements studied in single element mode. A sheathed air/H₂ flame with a Meker type of burner head were used for this part of the study. The same variables which were optimized for single element measurements were also considered in multielement optimization procedure. Optimum conditions for multielement measurements are not necessarily the optimum condition for any one of those elements; but in fact, the optimum conditions are a set of compromise optimum conditions. The detection limits obtained under compromise multielement conditions were within a factor of 2-5 of those obtained in a single element mode except for Mg. A RSD of 1% or better was obtained for all elements at higher concentrations.

These same elements were measured in the multielement mode with a sheathed air/C₂H₂ flame. The detection limits obtained were well above those obtained with a sheathed air/H₂ flame due to the increase

of flame background noise.

The multi-element AF instrument was briefly studied in a time multiplex nondispersive mode. The modification from a dispersive to a nondispersive system involves replacing the monochromator with a set of interference filters in front of the single detector. This system is much simpler to work with and less expensive to manufacture. The detection limits compared to those obtained by dispersive system are higher because the interference filters used in nondispersive system have a larger bandpass which significantly increases the flame background emission and scattering signals and noises. These decrease the range of linearity of calibration curves and compared to those obtained with the dispersive system. Measurement precision is as good as with the dispersive system for concentrations well above the detection limit.

HISTORICAL

In this section multielement atomic spectrometric techniques are discussed since the TMMS AF multielement instrument developed for this thesis research falls into this category of techniques. Atomic spectrometric techniques are based on atomization of the elements in a sample with a flame, plasma, or electrothermal atomizer. The emission, absorption, or fluorescence in the UV-visible region from the atomic vapor is then measured. Multielement atomic spectrometric instruments vary in design based on the optical phenomenon (emission, absorption, or fluorescence) that is measured and on the method that is used to distinguish and measure the optical signal from each element which is encoded at a particular wavelength.

The general characteristics of atomic multielement spectrometric measurements are first reviewed. Then recent developments in multielement atomic absorption, atomic emission, and atomic fluorescence instruments are discussed in turn. The Historical section concludes with a more detailed description of the TMMS AF instrument built by Salin since it represents the starting point for this research.

General Characteristics of Multielement Atomic Spectrometric Systems

The difference between multielement atomic spectroscopy and single element spectroscopy is not the atomization cell or light source, but the methods by which the optical information is selected and directed. The optical signal from each element at a different

wavelength must be distinguished. Winefordner et. al. (2) provide a superb discussion of the approaches used in multielement atomic spectroscopy which can first be classified by their optics as either dispersive or nondispersive. Dispersive techniques employing monochromators, polychromators, or spectrographs are most commonly used. In dispersive systems, the radiation from the source is focused on the entrance slit, collimated, and then directed to the dispersion device, a prism or a grating. The dispersed radiation is incident upon a focal plane where radiation over a small wavelength is selected and observed by an exit slit-detector combination or a small detector element. Nondispersive systems do not use monochromators but rather use filters or some form of spectral or time-based encoding to give element selectivity.

Dispersive systems can be temporal, spatial, or multiplex. Temporal devices use one single detector. Therefore the information collection is "sequential" or only one spectral element falls on the detector at any given time. Spatial systems employ multiple detectors or a multichannel detector. The spectral information from each spectral element falls on a separate detector or a different element of a multichannel detector simultaneously and independently (in a parallel fashion). The most common spatial detection system is a direct reader. They are used in arc and spark emission spectrographs as the replacement for photoplates and film. Direct readers are monochromators with many slits on the focal plane and a separate photomultiplier tube (PMT) behind each slit.

With multiplex systems one detector receives signals from

different spectral components of the spectrum. These signals are encoded in such a way that the signals corresponding to different spectral elements (e.g. wavelengths) can be distinguished. The signal from each spectral element can be encoded with respect to time (time multiplex) or different frequencies (frequency multiplex). Fourier transform spectroscopy (FTS) or dispersive Hadamard transform spectroscopy (HTS) (3) methods are frequency multiplex techniques. FTS is a nondispersive technique in which an interferometer is used to encode the wavelength information.

The PMT has become the primary photoelectric detector since its inception. A wide selection of tubes is now available to cover different zones of the spectrum (200 to 900 nm) with good amplification which makes it the detector of choice in most UV-visible optical spectrometers.

The image dissector photomultiplier tube (IDT) has been designed to overcome the limitations of the PMT as a detector device in multichannel systems (2, 4-8). An IDT is very much similar to PMT except it has a magnetic focusing circuitry that focuses photoelectrons from any point on the photocathode onto an aperture that directs the electrons to the dynodes. The IDT is placed in the focal plane of a spectrograph so that the spectrum is dispersed across the photocathode. Thus the signal from different areas of the photocathode and different wavelengths can be sequentially read.

Imaging devices, such as photodiode arrays and Vidicon target tubes are truly multichannel detectors. They consist of a series of discrete miniature photosensitive elements which each intercept at a

different small wavelength range when put in the focal plane of a spectrograph. The number of electrons-hole pairs generated by the photons impinging on detector elements is interrogated sequentially after a selected integration time. This is done with an electron beam in a SIT and with direct coupling and switches in a diode array (9). Both systems have been widely used in multielement atomic spectroscopy instruments (8, 10-17). These devices suffer from low S/N for low light levels because they have no internal gain and a relatively large electronic readout noise (2). The introduction of silicon intensified target (SIT) Vidicons has reduced the S/N problem by providing internal gain. The gain of the SIT is due to the acceleration of single photoelectrons before they strike the detector elements. Microchannel plate intensifiers have been placed in front of diode arrays to improve the S/N. Multichannel detectors are quite expensive when intensified and both Vidicons and diode arrays require a computer to process the great amount of information produced.

There are two types of excitation sources for multielement AAS and AFS, line sources and continuum sources. Hollow cathode lamps (HCL) and electrodeless discharge lamps (EDL) are the most commonly used line excitation sources. The xenon arc lamp is the primary continuum excitation source used for AAS and AFS. It has high intensity over a wide wavelength range.

A high resolution echelle monochromator (18-21) is required for AA with a continuum source to isolate a wavelength band as small as an absorption profile. Also they are useful for plasma emission system to isolate analyte narrow emission lines from other lines that can

cause spectral interference.

The concept of the echelle grating was developed in the late 1940's by Harrison and coworkers (7). An echelle monochromator has a very high dispersion and resolution. An echelle grating is used to disperse the spectrum in the horizontal direction and another cross-dispersion element, which can be either a prism or another grating, is used to disperse the spectrum into a two-dimensional format. Cross dispersion is required because the echelle grating is used with high orders which results in a small free spectral range. The disadvantage of the echelle system is a nonuniform spectral format when a prism used as a cross-dispersion element.

Multielement atomic absorption techniques

A primary concern in a multielement atomic absorption spectroscopy (AAS) system is alignment of several single element lamps to allow the radiation from all sources to be focused and directed down the same optical axis through the atomizer (e.g. a flame). This is difficult for a large number of sources and thus limits the number of elements that can be determined simultaneously. This problem was somewhat circumvented by combining radiation from different angles into one beam (1, 22-23) or by use of multielement HCL's (7, 24, 26) or a single continuum excitation source (27-29). In spite of being the most suitable instrument for single element analyses, AA still remains the least favorable technique for multielement analysis.

To overcome this alignment problem, Mavrodneou (21) used a grating to combine the radiation from different light sources and

directed the combined beams through a flame into a direct reader.

Rawson (23) used fiber optics to combine the light from five different HCL's into a single quartz tube called an integrator and directed the combined beam into a flame. Unfortunately the tube was short and caused incomplete mixing of radiation from the lamps inside the tube. He also used rectangular fiber optics as exit slits to direct the desired resonance lines into the PMT's of his direct reader.

Butler et. al. (24) used a multielement HCL as their light source with a direct reader configured with four moveable slits. Flame atomization was employed.

The application of rapid scanning spectrometers (RSS) to AAS analysis was studied by Rose (26, 30) and Dawson (31). An instrument of this type can scan a selected wavelength window or region on a time scale ranging from a few microseconds to several seconds.

Rose et. al. (26) modified an oscillating mirror rapid scanning spectrometer as a detector for a rapid simultaneous multielement AA system with electrothermal atomization. They used a zinc, cadmium, lead and copper multielement HCL as an excitation source and a PMT as the detector device. No data were reported for zinc due to the presence of zinc in their deionized water and the problems associated with Zn determinations by furnace AA. The detection limits in ng/mL obtained with this system using a carbon furnace atomizer were Cd (0.3), Pb (7), and Cu (5).

Dawson et. al. (31) demonstrated the potential of a RSS which utilized an oscillating diffraction grating as the scanning mechanism.

Coupled to an automatic sampler, the instrument was applied to simultaneous multielement analyses of clinical samples. With an air/C₂H₂ flame, Na and K were determined by AE and Ca and Mg by AA. The detection limits in $\mu\text{g/mL}$ were Na (0.06), K (0.4), Ca (0.08), and Mg (0.02). The analytical precision was approximately 3%.

Felkel and Pardue (7) studied the performance of an IDT coupled to an echelle grating spectrometer for simultaneous multielement AA measurements. The detector system and monochromator were computer controlled. The detection limits reported in $\mu\text{g/mL}$ were Cr (0.024), Cu (0.022), Fe (0.160), Mn (0.019), Ni (0.13), Co (0.52). Data reported were obtained with a multielement HCL containing Cr, Cu, Fe, Mn, Ni, and Co with an air/C₂H₂ flame as the atomizer source.

Horlick (10, 14) used a diode array in his multielement flame AAS for detecting two elements at time. He used a small array (256 elements, 0.25 in.) which enabled him to view a larger spectral range for additional elements. The report does not present AA sensitivities or detection limits.

Salin (1) developed a time multiplex multiple slit (TMMS) instrument for multielement AA measurements. He used single element HCL's in a pulsed mode of operation. The radiation from the HCL's is directed through the flame along one optical axis by using the beam splitters. The detection limits in ng/mL obtained for flame AA measurements were Au (50), Cd (8), Co (300), Cu (5), Fe (60), Mg (20), Mn (5), Ni (50), Pb (50), and Zn (20), and using carbon rod atomizer were Cd (0.2), Mn (2), Pb (8).

O'Haver et. al. (18) used a continuum source AAS with echelle

monochromator. The monochromator was modified for wavelength modulation with a quartz refractor plate to correct for nonanalyte absorbance at all wavelengths. A 200 W Hg-Xe arc and a 150 W Eimac Xe arc lamp were used as the continuum sources. A PMT was used as the detector device with an air/C₂H₂ flame. Linearity of the standard curves and detection limits compare well with standard curves for background corrected AAS with a line source. Sensitivities were poorer by a factor of 2-5.

This same system was modified to demonstrate its capability for correcting all major types of spectral interferences and for simultaneous multielement AA measurements (19). The modified instrument was computer controlled. Detection limits in µg/mL were Mn (0.006), Zn (0.06), Fe (0.06), Cu (0.01), Ni (0.4), Cr (0.01), V (0.4), Co (0.08), Sn (33), Mg (0.0003), Ca (0.003), Na (0.003), K (0.2).

Codding et. al. (15) evaluated a self-scanned linear photodiode array as a multichannel detector for a flame AAS. Electronic readout noise was the dominant noise source under all experimental conditions. All measurements were made with an air/C₂H₂ flame atomizer. A beam splitter was used to combine the radiation from single element HCL's. Simultaneous multielement determinations were performed with Mn and Mg as analytes and with Cu and Ag as analytes. Reported detection limits in µg/mL for a 1 s integration time were Ag (0.081), Cu (0.097), Mg (0.006), and Mn (0.046), and for 5 s integration time, were Ag (0.023), Cu (0.022), Mg (0.001), and Mn (0.011).

The Perkin-Elmer Co. has developed an automated sequential AA/AE system (32). The Perkin-Elmer Model 5000 conjunction with its automated

sequential multielement sample-handling system has the ability to analyze many samples for many elements. This system is essentially a highly automated single element AAS and is computer controlled. The wavelength, flame conditions, and the HCL position and current are selected for a given element and the absorbance is measured. This sequence of selection of measurement condition and measurements is automatically performed for all elements selected. This system can use both flame or furnace atomizer.

Lundberg and Johansson (25) developed a non-flame AAS. The system utilized a set of fixed exit slits corresponding to the elements of interest. A disc with suitable sections removed, rotated behind the set of slits and sequentially blocked and unblocked the different slits at a high rate. This allowed only one slit to be open at a time. A multielement HCL was used as an excitation line source. The background nonanalyte absorption was corrected by a hydrogen continuum lamp. Twenty background and analyte line measurements were made for each element per second. The detection limits are reported in pg for 2 μ L sample size as follows: Mn (2.0), Co (20), and Cu (8.0). Also they claimed their multislit spectrometer has somewhat better sensitivities compared to Varian Techtron AA6, but detection limits are higher by factor of 2-4.

Multielement atomic emission techniques

One can date the beginning of simultaneous multielement analysis by atomic emission spectroscopy (AES) back to the development of emission spectrometers with photoelectric detection in the 1940's.

Emission spectrometry is inherently the measurement mode most easily adaptable to multielement measurements since an external excitation source is not required. The atomizer is also the excitation source so that it is only necessary to distinguish and detect the emission at different wavelengths corresponding to different elements.

During the past decade, the inductively coupled plasma (ICP), direct coupled plasma (DCP), and microwave inductively coupled plasma (MIP) have replaced the flame or arc and sparks as the most popular emission excitation sources (8, 33-37). The high temperature plasmas provide efficient atomization and excitation of most elements at the expense of high background emission. Different techniques are available to reduce this background problem (38, 39).

Many of the commercial ICP systems in use today are direct reading polychromators (fixed wavelength) for simultaneous determination of 20-40 elements (33). These systems are not economically feasible when only a few elements are to be determined in each run. Computerized scanning monochromators for sequential reading are useful alternative to expensive and inflexible direct reading systems (33, 36). High resolution echelle monochromators are also employed in the ICP systems with a PMT for simultaneous analyses (34) or with multichannel detectors (18).

Berman and McLaren (34) assembled an ICP emission spectrometer for simultaneous multielement analysis. They used an echelle monochromator and made an extensive study of line/background ratios of atom and ion lines as a function of observation height, power, and aerosol Ar flow rate for several elements. No detection limits were

presented.

Fricke et. al. (35) compared several microwave cavities with Ar/He or He plasmas for the simultaneous determination of As, Ge, Sb, and Sn. The microwave induced plasma involves capacitatively coupling microwave energy into a flowing gas within a quartz tube (2). A polychromator configured as a direct reader was used with a 25 m entrance slit and 75 μm exit slits. They concluded that a Beenaker cavity using a pure He plasma is the easiest to tune and to operate and provides the most reproducible results. The detection limits reported in ng/mL were As (2.0), Sb (1.9), Ge (1.5), and Sn (2.0).

Rose et. al. (37) used their modified RSS for simultaneous microwave induced AES determination. The reported detection limits in $\mu\text{g/mL}$ were Zn (0.07), Bi (0.7), Cd (0.02), Mn (0.04), Mg (0.02), and Cu (0.09).

Pardue and Felkel (8) interfaced an echelle spectrometer to a SIT and IDT for multielement determination with a DCP excitation source. Spectral resolutions obtained varied from 0.4 to 0.9 \AA or the Vidicon system and 0.2 to 0.7 \AA with the IDT system. They extensively studied interelement effects, sensitivity, and S/N's for both systems. The detection limits obtained with IDT in $\mu\text{g/mL}$ were Li (0.27), Na (0.027), K (0.15), Mg (2.7), Ca (0.023), Sr (0.039), and Ba (0.076).

Caruso et. al. (35) compared a commercial ICP direct reader system (Jarrell-Ash Model 1160 Plasma Atomcomp) to a laboratory constructed ICP sequential detection system based on a computer controlled scanning monochromator system. The precision of the polychromator system is slightly better to that obtained with the

sequential slew scanning system. Detection limits reported in $\mu\text{g/g}$ for the polychromator system were Cd (0.004), Cu (0.003), Fe (0.003), Mg (0.0008), Mn (0.002), Mo (0.004), P (0.02), and Zn (0.005) and for sequential system were Cd (0.002), Cu (0.002), Fe (0.003), Mg (0.0002), Mn (0.0009), Mo (0.06), P (0.2), and Zn (0.007).

Olsson et. al. (36) studied a computerized sequential reading monochromator system for AES with an ICP as excitation source. The computer controls the grating rotation in the 200 to 430 nm wavelength range. Data acquisition, sample changing calibration, and background correction all are controlled by computer. No detection limits are reported.

Winefordner et. al. (29) developed a computer controlled AF/AE spectrometer for simultaneous multielement analysis. The system consists of a slewed scan monochromator with a PMT as the detector. For the AF mode of operation, a xenon arc (EIMAC) lamp is used. A quartz refractor plate-torque motor assembly is mounted behind the entrance slit of the monochromator and modulates the wavelength. A synchronous photon counting system is employed for detection. This arrangement provides a net signal consisting of emission plus fluorescence, continuous background emission correction, and correction for scatter from the continuum source. The detection limits for 19 elements in the N_2 separated air/ C_2H_2 flame and for 6 elements in the N_2 separated $\text{N}_2\text{O}/\text{C}_2\text{H}_2$ flame are reported for all three modes of operation: AF, AE, and AE/AF. The detection limits ranged from 3×10^{-4} mg/mL for Na (AE/AF mode) up to 12 mg/mL for Pb (AE mode).

Busch et. al. (16) developed a multielement emission spectro-

meter based on a SIT. To overcome the limited wavelength coverage associated with a one dimensional system, a multiple entrance slit was constructed from an aluminum plate with a horizontal row of 1.588 mm diameter holes spaced on 4 mm centers. This produced 29 holes across the 12 cm exit port opening. Then each hole was masked from behind the plate with two pieces of black tape to form an entrance slit 1.6 mm high. Polyvinylchloride fiber optic light guides were chosen to direct the light from the N_2O/C_2H_2 excitation source to the individual entrance slits. The diameter of the fiber optic light guides was selected so that each fiber optic strand could be plugged into each one of the 29 possible holes. The input end of each fiber optic was fitted with a lens which was mounted on a vertical slotted plate to permit individual adjustment vertically from 3 to 40 mm above the burner head. Detection limits obtained in g/mL were Mn (0.46), Cr (0.56), Sr (0.041), Ba (0.50), Li (0.013), and K (0.84).

Korba and Yeung (40) used a scanning Fabry-Perot interferometer for multielement flame emission analysis. A PMT was used as the detector and a total consumption burner with a H_2/O_2 flame as the excitation source. Reported detection limits in ng/mL were Mn (65), K (24), Rb (60), Ca (19), Cr (220), In (12), Sr (160), Ba (550), Na (0.7), and Li (45).

Multielement atomic fluorescence techniques

Atomic fluorescence spectroscopy (AFS) has received considerable attention as the basis for multielement analysis systems. AFS offers several distinct analytical advantages over the other methods, espe-

cially AAS (41). Compared to AAS, AFS can provide lower detection limits for some elements and calibration curves linear over a much larger concentration range. Also alignment of the excitation sources is much simpler since the emission and excitation optical axes are independent. AF spectra have fewer lines than AE spectra which enable lower resolution monochromators to be employed (2).

Since the AF intensity depends linearly on the source intensity, the ideal experimental set up for AFS employs a high intensity excitation source. Also a high efficiency atomization system with low background is critical (42). Tunable dye lasers are excellent excitation sources for single element AFS analysis (43-45). High intensity laser radiation can result in near saturation of upper energy level involved in the fluorescence transition. Operating at saturation is advantageous because the fluorescence radiance does not depend on the source intensity or the quantum efficiency of the transition (46-48).

Unfortunately, the cost of using many lasers tuned to different excitation wavelengths in a multielement AF system is cost prohibitive. A single dye laser can be used in a sequential multielement system although the wavelength range of tuning and the ease of tuning are restrictive. Winefordner et. al. (49) recently used a frequency-doubled, flashlamp-pumped, tunable dye laser for determination of nickel and tin in a nitrogen-separated air/C₂H₂ flame. They used the non-resonance nickel fluorescence line near 340 nm and tin fluorescence line at 317.5 nm with a 0.1 m monochromator and a PMT modified for pulsed, high current operation. The lowest detection limits obtained for nickel was 0.5 ng/mL and for tin was 3 ng/mL.

HCL's and EDL's are the most commonly used line excitation sources used for AF. HCL's do not have high enough output intensity for AF unless they are operated in a pulsed mode. There have been several interesting studies on pulsed HCL's (50-57) and comparisons of pulsed to DC current operation (42, 57). The pulsed HCL technique was applied originally by Mitchell and Johansson (58) to AFS measurements. Also this xenon arc lamp is used as a continuum excitation source for AFS (5, 26-29, 59).

Recently Winefordner et. al. (60, 61) used an ICP as an excitation source for flame AFS. A low resolution monochromator coupled with PMT as the detection device was used. The solution used for excitation of analyte emission from the ICP contained 10 to 20 mg/mL of the analyte. Several analytical flames are employed in this study. The effect of interferent contamination in the excitation solution is discussed. They reported an analytical precision of 1-2% at high concentrations and discussed the capability of an ICP excitation source for multielement analysis.

West and co-workers published a series of papers (62-67) on a sequential AFS system utilizing a wavelength scanning monochromator with dual element EDL's as light sources. Four elements could be scanned in about 1.5 min. The detection limits obtained by air/C₂H₂ in g/mL were Co (0.02), Ni (0.02), Cd (0.002), and Zn (0.003).

A slewed-scan (programed scan) dispersive system that utilizes computer control can save considerable analysis time and provide greater versatility over a linear scan system. Here the monochromator scans very fast between the analytical wavelengths of interest.

Malmstadt and co-workers (55, 68-70) used the programmed rapid scan approach with pulsed HCL's as light sources. A pre-mixed air/C₂H₂ or an Ar/H₂ diffusion air or oxygen flame were used for atomization. The detection limits obtained with the H₂/O₂ flame (68) in ng/mL were Cu (0.001), Cd (0.05), Cr (0.5), Fe (0.05), Mg (0.001), Ni (0.07), and Zn (0.02). Later the AE mode was added to their instrument and they were able to determine up to 8 elements by AFS and up to 25 elements by AES (69, 70). They employed a quartz refractor plate for background correction. The gain of the PMT was automatically adjusted for each element under computer control. This instrument was used to analyze a variety of clinical samples.

Winefordner and his co-workers also used the previously explained slewed-scan monochromator approach with a xenon arc lamp as an excitation source multielement for AE/AF (29).

Brinkman et. al. (71) used a slew-scan AF spectrometer with a xenon arc lamp for both AE and AF measurements with no background correction. The instrument was used to analyze oil samples using a standard addition procedure. Reported detection limits in $\mu\text{g/mL}$ for the air/C₂H₂ flame were Cd (0.3), Cr (0.4), Fe (0.7), Mg (0.02), Ni (0.8), Pb (1.0).

As previously mentioned, AFS does not require a high resolution monochromator. In fact, some multielement AFS systems do not use monochromators (non-dispersive).

Mitchell and Johansson (58, 72) used modulated HCL's and AC detection to electronically distinguish the analyte AF signal from the flame background emission signal. A rotating wheel containing four

interference filters was used for sequential wavelength selection. This four-element AFS instrument evolved into the Technicon's AFS 6 (9). Their instrument used four HCL's which were pulsed on-off in synchronization with placement of the appropriate interference filter in the emission optical path. The detection limits in $\mu\text{g/mL}$ were Ca (0.003), Cd (0.03), Co (0.06), Cr (0.02), Fe (0.03), Mg (0.005), Ni (0.08), Pb (0.07) in an air/ C_2H_2 flame.

A non-dispersive multielement AF spectrometer using pulsed HCL's and computer control system was developed by Palermo et. al. (73). They used a "solar blind" PMT with a photocathode which is sensitive only in the UV region. HCL's were pulsing sequentially. Therefore the fluorescence signals were also pulsed and each detected pulse was associated with a different HCL (element). The detected pulses were multiplexed in the time domain. Duration of the "on" pulses was 2-10 ms, depending on the atomizer (flame or electrothermal) used. The delay time before the next lamp was turned on was about three times the "on" time. Each cycle was repeated about 20 times in order to improve the S/N. The reported detection limits in $\mu\text{g/mL}$ with sheathed air/ H_2 were Cd (0.02), Hg (2.0), Pb (50), and Zn (0.2), and with a Pt-loop atomizer, were Cd (0.005), Hg (0.5), and Zn (2.0).

More recently Thamssen et. al. (74) described a multielement time multiplex AF system for direct analysis of air filters which is very similar to that just described, except no computer was used. A modified Perkin-Elmer graphite furnace was used to ash and volatilize the filter. The volatiles were directed into an air/ C_2H_2 flame. They used 4 HCL's or EDL's as the light sources.

In 1981 Baird^a introduced a HCL-ICP-AFS spectrometer, which is called the Plasma/AFS spectrometer (75-77). In this system an ICP is the atomization source and a separate wavelength selection and detector module is used for each element. Each module consists of one HCL, one PMT, an optical interference filter, and lenses. The modules are arranged around the plasma. Radiation from the HCL in a given module is directed into the plasma and the AF radiation generated in the plasma is passed through the optical interference filter to be detected by a PMT of the same element module. The instrument is a non-dispersive and operates in a rapid time division multiplex mode. HCL's are pulsed sequentially and at any given time, only one AF signal is being produced and detected. They claimed less spectral overlap interference was observed with HCL-ICP-AFS than with flame AAS, except for the nickel interference on antimony. The detection limits for 32 elements are reported, and compared with two other methods, flame AAS and ICP-AES. For most elements, detection limits are very comparable except for the refractory elements which are worse up to more than 2 orders of magnitude in some cases. They obtained a linear ranges of about 5 orders of magnitude for Ca and Ag.

Up to date, no one has used a photodiode array as a detector in multielement AFS. Chester et. al. (13) have evaluated the use of a SIT tube for multielement combined AE/AFS system. For multielement determinations, the monochromator has to be slewed 8 times to cover most of the analytical useful wavelength region (200-500 nm) in sec-

^aBaird Corporation, 125 Middlesex Turnpike, Bedford, MA 01730

tions. Detection limits in $\mu\text{g/mL}$ in air/ C_2H_2 were Cd (1), Co (1), Cr (0.04), Fe (0.7), Mg (0.006), Ni (8), Pb (1), and Zn (>1000).

Time Multiplex Multiple Slit AF Spectrometer

The instrumentation to be described later in this thesis is a modification of a multielement flame AF Spectrometer constructed in this laboratory by Eric Salin (1). Therefore, this previous instrument will be described in some detail to provide a foundation for later discussion. This previous instrument was designed for both multielement AA and AF operation, although only the multielement AF mode of operation is described here.

The time multiplex multiple slit (TMS) multielement flame AF spectrometer described by Salin (1) is based on the use of a multiple exit slit (MS) monochromator with a single detector and a time multiplex (TM) mode of pulsing for the HCL's and data acquisition. A "boxcar" type up-down integration technique previously described (69) is employed to process the signals.

The general operation of the instrument is illustrated by Figures 1 and 2. Much of the instrument is similar to a common single-element AF; however, the radiation from two or more lamps (one single element lamp for each element to be determined) is directed through the flame. The normal single slit in the focal plane of the monochromator is replaced by a multiple slit array such that the appropriate AF resonance radiation line from each element passes through the appropriate exit slit. The radiation passing through all the slits is directed to a single photomultiplier tube (PMT) with a mirrored light funnel. The

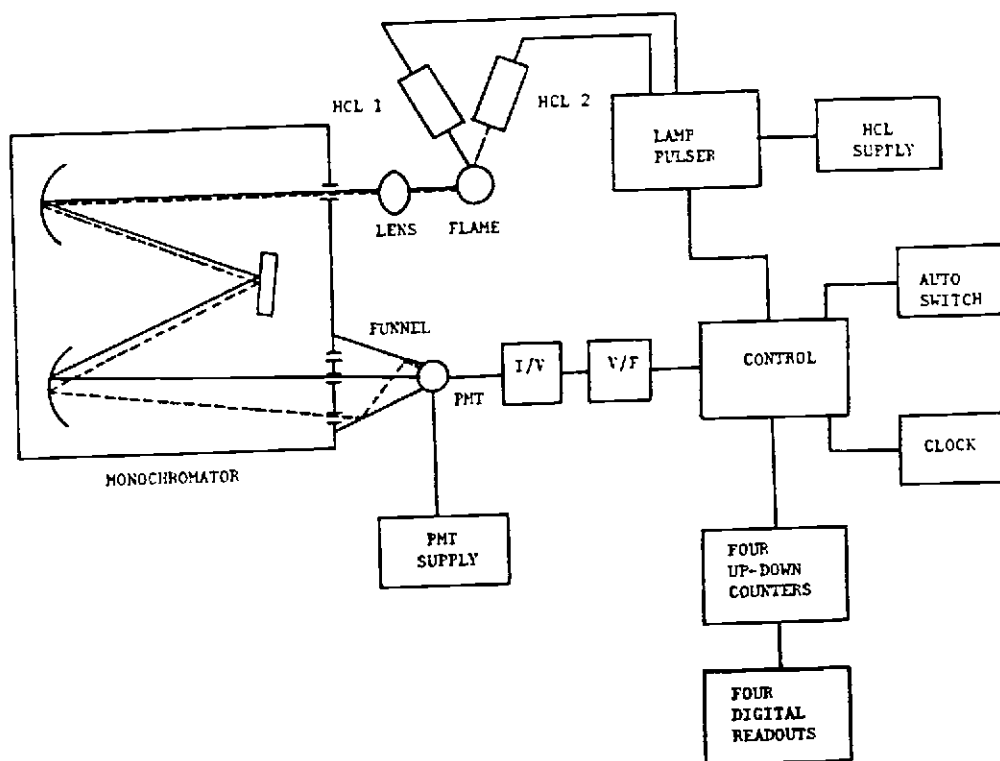


Figure 1. TMS system schematic in the AF configuration.

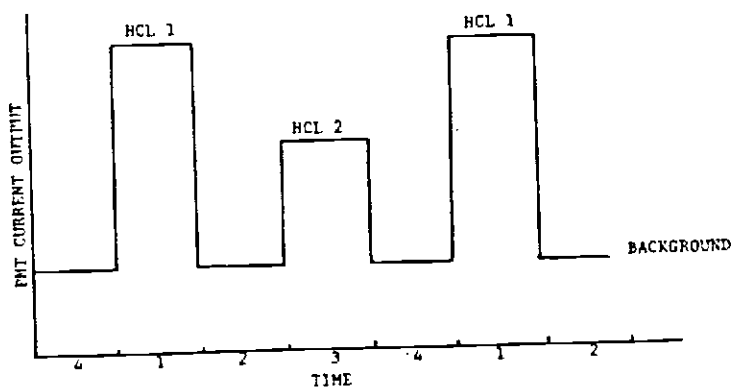


Figure 2. TMS PMT output.

anodic current from the PMT is converted to a voltage with an operational amplifier (OA) current-to-voltage (I/V) converter and then to a frequency with a voltage-to-frequency (V/F) converter. Thus the spectral signals are processed as frequencies proportional to the PMT signal by further circuitry. The signals for each element are distinguished with a time multiplex approach. With a clock and central control circuit, each element's HCL is pulsed at the same frequency but only one is turned on at a time in a sequential manner. The duty cycle (% time that a given lamp is on) is considerably less than typical 50%.

The same clock and control circuit controls the data acquisition and directs the PMT related V/F signal to a separate data acquisition channel which consists of essentially an up-down counters for each element. When a given lamp is pulsed on, the PMT signal is integrated for a specified time. This integration is accomplished digitally by counting the number of pulses output from the V/F converter for a given length of time with the up-down counter in the count mode. This integrated "lamp on" signal is proportional to the AF signal and the scattering signal and any signal due to the PMT dark current or flame background emission. To correct for the non-lamp related portion of the signal, the PMT signal is integrated for the same time period after the lamp is turned off. This signal is subtracted from the first lamp on integrated signal. This is accomplished by subtracting the number of V/F pulses in the "lamp off" period from the counts accumulated during the "lamp on" period by using the up-down counter in the count down mode. This integration addition-subtraction or

up-down counting can be carried out separately for each lamp for any number of lamp pulses.

For simplicity in the following discussion, a two element (2 HCL) system will be considered although the system was designed to determine four elements simultaneously with the same principle.

At time 1 (see Figure 2), HCL 1 is pulsed on (solid line in Figure 1) for one clock period (typically 10 ms). The light from this HCL goes through the flame and excites atomic fluorescence. An image of the flame is focused on the entrance slit of the monochromator and the light is dispersed by the grating in the focal plane such that the resonance AF radiation passes through its exit slit. The resonance radiation and any flame background emission over the spectral band pass is then reflected down a mirrored funnel into a PMT. The current from the PMT anode is converted to a voltage and then a frequency. After a brief delay (typically 0.7 ms) to allow for the lamp rise time, the signal is integrated (counted up) for 9.3 ms. Time 2 then begins. HCL 1 is turned off and after the same brief delay, the background signal is integrated for 9.3 ms and the result is subtracted from the previously stored signal in counter 1 by counting down during time period 2. At time 3, HCL 2 is pulsed on for 10 ms and the same procedure is again initiated except that the resonance radiation (dotted line in Figure 1) is passed through another exit slit and the signal in time interval 4 is subtracted from the result in counter 2.

Another cycle then begins after each 40 ms (in this example). Each complete cycle is called a lap and normally 100 laps are run for

signal averaging.

The detection limits obtained by Salin (1) in the multielement AF mode are (in ng/mL) Cd (90), Cu (50), Mg (100), and Zn (200). The single element AF detection limits reported are (in ng/mL) Au (200), Cd (20), Co (30), Cu (7), Fe (300), Mg (40), Mn (50), Ni (100), Pb (7,000), and Zn (30).

EXPERIMENTAL

The TMMS AF instrument designed by Salin (1) and described in the Historical section, was modified in two stages. In the first stage, a number of modifications were made to the instrument to improve the performance and the operating characteristics of the non-computerized instrument. In the second stage, the instrument was computerized by addition of a microcomputer system. These two stages of instrumental development will be described in turn. This section ends with a description of solution preparation procedures.

Non-Computerized TMMS AF Spectrometer

A block diagram of the non-computerized instrument is shown in Figure 1. Most components are the same as described by Salin (1) and the modifications or additions are described below.

The V/F converter, four-5 decade up-down counter boards, HCL power supply, and 5 V supply for the control, clock, up-down counter boards, and digital readout, and PMT supply were identical to that used by Salin. The I/V converter board was similar except an Analog Devices AD540JH OA was used in place of AD380J OA, and the OA feedback resistors and feedback capacitors were mounted on a printed circuit (PC) instead of a Vector board. The new electronic, optical, and burner instrumentation constructed is described below.

HCL pulsing system

Salin used the circuit illustrated in Figure 3A to pulse the HCL's. This circuit was slightly modified in this research as

shown in Figure 3B. In both cases, there are actually four identical circuits for the four HCL's. The timing for lamp pulsing is controlled by the outputs from lamp demultiplexer and buffer circuitry on the control circuit board to be discussed later. This control board circuitry outputs a 10 ms logic 1 (+5 V) pulse every 20 ms in a sequential manner to the base of each of the four control transistors (T_2 Figure 3) corresponding to each of the HCL's. These transistors are in the common collector configuration and are used simply as an on/off switch capable of high current throughput. When the control transistor receives a logic 1 signal, it is turned on and provides a current to the base of the power transistor (T_1 Figure 3). This current turns on the power transistor and allows current to flow through the HCL. In Figure 3A, the current through HCL is limited and controlled by the load resistor R_L and will be denoted the resistor control configuration. This system of controlling current is inconvenient. First, to adjust the current, the power to the lamp pulsing circuit must be turned off to allow a different load resistor to be substituted. Second, the choice of lamp current is limited by the resistances of the high wattage resistors available. The HCL high voltage supply voltage can also be changed to alter the lamp current but this will affect the current to all lamps since only one supply is used. Third, the load resistance required for a given lamp current must be calculated beforehand.

To eliminate these problems, it was decided to control the lamp current through the HCL by controlling the base current into the power

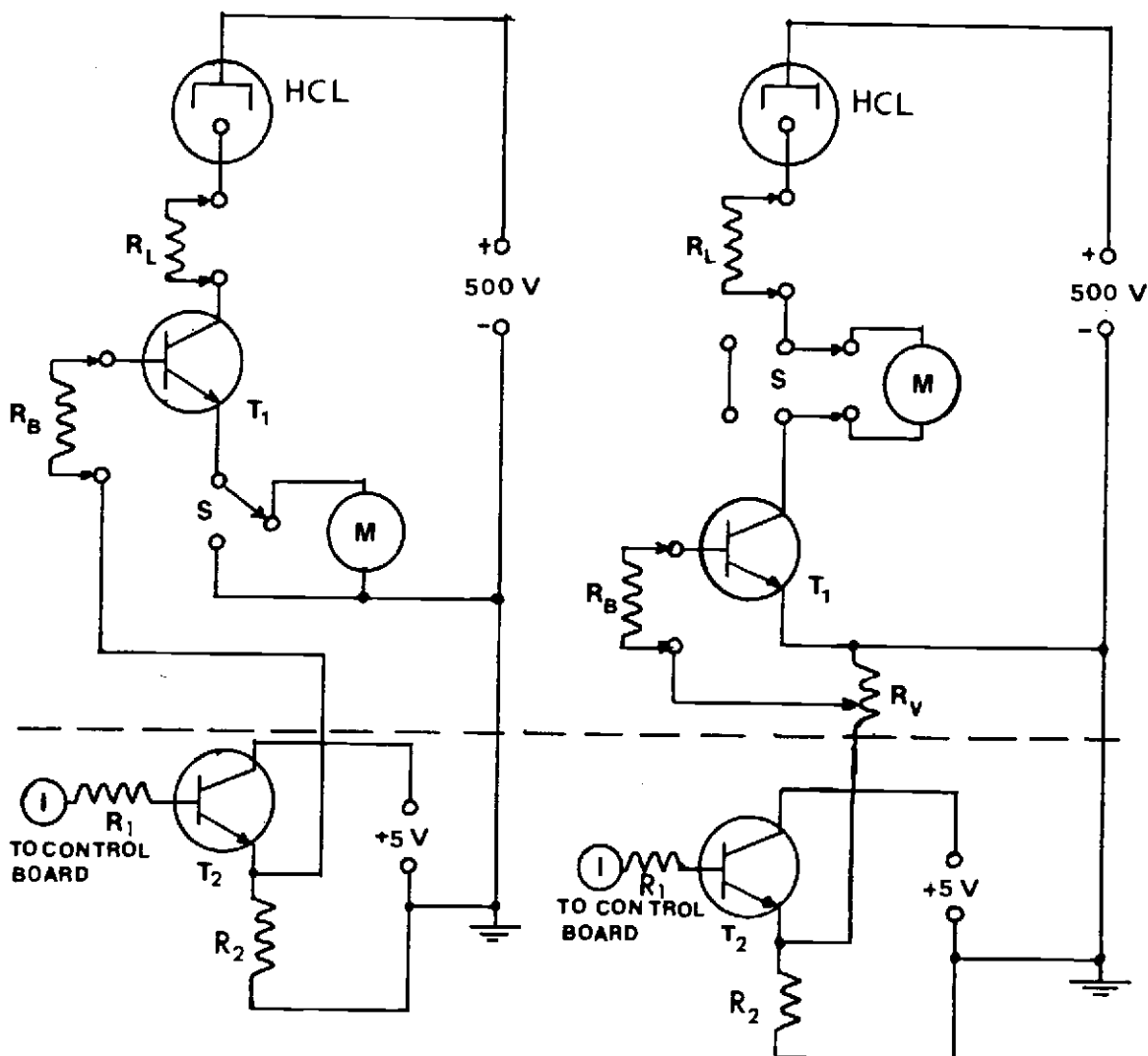


Figure 3. Non-computerized HCL pulsing circuitry. Components below the dotted line are mounted on PC board and above are mounted on the front panel of the electronic case. T1, SK3111, NPN power transistor; T2, 2N3416, NPN transistor; M, 20 mA DC, ammeter; R_L , 5W resistor; R_B , R_1 , and R_2 are 100 Ω , 1.5 k Ω , and 18 k Ω , resistors, respectively; R_V is a 3 k Ω potentiometer; S, DPDT switch.

resistor (52). The base current and hence the lamp current is controlled by a variable resistor R_V , installed between R_B and T_1 as shown in Figure 3B. The knobs controlling the potentiometer R_V for each of the four lamps are installed on the front panel of the electronics case for easy access.

The resistor and current control modes of operation were compared. It was found that the noise and drift in the HCL signals were equivalent in both modes of operation.

As shown in Figure 3A, the ammeter (M) could be placed between the T_1 and ground of the original circuit to measure the average lamp current for one HCL at a time. However, even when the HCL current was zero, a residual signal of about 2.2 mA registered on M due to current passing from the base to the emitter of the power transistor. Therefore, the ammeter was relocated between R_L and T_1 as shown in Figure 3B. Four DPDT switches were installed on the front panel, which allow the operator to put the ammeter in any one of four HCL pulsing circuits. A rotary selector switch on the front panel is used in conjunction with the above switches to choose for which of the four HCL circuits the current meter is inserted. This prevents the accidental usage of ammeter by two HCL pulsing circuits.

Control board

The control board schematic shown in Figure 4 is identical to that described by Salin (1) except for a few modifications. The operation of the control board revolves around the use of demultiplexer IC's. One demultiplexer [15] controls the pulsing of

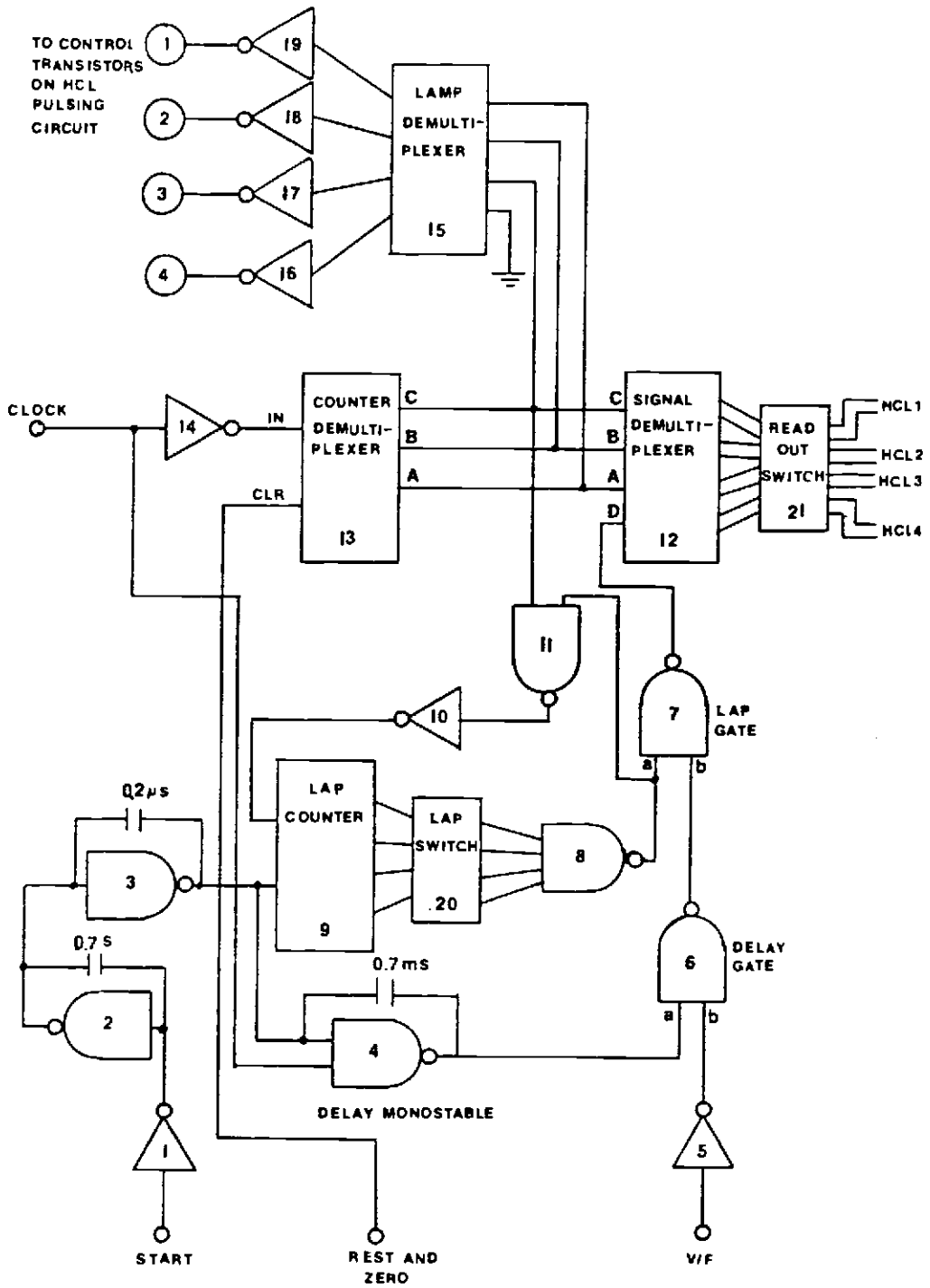


Figure 4. Simplified control electronics schematic.

the HCL's, and the other [12] controls the sequential channeling of the V/F pulse train to the appropriate up-down counter. The pulsing of the lamps and data acquisition are perfectly synchronized since they are triggered off the same clock signal.

The data acquisition is initiated with a logic 0 start pulse from the auto start circuit to be described later. This start pulse triggers monostables ([2], [3]) to produce a $0.2 \mu\text{s}$ pulse which clears the lap counter and the demultiplexer counter, sets the up-down counters outputs to zero and resets the clock. The demultiplexer counter [13] starts to trigger on the logic 0 to 1 transitions from the clock after the starting pulse. The BCD outputs of this counter (A, B, C) are decoded by the lamp demultiplexer to cause sequential pulsing of the HCL's and by the signal demultiplexer to cause the pulse train from the V/F converter directed sequentially to the appropriate up-down counter.

The lap counter [9] receives one pulse from the output of demultiplexer counter after every eight clock pulses (one lap). After a preselected number of laps, the output of gate 8 is driven to logic 0 which blocks any more data acquisition via gate 7 and stops the lap counter. At this time, the lamps continue to be pulsed, and the same data acquisition cycle is repeated by activating with another start pulse.

The control board used by Salin was a prototype wired on a SK-10 bread board, and this was replaced with a PC board. Additional switches were added to the control board to allow easy selection of different operating conditions. The readout switch [21] (two 8 SPST

switches) allows the V/F signal due to any one HCL to be sent to two (rather than one) up-down counters and their respective readouts. This is useful for testing the readout systems. The lap switch [20] (two 8 SPST switches) is used to select the number of laps (1 to 324) to be used in a measurement. The schematic for the control board as well as coding for the switches is given in Appendix I.

Digital readout

The original instrument used two 5-digit and two 4-digit decimal readouts to read to BCD outputs of the four 5-decade up-down counter boards. The 4-digit readouts were bulky Nixie tube readout modules installed in a Heath EU-801-15 analog digital designer. An added disadvantage of the 4-digit counters was that only the upper four digits of the up-down counters could be monitored thus resulting in loss of one digit of resolution. To make the instrument more compact and to provide full resolution for all four signal channels, two more 5-digit decimal readouts with appropriate decoding were constructed and the details are found in Appendix II.

Crystal clock board

The crystal clock board provides the system clock signal which is input to the control board which in turn controls the timing for HCL pulsing and data acquisition. Previously, a Heath Model EU-800-KC crystal clock board was employed which did not conveniently fit into a Vector PC card cage or allow convenient switching of the clock frequency. A crystal clock circuit was constructed on a PC board. The board is based on a standard design (78), using a 1 MHz crystal, and

provides switch selectable TTL clock frequencies from 10 Hz - 1 MHz in 1 decade steps. Details are given in Appendix III.

Automated start switch

In the previous instrument, each measurement cycle (given number of laps) was initiated with a manually controlled SPDT switch. To make repetitive measurements more convenient, an automated start switch circuit was constructed on a PC board to trigger the control circuit at preselected time intervals. The circuit provides a pulse train with a pulse width of 5 ms with a period adjustable between 2 s and 56 s. Normally the period is chosen to be about 12 s longer than the time to complete the chosen number of laps to provide enough time for reading the data off the digital displays. Details of the circuit and operation are found in Appendix IV.

Optical instrumentation

The optical configuration for AF was the same as used by Salin except for a few changes. The photofunnel and PMT were identical to before. The only modification to the monochromator was moving the wavelength selection dial to the opposite side for convenience. The entrance slit is 1.2 mm wide and 13 mm high and the slits on the exit slit array are manufactured to the same size to yield a 4.2 nm spectral bandpass. The construction of the slit array is simple. A quartz slide is placed on top of the AA slit mask slide (1) which defines the wavelength positions for ten elements. Pieces of silver tape (Leitz silver tape for binding slides) were placed on the slide using the same center to center distances used for AA. The 1.2 x 13

mm gaps between pieces of silver tape define the slits. Separate slits were made for Zn, Co, Fe, Au, Mn, and Cu. The Ni and Cd, and Mg and Pb lines pairs were so close that a single 1.2 mm slit width was used for each pair. The slit array slide is placed in a slide holder and held by electrical tape; the holder is secured to the focal plane in a predetermined position as described by Salin (1).

The Mg 285.2 nm line is used as a standard or reference line for alignment of the slit array holder because it is an intense and easy to find line which can be isolated with an interference filter. Also, this line appears in the middle of the slit array pattern.

Two telescopic tubes (3 to 6 in. extension) of 1 inch diameter were constructed (one from gray PVC plastic [D] and the other one from anodized aluminum [B]). The PVC tube is placed between the entrance lens and the entrance slit [E]. The aluminum tube is placed on the other side of the entrance lens and pointed down the optical axis toward the flame [A]. Both tubes are screwed to entrance lens holder [C] as shown in Figure 5. These tubes block room light from entering the monochromator.

Also, a new HCL mount was constructed ([F] in Figure 5). It has an annular shape and is made from one-fourth inch thick aluminum. The mount encompasses three-fourths of a circle and is 3/4 inch wide with a 10 inch internal diameter. Twenty-three evenly spaced one-fourth inch tapped holes are drilled around the ring mount. The ring mount is attached to the optical rail on which the burner and entrance lens are mounted with a rod and optical rail carrier mount. The HCL's are secured in "V" shaped aluminum HC holders [G] with four plastic screws

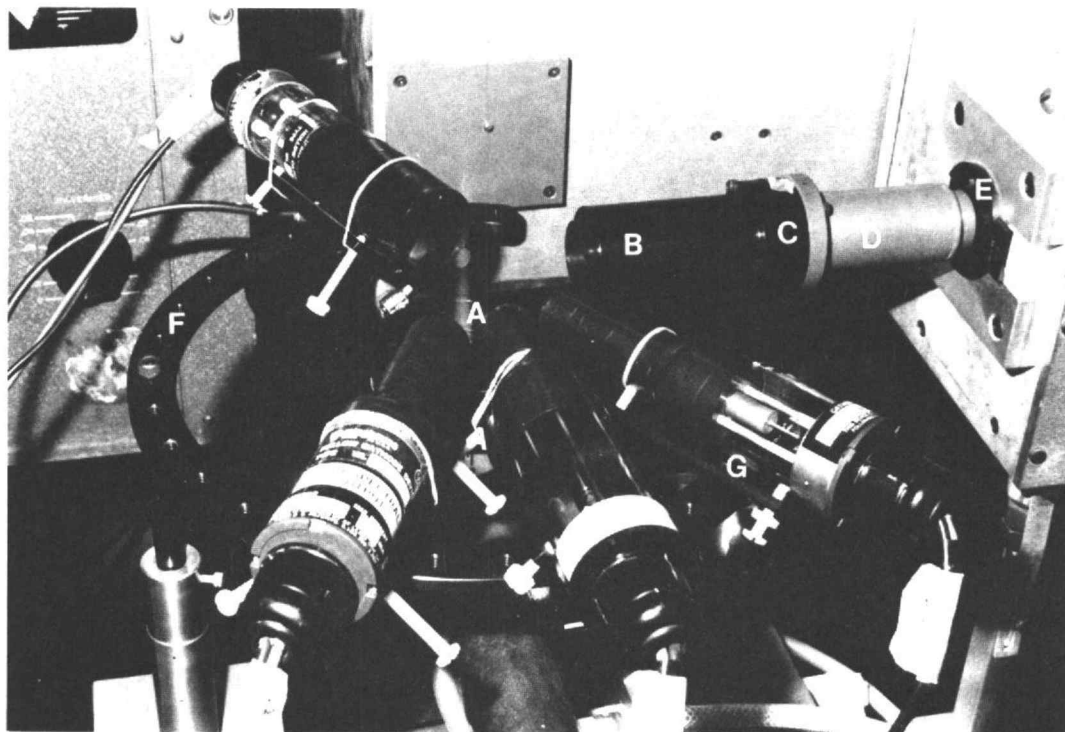


Figure 5. HCL mounting assembly and optical tubes. A, flame; B, aluminum tube; C, entrance lens holder; D, PVC plastic tube; E, entrance slit of monochromator; F, HCL mount; G, "V" shaped aluminum HCL holder.

which can also be used to adjust the HCL beam position. These HCL holders can be screwed into any of the twenty-three holes on the HCL mounting ring. All aluminum parts are anodized black to minimize light reflection. The HCL mounting ring and the HCL holders are shown in Figure 5.

Burner instrumentation

Two burner heads were constructed for insertion into a Jarrell-Ash (82-835) nebulizer-chamber assembly. One is a capillary (79) burner head which consists of a stainless steel cylindrical body (1 in. diameter and 1.5 in. length) with a 0.5 in. diameter hole drilled through the center. A bundle of 0.5 in. long and 0.027 in. ID diameter stainless steel hypodermic tubes were packed in 0.5 in. hole and the space between the tubes at the top was filled with high temperature resistant Savereisen 1800 cement. The capillary tubes extend approximately 1/5 inch above the level of the burner head to prevent overheating of the stainless steel head as shown in Figure 6A.

The second burner head is of a Meker design and is made from a cylindrical piece of stainless steel (1 in. diameter and 1.5 in. length). An 0.7 in. hole is drilled in one end of the cylinder to leave an 0.1 in. thick cap. A 16-hole pattern of 0.040 in. uniformly spaced holes is drilled into the cap in a circular area of 0.5 in. diameter as shown in Figure 6B.

The Meker burner head used by Salin (1) has a safety plug and was not designed to be used with water cooling and gas shielding accessories. Therefore, the new burner heads were made to fit into a

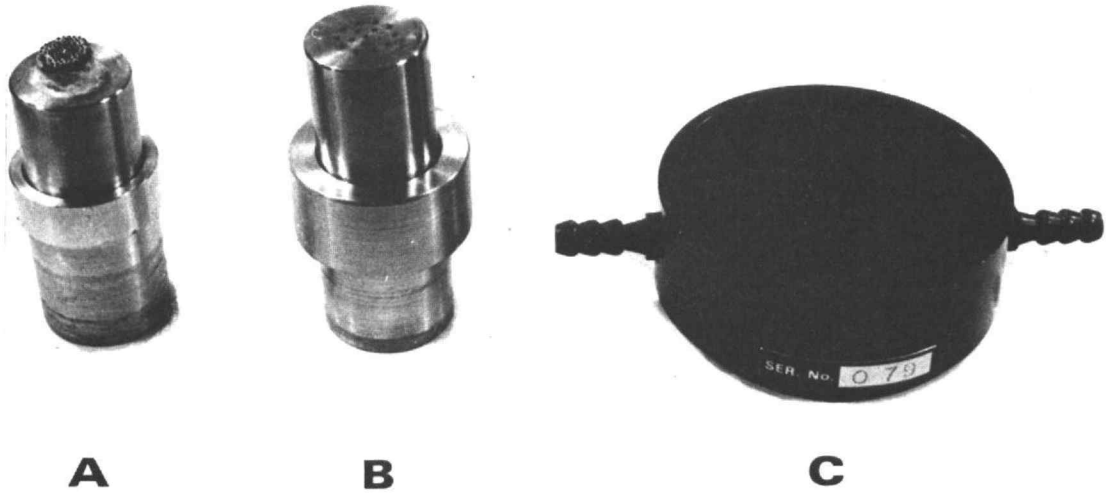


Figure 6. Burner heads and flame sheathing. A, capillary burner head; B, Meker burner head; C, Varian Techtron circular flame separator for inert gas sheathing and water cooling jacket.

Varian Techtron circular flame separator (SER. No. 076) (Figure 6C). It is an annular shaped metal device which slips over the burner head. The sheath gas is brought into a gas port on the side and exits through two circular concentric orifices on the top to form a gas sheath around the flame. Two more ports on the side are used for circulation of water through the separator to cool the burner head.

The Jarrell-Ash nebulizer-chamber assembly with the desired burner head was mounted on a micrometer bushing translation stage to provide precise positioning capability in the Y axis (perpendicular to optical axis). The nebulizer-chamber assembly already had X axis (along the optical rail) and Z axis (flame height) positioning capability. The HCL mount, telescopic tubes, and burner translation stage all are mounted on previously described optical rail (K) which is perpendicular to monochromator face (entrance slit) (Figure 7).

The burner gas control system was expanded over that used by Salin (1). All gas control components were mounted on a panel as shown in Figure 7. The three flowmeters (Roger Gilmont No. 3) and three 2-way (on-off) valves (Whitney B-43XS4) are used to control the flow rates of the fuel (H_2 or C_2H_2), oxidant (air), and sheath gas (Ar). An additional 3-way ball valve (Whitey SS-43X54) is used to switch between H_2 and C_2H_2 . Also, a flash arrestor (Matheson No. 6103) was installed between the burner and fuel flowmeter to prevent any flashback through the system.

Nondispersive AF instrumentation

The TMS AF spectrometer was converted for some studies to a non-

Figure 7. TMS flame AF configuration.

- A. Electronic Cage (PC boards, digital displays, power supplies, ADC, DAC, V/F, I/V, and HCL current system)
- B. SYM-1 microcomputer system
- C. PMT power supply
- D. HCL power supply
- E. Monochromator
- F. Entrance lens holder and telescopic tubes
- G. Gas flow system control
- H. Automated sampler
- I. HCL's and burner assembly
- K. Optical rail

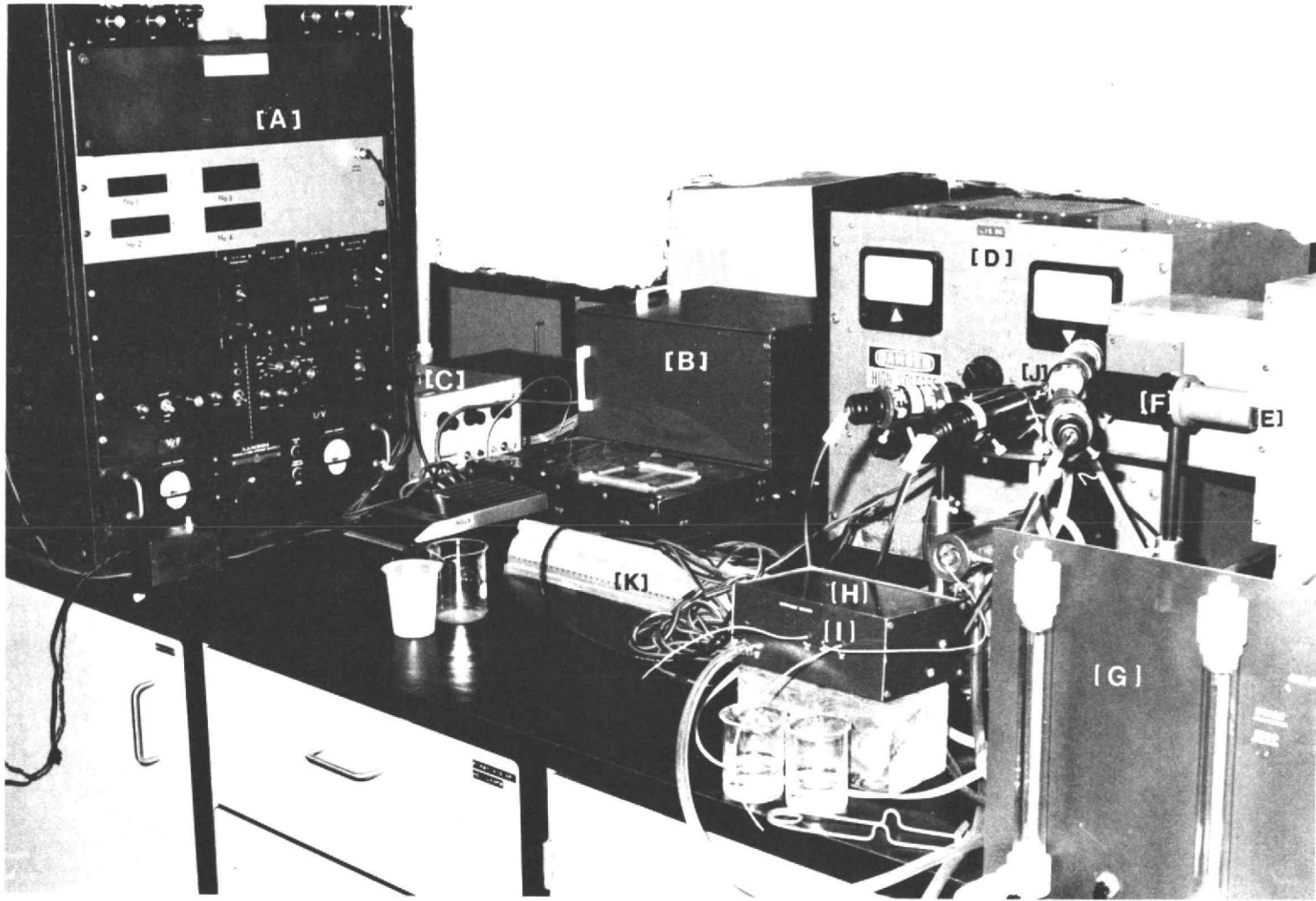


Figure 7.

dispersive configuration by using filters instead of a monochromator for wavelength selection. Thus, this instrument configuration is based on the use of a time multiplex (TM) mode of operation and multiple filter (MF) window with a single detector. All electronic and optical instrumentation is the same as for the dispersive TMMS AF instrument except the monochromator and photon funnel-PMT assembly are replaced by PMT-filter assembly and mount. As shown in Figure 8, the PMT-filter assembly consists of a commercial PMT housing [A] (Model 3150, Pacific Precision Instruments) containing a RCA-1P28A PMT to which two filters [B] are taped across the PMT housing window, and all the open holes between filters are covered with black electrical tape. Because only a small portion of the PMT housing window is exposed to the radiation coming from the flame, a small square of a 0.5 inch side length was cut from the middle of a black piece of cardboard (2 x 2.5 in.) and was placed in front of filters.

The filters used in this assembly are 1-inch diameter circular interference filters from the Corion Instrument Corporation with the specifications shown in Table I. A circular lens holder [C] is placed in front of the filters and the cardboard aperture and is taped to PMT housing in order to block room light such that the filters are exposed only to the light which passes through the lens (one inch diameter with a focal length of 3 in.). A black painted paper tube (1 in. diameter and 1.5 in. length) is placed and taped to the other side of the lens holder. The tube [D] is located around the optical axis between the entrance lens and the flame.

The PMT housing filter assembly is taped to a "V" shaped piece

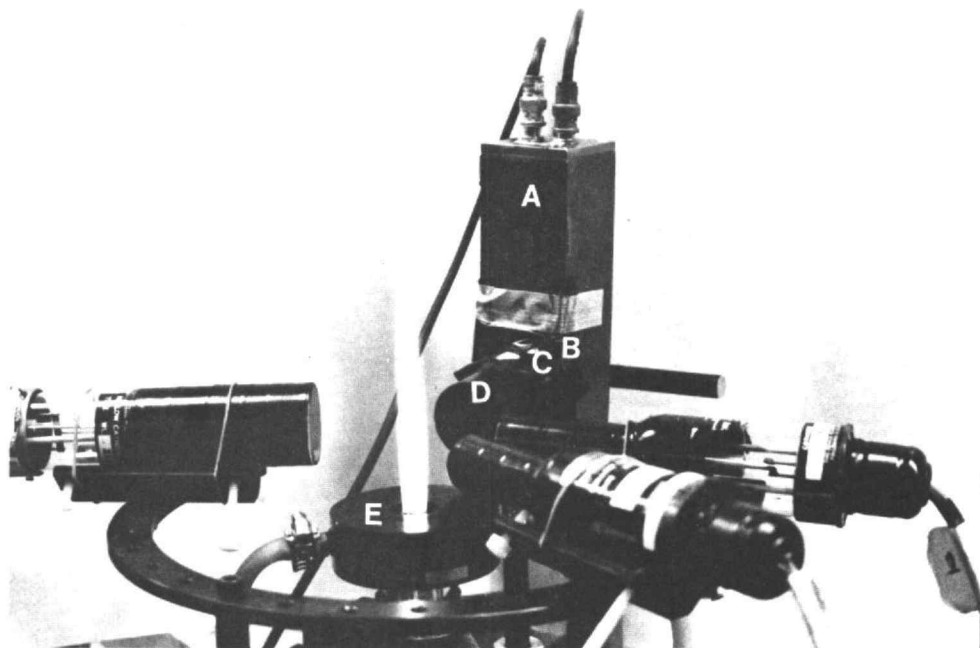


Figure 8. TMMF flame AF configuration. A, PMT housing; B, filters; C, entrance lens; D, paper tube; E, flame assembly.

of aluminum which is screwed to the rod of a base carrier. To fit the PMT housing filter assembly and its lens holder on the optical axis, the entrance lens holder and optical tubes from TMMS AF set up must be removed to create enough room for TMMF AF set up. The burner assembly, HCL mount, PMT housing-filter assembly and entrance lens holder are all mounted on the same optical rail as shown in Figure 8.

Table I. Specifications for Filters Used in TMMF PMT Filter-Assembly

Filter No.	Half Width (nm)	Wavelength of Max. Transmittance (nm)	Maximum % T	Elements(s) Used For
772178	12	285.2	13	Mg, Mn
3228-9602177-c	10	322.5	21	Cu

Computerized TMMS AF Spectrometer

The second stage of modification centered around the use of a microcomputer for control and data acquisition to allow the operator the versatility of software modification of the AF experiments and to permit instant "on line" data processing.

Introduction

In the computerized system (Figure 9) a microcomputer (SYM-1) is the heart of the system and controls various operations. The optical system and arrangement in this system is the same as the conventional TMMS AF system (Figure 1).

The computerized AF instrument was constructed to provide three different modes of operation which are switch selectable. In all three modes of operation, the AF signals, encoded as photoanodic currents, are converted to a voltage by the I/V converter. Mode 1 is the manual mode described in the previous section with the control board and four digital displays. In mode 2 the voltage is converted to a frequency by the V/F converter and the frequency is counted by a 2-byte up-down counter. For mode 3, the analog voltage is converted to a digital number with an ADC. In both modes 2 and 3, the data acquisition (control of counter or ADC) is controlled by the microcomputer and data are stored in memory for later manipulation. User communication to the microcomputer and display of data, calculations, and the messages is accomplished with a teletype (TTY). The microcomputer also controls the lamp pulsing system and sample introduction into the flame. In the following sections the computer system and interfacing

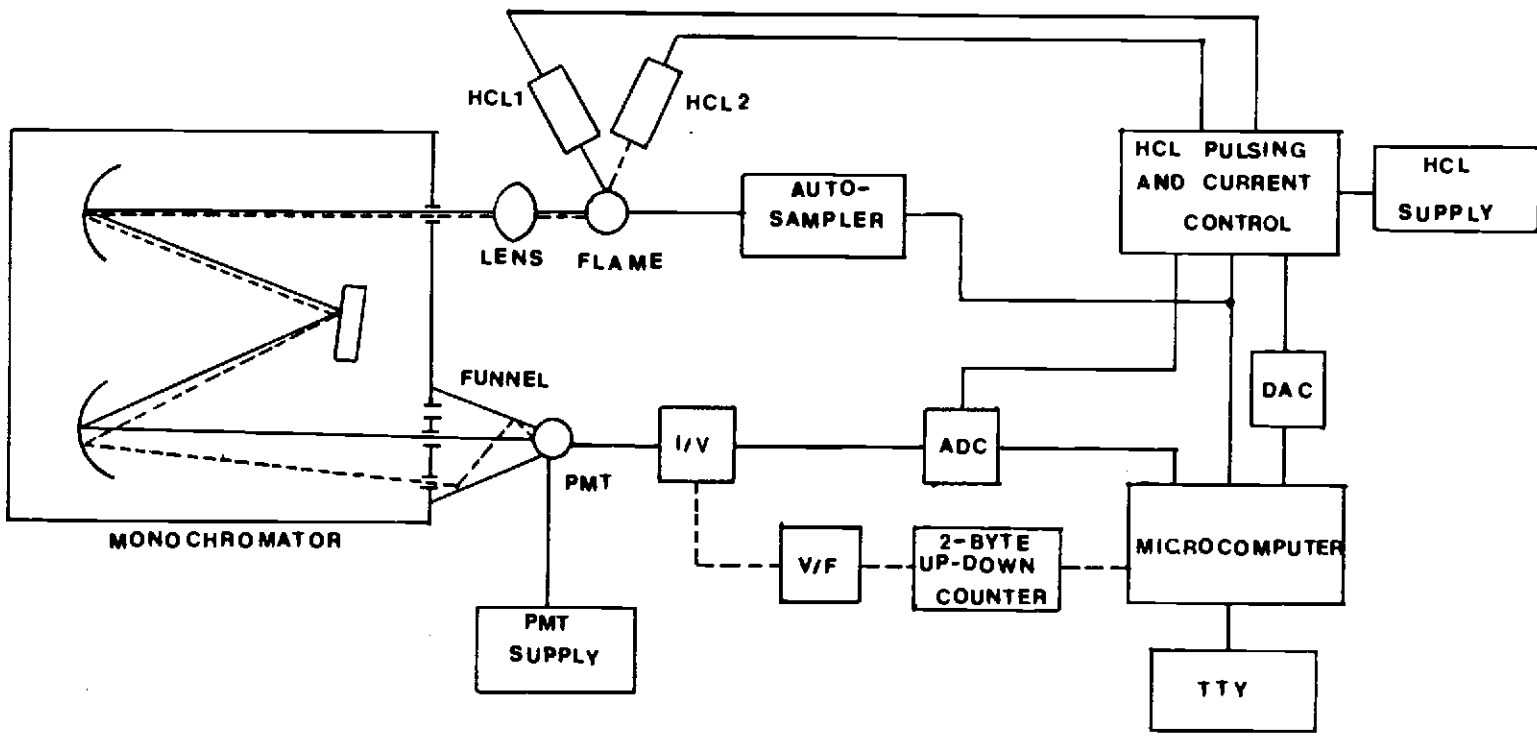


Figure 9. TMMS microcomputer control system schematic. Mode 2 involves using the V/F and 2-byte up-down counter for digitization of the signal. Mode 3 involves using the ADC instead of the V/F and counter.

hardware are described in detail. This is followed by an overview of the software.

The SYM-1 single board microcomputer

The single board SYM-1 microcomputer (μ C) used in this research is based on the 6502 microprocessor (μ P), and it is produced by Synertek System Corporation. The 6502 has a set of 56 instructions with 13 addressing modes. The features and operation of this computer are documented in detail in several manuals (80).

The SYM-1 is an 8-bit μ C which is equipped with 1) 4K of on-board static RAM, 2) a system monitor (supermon) which is stored in 4K of ROM, 3) three external sockets to install additional ROM or EPROM chips, 4) a cassette tape interface with monitor control for program and/or data storage, 5) a 20 mA 110 baud rate current loop teletype (TTY) interface, 6) an RS-232 serial interface (baud rates of 110, 300, 600, 1200, 2400, and 4800), 7) 30 I/O lines provided by three 6522 and one 6532 chips that are bidirectional and individually programmable. An extra 6522 was inserted into an on-board socket to provide 16 more I/O lines. The 6522 versatile interface adapter (VIA) chips each provide 16 I/O lines plus 2 timers. A few changes were made on the SYM board (Appendix V) to provide a total of 50 I/O lines, 8) a HEX keyboard and HEX LED display are included on the SYM-1 board which is often sufficient for interaction with the μ C.

The buss structure of the SYM-1 consists of 1) a unidirectional 16-bit address buss (e.g. 64K of addressable memory), 2) an 8-bit bidirectional data buss, 3) a control buss which includes two

interrupt input lines (Interrupt Request (\overline{IRQ}) and a Non-Maskable Interrupt (\overline{NMI}), a 1.0 MHz system clock line, a ready/write (R/W) line, a reset (\overline{RES}) line, and a ready (RDY) line.

The address, data, and control buss lines as well as I/O and TTY, RS-232, and cassette interface lines are brought out to edge connectors which include the application connector (AC), the expansion connector (EC), the auxiliary application connector (AAC), the power connector (PC), the terminal connector (TC), and the key board connector (KC). All these connectors provide +5 V and ground (GND), and the AC provides some of I/O lines, audio, TTY, and keyboard lines. All the 6532 chip's functions such as RDY, \overline{IRQ} , \overline{NMI} , R/W, data, address, clocks, and some I/O lines are available at EC. The AAC provides mostly I/O lines from 6522 chips. The PC's lines are all +5 V and GND. The TC provides RS-232, TTY, audio, and audio remote lines and the KC provides two RS-232 lines.

A number of jumpers on the SYM were changed or added to increase I/O lines availability, to add basic ROM chips, to provide automatic log-on (80), and to provide better tape reliability (81) (see Appendix V).

Two-4KX8-ROMs containing a 8K BASIC by Synertek and designed to run with the Supermon monitor, were installed in sockets U21 (ROM #02-0019-01), and U22 (ROM #02-0020-01).

The SYM microcomputer system

The SYM was connected to a motherboard which provides additional memory and allows a 16K RAM board and 16K EPROM board to be connected

to the SYM buss. The SYM and motherboard were housed in a metal and plexiglas box with a fan. The motherboard, RAM board, and EPROM board are described in more detail later.

Various connectors, switches, and cables were attached to the box to allow selection of option and connection to external devices as shown in Figure 10A. Connections were provided in the form of 4-sets of DB25 Amphenol female connectors for I/O port lines. Each connector is attached to the appropriate pins of a 6522 (three) or 6532 (one) on the SYM such that each connector provides two eight-bit I/O ports, 2 chip selection lines, and ground. The upper port is called PB and lower port is called PA (Figure 10B). The I/O port connections are indicated in Appendix VI. Two ports are required for ADC, two for the DAC, one port for the up-down counter, and 2 ports for the auto sampler and HCL pulsing circuit.

The in, out audio tape lines from the SYM TC connector were each brought out on a separate cable fitted with an Amphenol jack phone connectors to plug into a portable tape recorder (Panasonic, Model RQ-2133). The remote control circuitry on the SYM-1 allows the cassette recorder to be used under software control (Supermon audio cassette interface program (80)). This allows the computer to start the tape recorder when a program is to be loaded or saved and to stop the recorder when the process is completed. Details of remote control connection and usage is found in SYM-1 manual (80).

The TTY lines from the SYM TC connector pins 9, 10, 11, and 12 were brought out on a cable fitted with a 7 pin Amphenol connector.

As Figure 10A indicates, a BNC male connector is brought out and

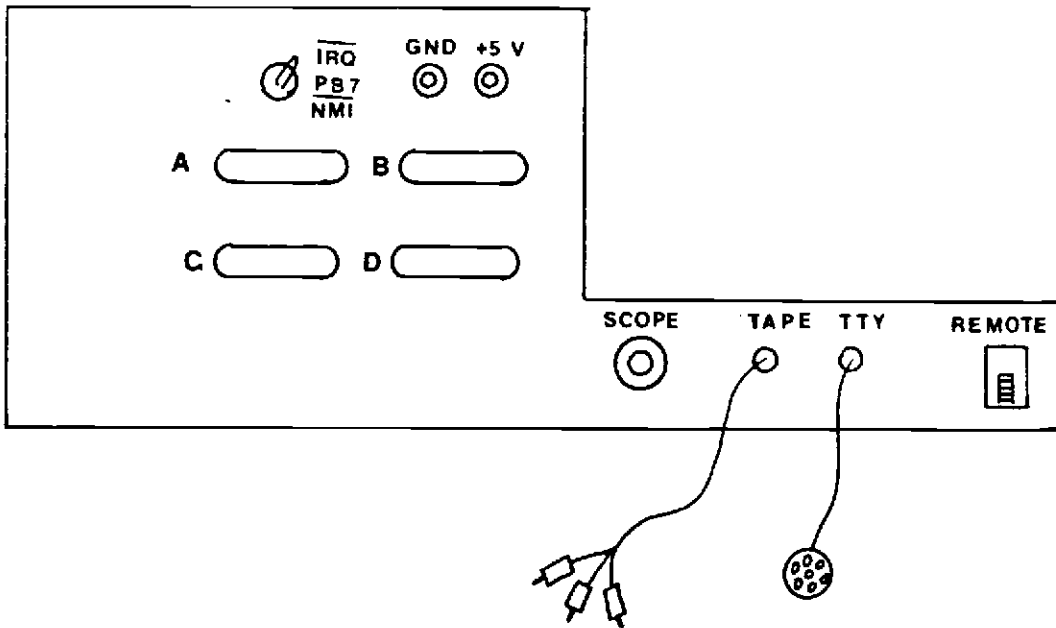


Figure 10A. Physical configuration of left side of computer box. Connector A is from AAC (A800 and A801), Connector B is from AC (A000 and A001), Connector C is from AAC (AC00 and AC01), Connector D is from AC (A400, A4001), and SCOPE, TAPE, TTY, and REMOTE are from TC.

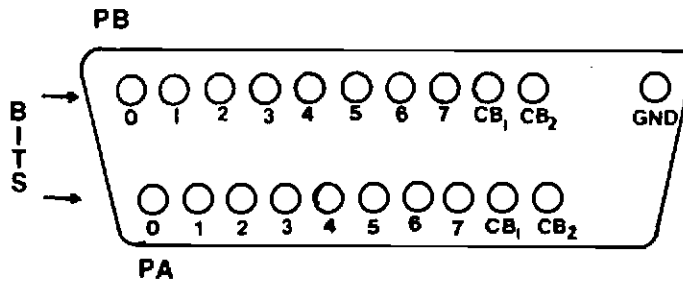


Figure 10B. A typical I/O connector.

connected to the scope line on the SYM TC connector. It allows an oscilloscope to be used as a one line monitor.

The +5 V and GND connections in the form of female banana jack plugs provide power for a logic test probe and other low current testing tools.

Whenever an interrupt is to be used, \overline{IRQ} or \overline{NMI} has to be connected externally to PA7 I/O line of the 6532 at A400. A SPDT on-off-on switch is installed to connect PA7 to \overline{NMI} or \overline{IRQ} line from the SYM EC connector when required. When the switch is in the off position, PA7 acts as a I/O line.

The Little Buffered Mother board (LBM) (Seawell Marketing, Inc.) mates directly to the SYM-1's AC, EC, and PC connectors. The LBM provides 1) sockets for 4K of additional RAM which were filled, 2) four 44-pin female edge connectors which allow the boards to be plugged into the SYM buss, 3) three voltage regulators that convert unregulated +8, +16, and -16 V to +5, +12, and -12 V, respectively, 4) 3 LED's indicating power on or off and the status of the \overline{IRQ} , and \overline{NMI} lines. There are 10 switches on the LBM board used to properly configure the memory space. The switch positions used are indicated in Appendix V. Two wires are brought through the back of the computer box and connected to the power connector (PC) on the LBM. The other ends of the wires are terminated with male banana plugs and connected to the ground and +8 V terminals of an unregulated power supply.

To expand the memory of the system a SEAWELL SEA-16 (Seawell Marketing, Inc.) memory expansion board was inserted in one slot of the LBM board. The SEA-16 board is a 16K x 8 static N-MOS RAM board.

It has two equivalent 8K x 8 sections of memory, and each section is addressable separately to any desired 8K block through switches as detailed in Appendix V. This RAM was located from 2000 to 4000 as shown in the memory map (Figure 11).

An EPROM PC board was constructed. This board has space for eight 2K 2516 EPROM chips and thus 16K total of EPROM can be used, and the address lines are buffered. Each of two 8K EPROM blocks can be addressed separately to any 8K block in the memory map with switches located on top right corner of the EPROM board. The switch positions are described in Appendix V.

To expand the existing 8K BASIC interpreter a BROWN'S BASIC ENHANCEMENT software package was purchased from SYM-1 Users' Group. This package provides a powerful set of tools to assist in construction and development of BASIC programs. The use of this package is described in detail in its manual (82). It provides 1) a super terminal control patch that includes a versatile collection of control code editing and absolute and relative cursor addressing commands, 2) Save/Load extensions which allow all the tape files, whether program, variable, or memory block, to be identified by means of a quoted label ("ID (a hex ID, a decimal ID, or a BASIC arithmetic expression ID)"), 3) an ultra renumber patch which provides a fast four parameter renumbering commands.

This enhancement program was burned on to two 2K EPROM's which were installed into the EPROM board. The original program was written to start at location 0200. An image of this program was burned on EPROM's with a base address of 6000. This method of storing program

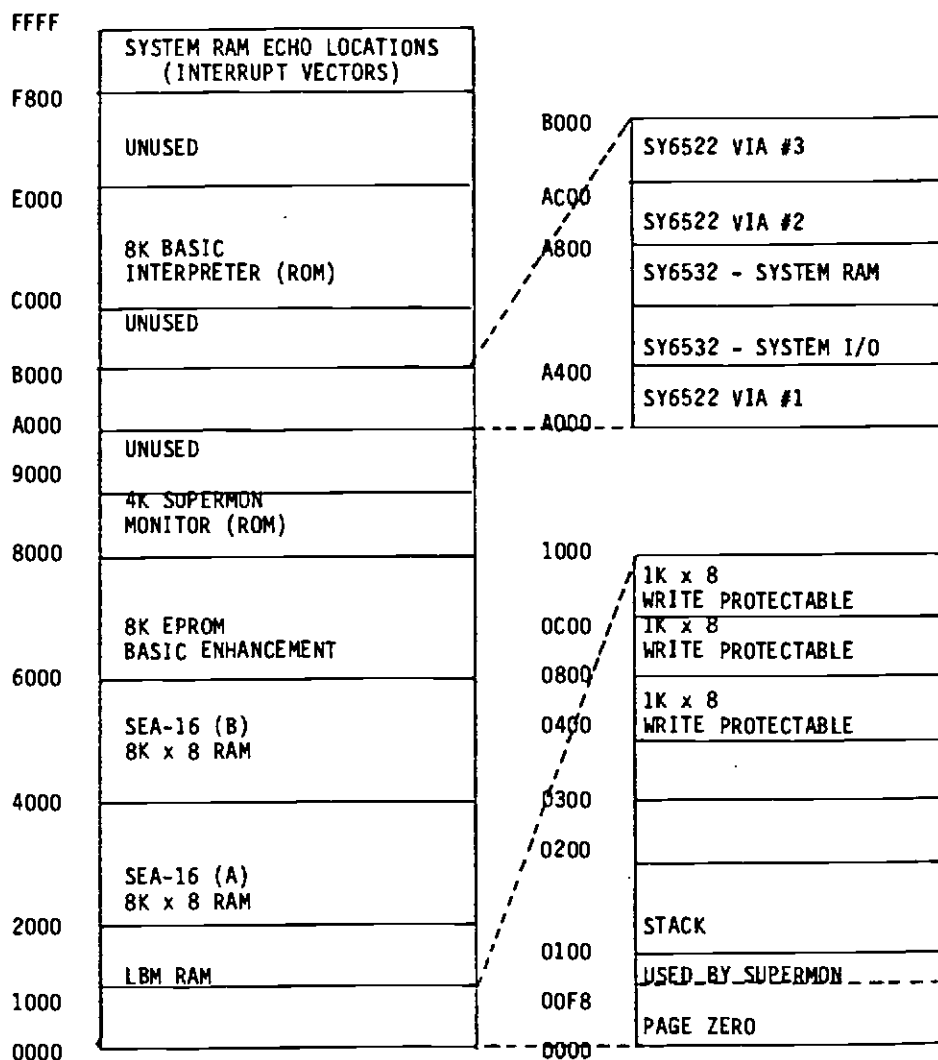


Figure 11. SYM-1 memory map.

is necessary because the EPROM board is addressed in 8K blocks. Therefore to locate it at 0200 would require the EPROM's base address to be 0000. This would result in an address conflict with the computer use of R/W memory in pages 0 and 1. To overcome this problem a short mover program was burned into EPROM just above the image of the enhancement program. To use the enhancement program with BASIC, the user executes the mover program with a G 6B00 [CR] command. This copies an image of the enhancement program into R/W memory starting at 0200. The last instruction of the mover program is a jump to 0200 which initializes the enhancement program and establishes links to the BASIC program, and BASIC responds with a cold start prompt. A listing to the mover program is given in Appendix VIII.

For interaction between the operator and the μ C, an inexpensive, small keyboard (No. 753, George Risk Industries, Inc.) and hard copy unit (Ser. No. EUY-10E0IIL U Panasonic) was constructed (83) and connected to the TTY 20 mA current loop serial interface. This device is a UART (Universal Asynchronous Receive and Transmit) based "TTY" which employs a commercially available keyboard and electrostatic printer and driver as previously described (83). It did not initially work reliably with the SYM-1 microcomputer because of the sensitivity of the SYM-1 to variations and drifts in the baud rate determined by the 555 time clock circuit in the keyboard-printer. To alleviate this problem, a baud rate generator PC board (Appendix VIII) was constructed to replace the 555 timer circuit (Figure 24, (83)). The stability of the crystal controlled oscillator ensures reliable operation.

The break key on the keyboard is connected to $\overline{\text{NMI}}$ pin of the EC connector of the LBM board. This pin is normally high (+5 V) and each time that the break key is pushed, a short logic 0 pulse is generated which causes a $\overline{\text{NMI}}$. This allows an exit from BASIC to the monitor without resetting the μC .

2-Byte multiplexed up-down counter

In mode 2, the PMT anodic currents are converted to a voltage, and then directed to the V/F for conversion to a pulse train. Binary counters are used to count the number of pulses in a preselected time. This converts the signal data into the binary form which can be directly transferred to μC memory through I/O lines.

A 2-byte (16 bit) multiplexed up-down counter was constructed from four cascaded 4-bit binary up-down counters (Appendix IX) for this purpose. This counter is connected to μC via 13 I/O lines. Eight I/O lines are used to transfer the data from the counter outputs to the SYM-1. The 16 output lines of the counters are TRI-STATE'd to 8 I/O lines such that the data in lower 8 bits and upper 8 bits can be transferred in two steps. The other 5 I/O lines are used to control the counter. The control lines are used to clear the counter, to gate in the V/F pulse train for a selected time, to control the counting mode (up or down), and to control the transfer of data to the SYM.

HCL pulser

During the time which μC is performing calculations or printing the results, it can not control the lamp pulsing system through software. Therefore a simple HCL pulse circuit was designed to pulse

the lamps when the computer is busy and allow the computer under software control to pulse the lamps during data acquisition. Details are presented in Appendix X.

Automated sampler

To allow automated introduction of the samples into the flame in AF experiments, an automated sampler was designed (Figure 12). Through software control, one can switch between the blank and an analyte solution.

A SPDT relay switch is used to turn on and off the AC power to the 3-way solenoid valve. The solid state relay is controlled by one I/O line which goes through a TRI-STATE buffer before going to the control input of the relay. A logic 1 signal on the I/O line switches the relay on and hence the solenoid valve which directs air (40 PSI) to a 3-way slide valve. This causes the output of the slide valve to be connected to input 1 (blank). The output of the valve is connected to the burner nebulizer with 0.5 mm ID tubing. When a logic 0 signal is connected to the control input, the output of the solenoid valve is connected to the atmosphere and the output of the slide valve is connected to position 2 (sample) through the action of a spring.

The TRI-STATE buffer is installed on the HCL pulser board to eliminate an extra PC board. The buffer output is brought out to a BNC male connector on the right side of the front panel of the electronics cage just below the PC boards' cage.

8-12 bit ADC

In mode 3 the signal voltage from the I/V converter is connected

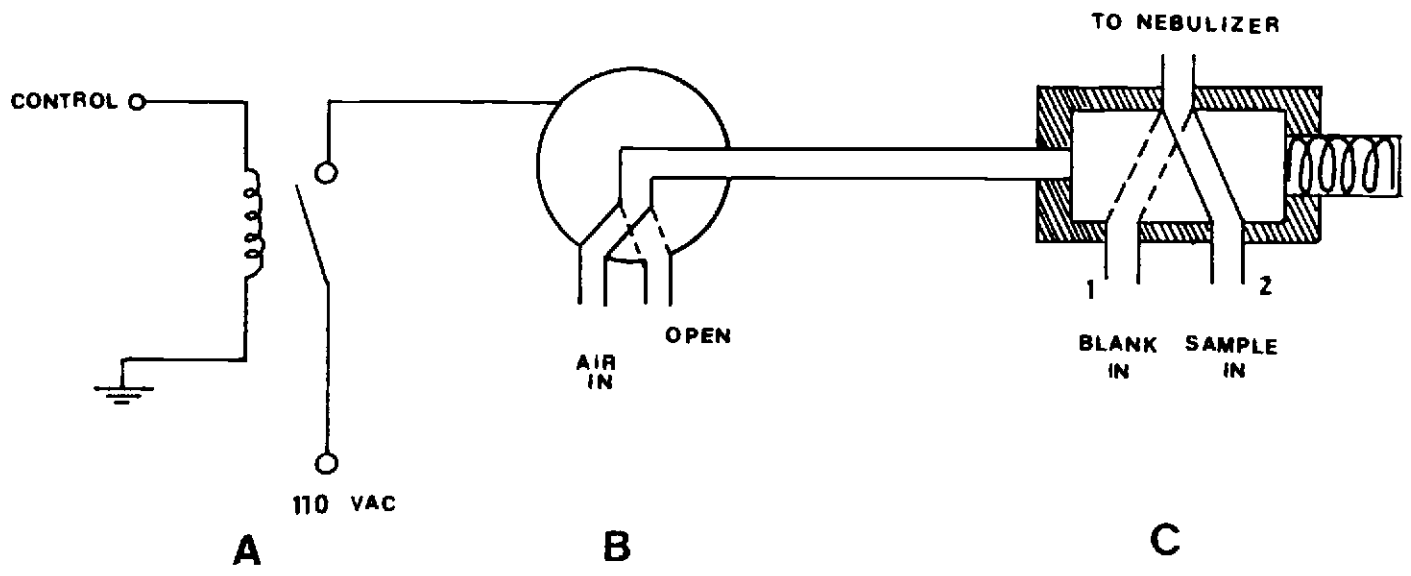


Figure 12. Automated sampler schematic components. A, SPST microcube solid state relay switch (Grayhill); B, 3-way solenoid valve (ser. no. H02-726 Skinner Precision Industries, Inc.); C, 3-way slide valve (Dionex).

to ADC. The ADC module constructed is based on a previous design and is documented in detail elsewhere (83). It is reviewed in briefly here. The ADC PC board is based on an Analog Devices AD7501 one of eight analog multiplexer and an Analog Devices AD574 eight or twelve bit ADC. The device is capable of 1) selecting one of eight analog channels for digitization, 2) performing an eight bit conversion in 16 μ s or a 12 bit conversion in 25 μ s, and 3) transferring the resulting data in two steps into the SYM-1 using eight I/O lines. The ADC board is mounted in a box and placed inside of a Vector rack mountable strut cage which is mounted in the electronics cage. The board's 22 pin male edge connector protrudes through the back of the box and inserts into a 22 pin female edge connector, screwed to the back of the cage. All the input and output connections to or from ADC are connected to this 22 pin female connector.

12 bit latched DAC

The microcomputer controlled HCL pulsing circuit requires a digital to analog conversion. For this purpose a DAC PC board was constructed and placed in a vector box and installed in the electronics cage. An eight pole DIP switch was installed on front of box for range selection, and other connections are at the back of box. The design of the DAC PC board is identical to that previously described (83) except an OA in the voltage follower configuration was installed on the output as shown in Appendix XI. This allows the DAC to output a higher current and prevents damage to the DAC.

HCL pulsing circuitry system with power supply current regulator

HCL's pulsed at high currents provide excellent high intensity sources for atomic fluorescence spectrometry. The power supply must provide very reproducible current pulses to ensure stable light output from the lamp.

The current through the lamp can change if the lamp resistance changes. For this reason a current-regulator system was designed. The current-regulator system, which is basically a feedback control system, is based on the null comparison concept. The HCL's, and power supply are in the feedback loop of an operational amplifier (OA). This allows the lamp current to be continually compared to a reference current set by the user.

Figure 13 presents the modified HCL pulsing circuit. In the following description only two HCL's are considered even though the circuit is actually used for 4 HCL's. When a logic 1 pulse is generated from the HCL pulser circuit (Appendix X) (software or free running mode) for input 1, transistor T1 is turned on and T2 is turned off so that point A is at +15 V which turns FET switch AS1 on. This allows the voltage applied to point C from the DAC (or +5 V power supply) to pass through AS1 (the 250 k Ω variable resistor is turned completely clockwise for zero resistance) to the non-inverting input of control amplifier (OA1). The output voltage of OA1 is controlled to be the same as non-inverting input voltage. Transistor T5 passes the OA output signal to FET's AS3 and AS4. At this time, only AS3 passes the signal because point F is connected to point A (+15 V) and Point G is connected to point B (0 V). The signal passed by AS3 turns

Figure 13. HCL pulsing circuitry system with power supply current regulator.

Component	Identification No. or Valve	Description
T1-T5	2N3416	NPN transistor
T6, T7	SK3111	NPN power transistor
AS1-AS4	CD4016	FET - analog switch
OA1	TL081	Operational amplifier
R1-R6	100 Ω	Resistor
R7-R12	1 k Ω	Resistor
R13, R14	250 k Ω	Variable resistor
R15, R16	1 M Ω	Resistor
R17	5 k Ω	Potentiometer
R18	18 k Ω	Resistor
R19	400 k Ω	Resistor
R _{Sense}	15 - 3 Ω	Resistor
M	10 mA DC	Current meter
S1, S2	DPDT	Switch
C1	100 pF	Capacitor
SS	Two-QPDT	Rotatory switch

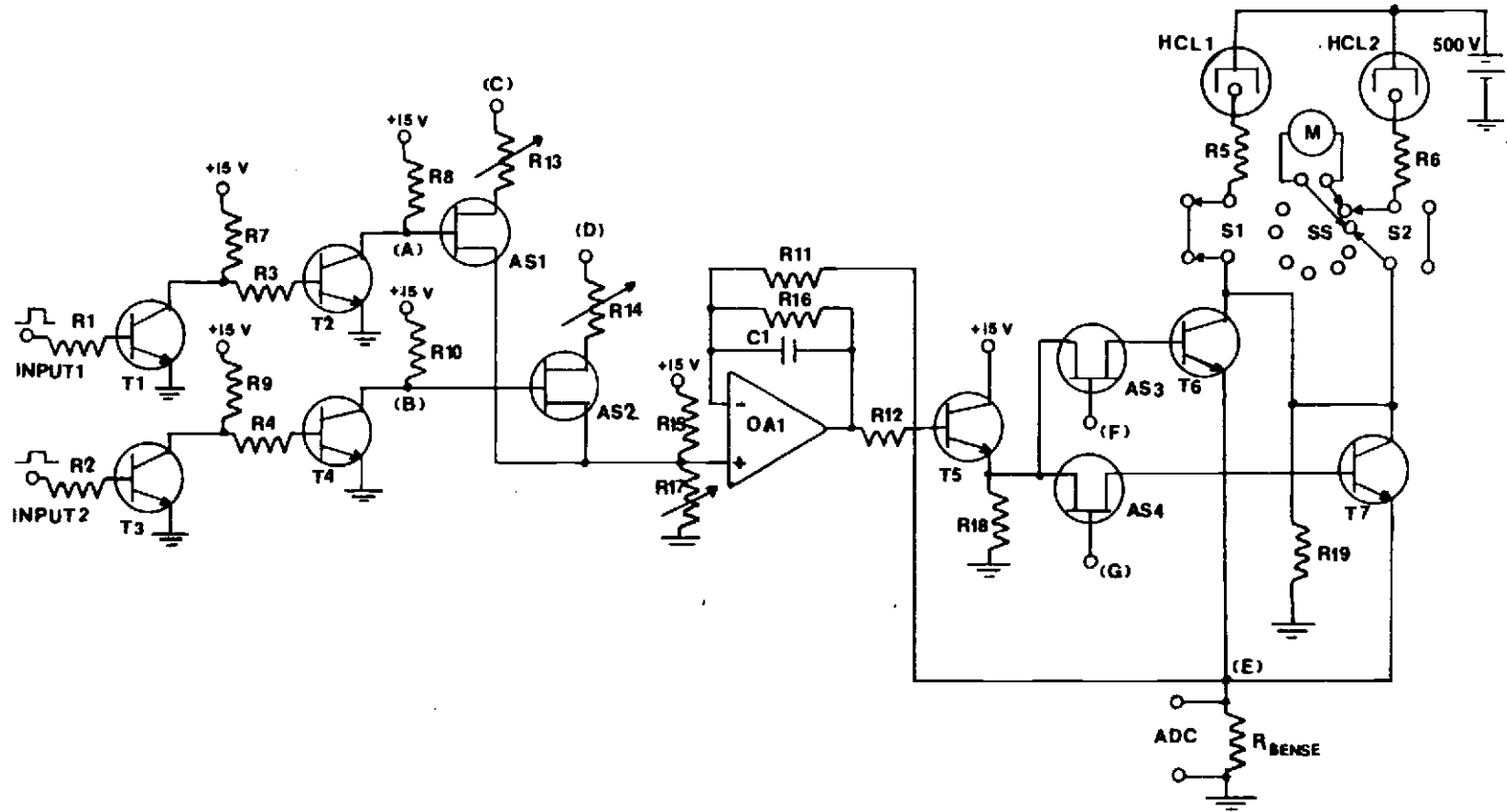


Figure 13.

Table II. HCL Pulsing Circuitry System Pin Configuration

Pin	Description
A	To HCL #2 - Control Resistor (250 k Ω variable)
B	To HCL #3 - Control Resistor (250 k Ω variable)
C	To HCL #4 - Control Resistor (250 k Ω variable)
D	To HCL #1 - Control Resistor (250 k Ω variable)
E	HCL #1 - Control Pulse in (from HCL pulser board Pin P)
F	HCL #2 - Control Pulse in (from HCL pulser board Pin M)
H	HCL #3 - Control Pulse in (from HCL pulser board Pin U)
J	HCL #4 - Control Pulse in (from HCL pulser board Pin S)
K-S	N.C.
T	To the power transistor emitters
U	+15 V
V	HCL #1 - Control pulse out (to the power transistor base)
W	HCL #2 - Control pulse out (to the power transistor base)
X	HCL #3 - Control pulse out (to the power transistor base)
Y	HCL #4 - Control pulse out (to the power transistor base)
Z	-15 V
1-22	GND

the power transistor T6 on and allows current to flow through the HCL1 and turn it on for the period of time that input 1 is at logic level 1. When the lamp is on, current flows through load resistor R5, transistor T6, and R_{sense} . The voltage drop across R_{sense} is E_{sense} and is given by equation 1.

$$E_{sense} = (i_{HCL}) (R_{sense}) \quad (1)$$

This positive voltage at point E is applied to the inverting input of control amplifier OA1. The current through the HCL1 quickly assumes the value such that the voltage at point E (E_{sense}) equals the voltage at non-inverting input. By the same reasoning, any fluctuation in the lamp circuit (e.g. lamp resistance), which causes non-equality between the inverting and non-inverting inputs of the OA1, causes the output of OA1 to assume value to maintain E_{sense} and hence i_{HCL} to a constant level. The above process is repeated for each HCL. For HCL2, the lamp is turned on when the input 2 and T3 is high and AS4 and T7 are turned on.

If the system is controlled by the μC , lamp currents are selected by the user at the TTY terminal. The software calculates the digital signal to feed to the input of the DAC which produces the necessary DAC output voltage to produce a selected i_{HCL} . This calculation is based on R_{sense} value, experimental constants, and other variables to provide the selected i_{HCL} .

When the μC is not interfaced, a constant voltage (+5 V) is applied to points C and D instead of the DAC output. The current i_{HCL} is adjusted with the 250 k Ω variable resistor. During this adjustment, the ammeter (M) is switched into the appropriate HCL

current path, first by selector switch SS, then by switching S1 (for HCL1) or S2 (for HCL2) to the "M" position. The two-switch system is used to prevent any accidental damage to the ammeter or HCL by connecting two HCL's to the same ammeter.

The voltage at point E (E_{sense}) is connected to the one channel of the ADC to convert the voltage to digital form for input to the computer. This digital signal is used by the computer to calculate i_{HCL} which is displayed at the computer terminal. This provides the user with conformation that the desired i_{HCL} has been selected.

Mode selection

A switch box was designed which allows easy selection of the three modes of operation. These switches are installed on front panel of the electronics cage and described in Appendix XII.

PC board arrangement in vector card cage

The PC boards are placed in a Vector card cage (type CCK13-Vector) which is mounted in a rack. The locations of the boards are shown in Figure 14. The letters correspond to the standard card rail locations on the Vector card cage.

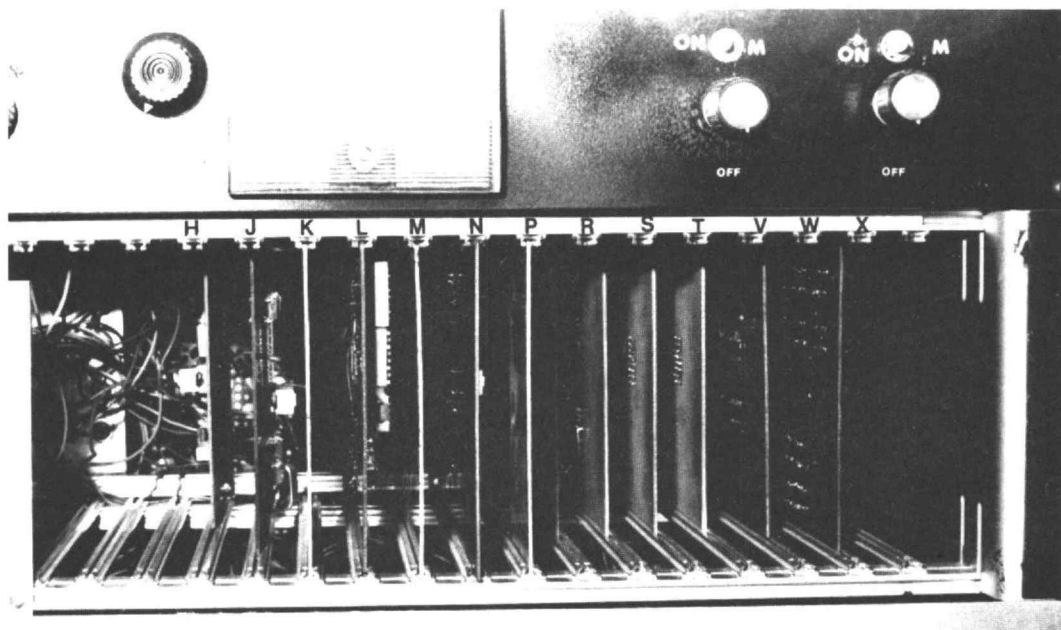


Figure 14. PC board locations in Vector card cage. H, automated start switch; J, 1 MHz crystal clock; K, aluminum shield; L, control board; M, aluminum shield; N, HCL pulse control and current feedback circuit; P, aluminum shield; R, up-down counter #1; S, up-down counter #2; T, up-down counter #3; V, up-down counter #4; W, HCL pulser; X, 2-byte multiplexed up-down counter.

Operation and Software for Computerized TMMS AF Spectrometer

In this section, the variables that are important in computerizing the operation of the instrument are first defined. Also the calculations necessary to extract signal and S/N information from the raw data are reviewed. Next the software is described from an operational point of view. This includes a discussion of the operator input of experimental parameters and the control, calculation, and output functions performed by the software.

Definitions of lamp and data acquisition parameters

The variables relating to the pulsing of the HCL's and to data acquisition are identified and briefly described below and in Figure 15.

- 1) HCL peak current (i_p): The maximum HCL current during the time the lamp is on, typically 70 to 1000 mA.
- 2) HCL pulse width (t_p): The length of time the HCL is pulsed on, typically 1 to 10 ms.
- 3) Lap (cycle) time (t_L): The total time for all the HCL's used (up to 4) to be pulsed on and off one time.
Typically the signals from 10 to 100 laps are added together in one measurement to produce one data point.
- 4) Percent duty cycle (%DC): The percent time that given HCL is on during one lap (cycle) or

$$\%DC = 100 (t_p/t_L) \quad (2)$$

Typically %DC is 1-12.5.

- 5) HCL rms current (i_{rms}): The average HCL current over the period of one lap.

$$i_{rms} = i_p \times \%DC/100 \quad (3)$$

- 6) Delay time (t_d): The period of time from the moment that lamp goes on (or off) until data acquisition begins. Normally the delay time is adjusted to be about five times the time constant (τ) of the I/V converter feedback network to allow the electronics to respond fully.
- 7) Data collection time (t_c): The period of time over which the data are acquired for the rest of the pulse after the delay or

$$t_c = t_p - t_d \quad (4)$$

For background corrected measurements, an identical delay and data collection time occur after the pulse to yield the lamp off signal which may be subtracted from the previous lamp on signal.

In mode 2, the V/F counter integrates for the signal the rest of the pulse width for time t_c . For mode 3, one or more data acquisitions are made and summed per pulse. The number of data acquisitions (q) is determined by the data collection time to t_c and the time to make one data acquisition and store the result in memory (t_a). Thus q is equal to t_c/t_a rounded up to the closest integer value. Since t_a is 200 μ s, q is 48 for a pulse width of 10 ms and 3 for a pulse width of 1 ms for a fixed t_d of 0.5 ms.

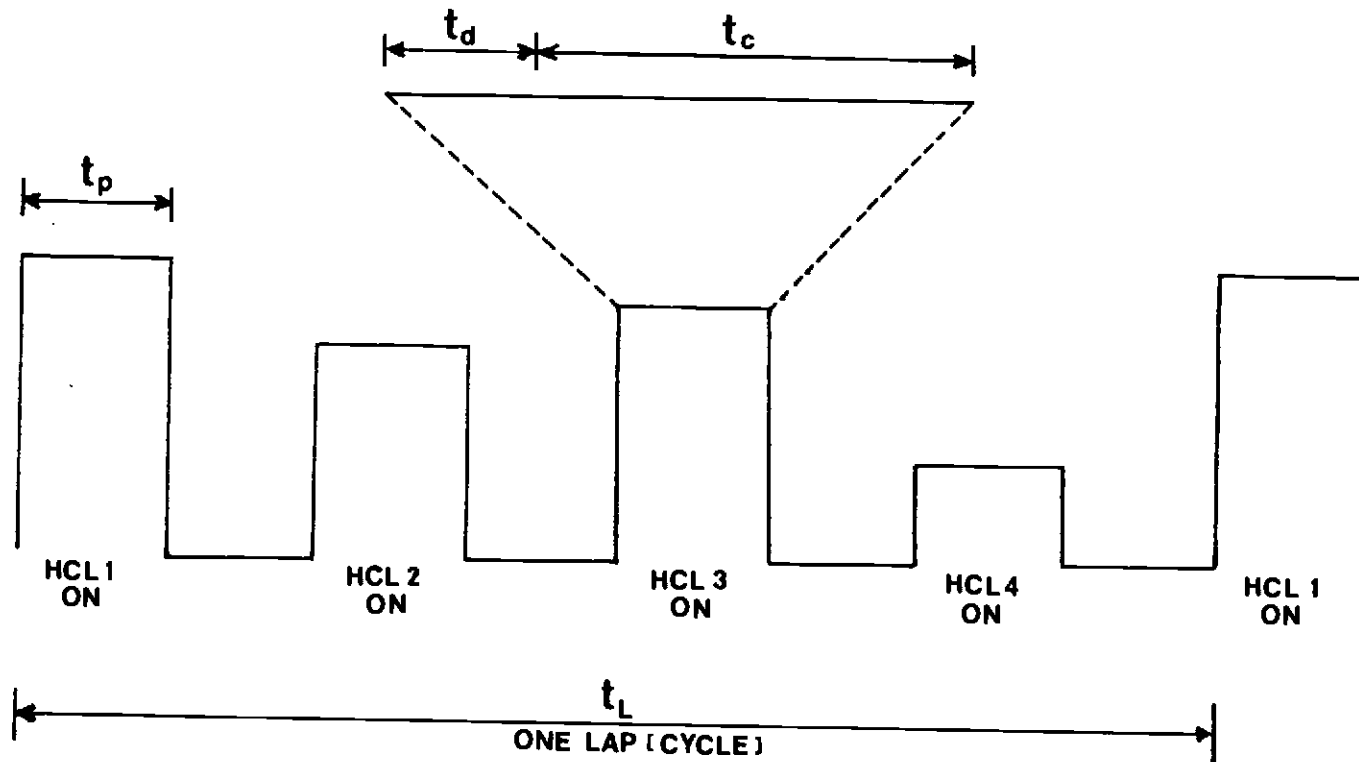


Figure 15. TMMS AF variables timing diagram. t_p = pulse width, t_d = delay time, t_c = data collection time, t_L = lap time.

Signal information and resolution considerations

In mode 2, the signals for ℓ laps are summed together and presented as one data point. Equation 5 shows how the signal reported by the computer (N) is related to input peak voltage to V/F counter.

$$N = \ell K E_p t_c \quad (5)$$

N = number of counts

K = V/F conversion factor (100 kHz/V)

E_p = peak signal voltage, V

t_c = data collection time per pulse, s

ℓ = number of laps

In mode 3, each data point is normalized by dividing it by the number of readings per pulse. The stored digital number (D') acquired by the ADC during one reading is proportional to the voltage input to the 12-bit ADC. Thus during one pulse with q readings, the summed signal is qD' . The final digital signal acquired by summing the results for ℓ laps is $\ell qD'$. This is normalized by dividing by q to yield a data point (D) equal to $\ell D'$. This value is reported as the sum of the mV readings from ℓ pulses (E_{sum}) by multiplying D by (10,000/4095) (10,000 mV is equivalent to 4095 for 12-bit ADC or DAC). Thus in mode 3, one data point is calculated as

$$E_{sum} = 10,000D/4095 \quad (6)$$

The peak voltage E_p in volts can be calculated from E_{sum} with equation 7.

$$E_p = E_{sum}/1000\ell \quad (7)$$

The resolution of the V/F converter is 1 count per lap. The relative resolution per lap (N^{-1}) and absolute voltage resolution per

lap $(Kt)^{-1}$ depends on the integration time and thus the pulse width. The relative resolution for ℓ laps is $\ell^{1/2}/N$ if the contribution from quantization noise is limiting. In contrast, the resolution of the ADC is determined by the least significant bit and is independent of pulse width. For one data acquisition, the absolute resolution is 2.4 mV and the relative resolution is $(2.4 \times 10^{-3})/E_p$. For q acquisitions and ℓ laps, the relative resolution is $(2.4 \times 10^{-3})/(E_p(q\ell)^{1/2})$.

Table III shows the effect of the HCL pulse height and width on the resolution for both the ADC and V/F converter. The peak voltage varies from 10 to 0.01 V for a dynamic range of 3 orders of magnitude.

Table III. Resolution Considerations^a

E_p (V)	t_p (ms)	V/F			ADC ^b		
		Counts (N)	Rel. Res. (N^{-1})	Abs. Res. (mV)	D	Rel. Res. (D^{-1})	Abs. Res. (mV)
10	10	10^4	10^{-4}	1	4095	2.4×10^{-4}	2.4
0.1	10	10^2	10^{-2}	1	40.9	2.4×10^{-2}	2.4
0.01	10	10^1	10^{-1}	1	4	2.4×10^{-1}	2.4
10	1	10^3	10^{-3}	10	4095	2.4×10^{-4}	2.4
0.1	1	10^1	10^{-1}	10	40.9	2.4×10^{-2}	2.4
0.01	1	1	1	10	4	2.4×10^{-1}	2.4

^aCalculations for one lap. Delay time t_d assumed to be 0 ms.

^bOne data acquisition per lap ($q = 1$).

For a 10 ms pulse, the resolution of the V/F converter (mode 2) is about a factor of 2.5 better. However, for a 1 ms pulse width, the resolution of the ADC (mode 3) is superior by about a factor of 4. This occurs because 10 times less counts are accumulated by the counter with the V/F when the integration time is reduced by a factor

of ten. Table III shows that if measurements are limited by resolution rather than noise, mode 3 is superior for pulse widths less than about 4 ms. The contribution of quantization error to the relative uncertainty of noise decreases in mode 3 in proportion to $q^{1/2}$.

Extraction of signal and noise information

The signals and noise observed are composed of various component signals and noise from different sources. These different signal and noise components can be extracted from measurements made under different sets of conditions. The general procedure and terminology used follows the work of Bower and Ingle (84).

Data are acquired during the lamp pulse (or when the lamp would be pulsed on if the lamp is blocked or off) and for an equal time after the lamp pulse. In the corrected mode, the lamp off data are subtracted from the lamp on data for each lap. This corrected signal is related only to signals dependent on the lamp intensity (i.e. analyte and background fluorescence and scattering). The average signal for non-lamp related signals (e.g. background and analyte emission, dark current) is zero because these are DC signals that are present all the time. In the uncorrected mode, the total or uncorrected lamp on signal is obtained by not subtracting the lamp off signal from the lamp-on signal. If the lamp is off or blocked, this uncorrected measurement yields the magnitude of the lamp off signal.

To calculate the mean signal and noise under different sets of conditions, n data points (N 's or E_{sum} 's) (typically 20) are taken and the computer calculates the mean, the rms noise or standard deviation

(SD), and the signal-to-noise ratio (S/N). This complete process is called a run, and often the results of a few runs are used to calculate the average mean, SD and S/N.

The signal (mean) and rms noise (SD) calculated from n data points have units of counts in mode 2 or millivolts in mode 3. These can be converted to units of volts with equations 5, 6, and 7 and are symbolized below as E and σ , for the mean signal and rms noise, respectively, of the peak signals in V.

Repetitive measurements are made in the corrected signal mode with the entrance slit covered. This yields E_{dt} and σ_{dt} , the dark current signal and rms noise, respectively. With the flame and lamps off, the same measurements can be made in the corrected mode with the entrance slit uncovered to determine if stray light from the room causes significant noise.

With the lamps off and a blank aspirating, E_{bet} and σ_{bet} are obtained from n repetitive measurements in the corrected mode and are the total background emission signal and rms noise, respectively.

The above dark current and total background emission measurements can be used to determine the noise contribution with synchronous detection due to background emission from the flame (σ_{be}) from equation 8.

$$\sigma_{bet} = (\sigma_{be}^2 + \sigma_{dt}^2)^{1/2} \quad (8)$$

The above dark current and total background emission measurements can also be made in the uncorrected mode to determine the magnitude of the DC signals, E_{dt} and E_{bet} , from which the DC background emission signal from the flame (E_{be}) can be calculated from equation 9.

$$E_{bet} = E_{be} + E_{dt} \quad (9)$$

Under corrected conditions, the noise magnitudes may be less than in the uncorrected mode if flicker noise limits measurements.

With the flame and lamp on and a blank aspirating, n measurements are made in the corrected mode to estimate E_{bft} and σ_{bft} , the total fluorescence background signal and noise, respectively. Note that σ_{bft} is the blank noise that limits the detection limit. Comparison of σ_{bft} to σ_{bet} (corrected mode) indicates if scattering or background fluorescence noise is significant.

With an analyte solution aspirating, n measurements are made in the corrected mode to obtain the total analyte fluorescence signal E_{ft} and its rms noise, σ_{ft} . From these measurements and the blank measurements, the analyte fluorescence signal (E_f) and the rms noise (σ_f) for making a paired fluorescence measurement (i.e. sample and blank) are calculated with equations 10 and 11.

$$E_f = E_{ft} - E_{bft} \quad (10)$$

$$\sigma_f = (\sigma_{ft}^2 + \sigma_{bft}^2)^{1/2} \quad (11)$$

With the lamps off and an analyte solution aspirating, E_{et} and σ_{et} are obtained with the uncorrected or the corrected modes from n repetitive measurements and are the total analyte emission signal and rms noise, respectively.

In the corrected mode E_e averages to zero and the contribution of analyte emission noise (σ_e) to fluorescence measurements is calculated from σ_{et} and equation 12

$$\sigma_e = (\sigma_{et}^2 - \sigma_{bet}^2)^{1/2} \quad (12)$$

where σ_{bet} is measured in the corrected mode. The noise due to

analyte fluorescence (σ_f) is calculated from equation 13.

$$\sigma_f = (\sigma_{ft}^2 - \sigma_{bft}^2 - \sigma_e^2)^{1/2} \quad (13)$$

In the uncorrected mode, the analyte emission signal is obtained from equation 14.

$$E_e = E_{et} - E_{bet} \quad (14)$$

The computer calculates several quantities from the acquired mean signals and noise magnitudes (SD's) in the sample (total fluorescence) and blank measurements. The net analyte fluorescence signal (E_f) is calculated from equation 10. The S/N for making an AF measurement is calculated from equation 15

$$S/N = E_f/\sigma_F \quad (15)$$

where σ_F is calculated from equation 11. Equation 16 is used to calculate the blank noise limited S/N ($(S/N)_{bk}$).

$$(S/N)_{bk} = E_f/\sigma_{bft} \quad (16)$$

The detection limit (DL) is obtained from equation 17

$$DL = 2 \sigma_{bft}/(\text{slope}) \quad (17)$$

where the slope is calculated from E_f/c and the value for c has previously been input to the computer.

The fundamental rms shot noise in the analyte fluorescence signal, $(\sigma_f)_s$, is calculated from equations 18-21.

$$(\sigma_f)_s = (mR_fKE_f)^{1/2} \quad (18)$$

$$K = 2e\Delta f (1 + \alpha) \quad (19)$$

$$\delta = 10 (\log m)/9 \quad (20)$$

$$\alpha = (\delta - 1)^{-1} \quad (21)$$

m = PMT gain

R_f = feedback resistance, Ω

K = noise bandpass constant, A

Δf = noise equivalent bandpass, s^{-1}

α = secondary emission factor, dimensionless

δ = gain per dynode stage of PMT, dimensionless

e = 1.6×10^{-19} C

For a DC signal in mode 2, $\Delta f = (2t)^{-1}$, where t is the integration time (t_c).

The above equations normally apply to measurements on DC signals. For TMS measurements, the lamp is pulsed so E_f in equation 18 represents the peak value or total analyte fluorescence signal during the lamp pulse. The total observation time for the fluorescence signal of one element in one run of ℓ laps is ℓt_c and

$$\Delta f = (2\ell t_c)^{-1} \quad (22)$$

For mode 3 with $q = 1$, the time constant of the I/V converter limits the noise equivalent bandpass of $\Delta f = (4\tau)^{-1}$ where τ is the time constant. Since q points are taken per pulse every 2τ ($\tau = 0.1$ ms, $t_a = 0.2$ ms), mode 3 effectively performs an integration over the data observation time t_c . This signal averaging provided by taking q points per pulse for ℓ laps reduces Δf calculated from τ by $\sim (1/q\ell)$ such that the Δf from equation 22 provides a good estimate for Δf in mode 3.

In the program, the shot noise is the analyte fluorescence signal is calculated from equation 18. The user inputs the values R_f , C_f , ℓ , and the PMT bias voltage E_{PMT} . The PMT gain (m) is determined from the bias voltage applied to the PMT and RCA 1P28 calibration graph (84). The computer program has a look up table of m values for

voltages from 400 - 1000 V in 100 volt intervals. Next δ and α are calculated from equations 20 and 21 and the value of m . The value of Δf is calculated from equations 4 and 22 and the known values of t_p , t_d , and ℓ . This value of Δf is then used to determine K with equation 19. Finally the analyte fluorescence shot noise is calculated from equation 18 and the known calculated values of m , R_f , and K .

For mode 2, E_f is taken as the difference in total counts accumulated (N) for the sample and blank measurements divided by $Kt_c\ell$ so that the shot noise is reported in volts. For mode 3, E_f is taken as the difference in E_{sum} for the total sample and blank measurements and divided by 1000 and reported as the shot noise in volts. From equation 7 and 18, the shot noise in volts is the shot noise reported divided by $\ell^{1/2}$.

In many cases it was useful to calculate manually the analyte fluorescence photocathodic peak current (i_f) from equation 23. The

$$i_f = E_f/mR_f \quad (23)$$

rms photocathodic current in amperes is calculated from equation 24.

$$(i_f)_{rms} = i_f t_p/t_L = i_f(\%DC) \quad (24)$$

Operation and software considerations

Before starting the program, the operator selects R_{sense} , E_{PMT} , the HCL load resistors, the proper slit mask, R_f , C_f , the burner and the oxidant, fuel and the sheath gas flow rates. The monochromator wavelength drive is used to align the system based on the 285.2 nm line from the Mg HCL.

BASIC and machine language programs were developed for modes 2 and 3 and the listings are given in Appendix XIII. Figure 16 shows a

flow chart for the programs. The operator first loads the appropriate BASIC and assembly language programs for the mode to be used. After typing RUN, the program first, through TTY communication, requests input information from the user about the magnitude of experimental variables. The operator then chooses between two basic options, the operator analysis or characterization. Depending on the option selected, the operator is guided by prompts to choose the types of measurements to be made (dark, blank, or sample) or to input other data. Once the correct information is input, the user signals the start of data acquisition. After data acquisition, various calculations are performed and printed out with the data. The assembly language routines perform most of the control functions. After input of parameters and bookkeeping calculations performed in BASIC for any particular measurement (calibration, dark, blank, or sample), the assembly part of the program takes over and starts to pulse the HCL's and collect data. The assembly program configures the I/O lines properly (input or output), controls the HCL's pulsing and currents, collects data, and stores the data in reserved memory blocks. It also controls the operations of the ADC, the DAC, or the 2-byte up-down counter and keeps track of the number of laps and data points. Finally it controls the clock and all other timing functions. The data stored are later pulled out of memory by BASIC and calculations are performed in BASIC. The use of the program is described now in more detail.

The program starts in BASIC, and asks the operator to input the HCL's pulse width in milliseconds, then percent duty cycle, the

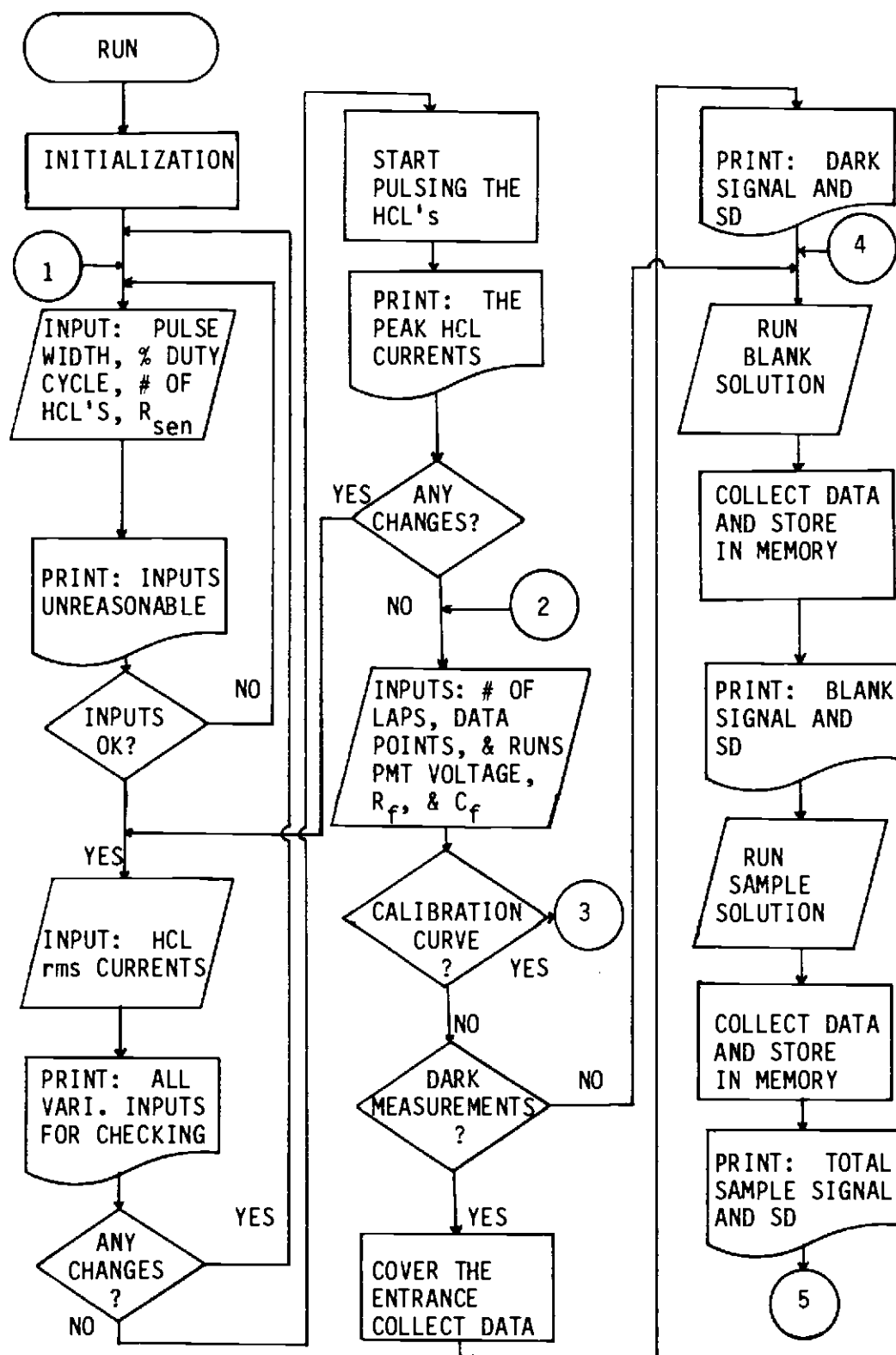


Figure 16. Simplified computer program flowchart.

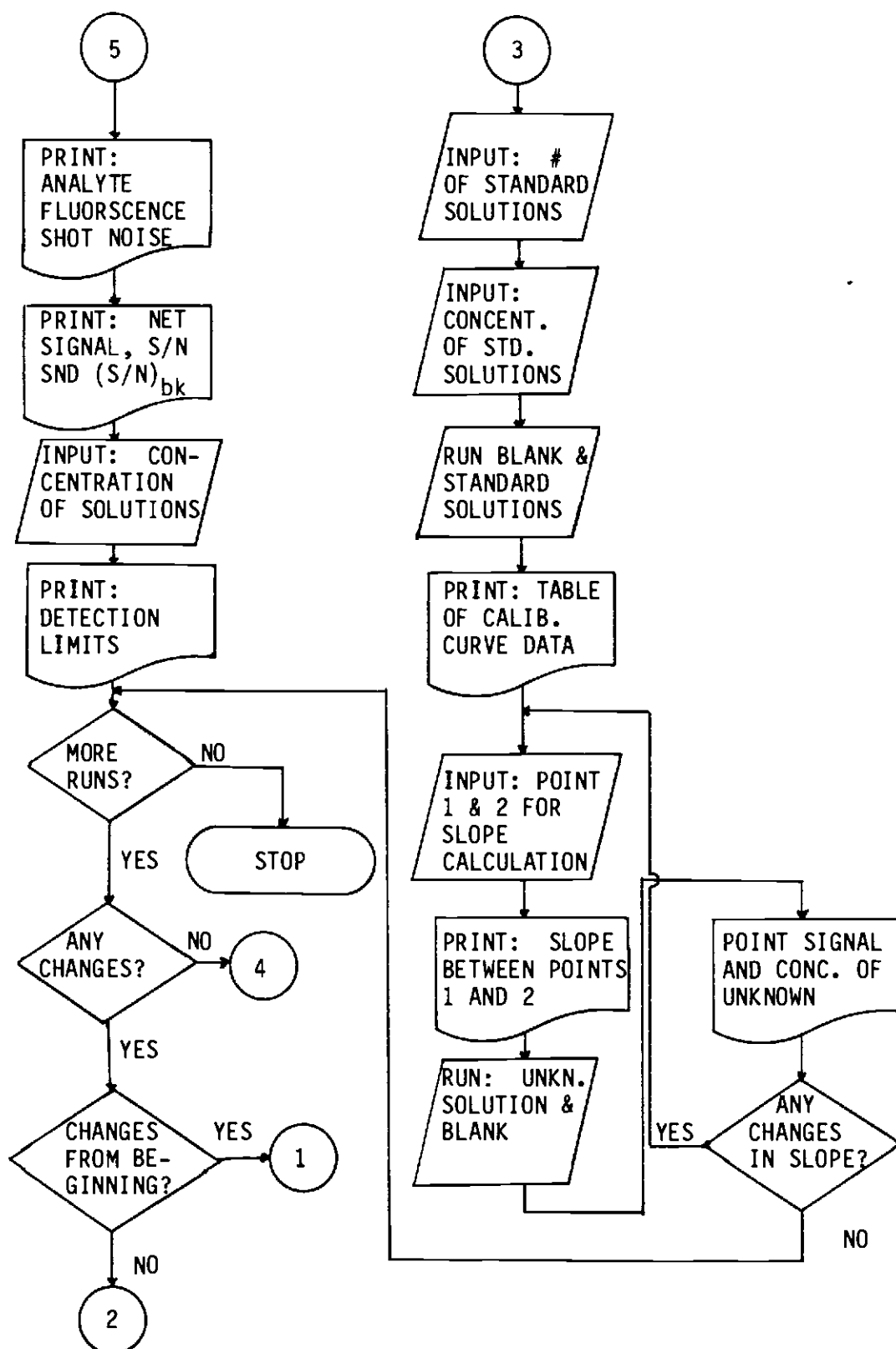


Figure 16. continued.

number of HCL's to be used, and the R_{sense} value in ohms. The off time is calculated for the given percent duty cycle and the number of HCL's, and if the off time is smaller than the selected HCL pulse width (the product of percent duty cycle and number of lamps greater than 50%), an error message is printed and new inputs are requested. Next the rms HCL currents are input sequentially. These values are converted to appropriate digital numbers and checked against the DAC capacity (not larger than 4095). If the DAC capacity is exceeded, an error message is printed which indicates that the HCL current or R_{sense} should be changed.

Before pulsing the HCL's, all the input values are printed for final checking and if no changes needed, the pulsing starts. The ADC reads the voltage at the sense resistor and calculates the peak HCL current from equation 1 and R_{sense} for each HCL and prints i_p for HCL. If the currents are acceptable, the program proceeds to the next step. If not, new HCL currents values are input. Once the HCL currents are acceptable, the program asks for the number of laps, the number of data points per run, the values of R_f in M ohms and C_f in p Farads (I/V converter feedback resistor and capacitor), the number of runs, and the PMT voltage in volts. At this point the program calculates the delay time t_d as $5R_f C_f$. The delay time and pulse width (t_p) are then used to calculate the data collection time with equation 4. For later shot noise calculations, Δf , δ , and K are calculated with equation 22, 20 and 19, respectively.

Next the operator chooses between two of the basic options, analysis or characterization. If the characterization option is chosen

(a no answer (0) to calibration curve question), the program asks if a dark current measurement is needed. If so the operator is requested to cover the entrance slit. On a signal (CR) from the operator, the data are taken in the uncorrected mode and the mean and SD in the dark signal are calculated and printed for each HCL chosen. The operator is given the choice of printing out the n dark signals obtained in the run.

After the dark current measurement or if no dark current measurement is requested, the program indicates a blank run is to be made. The program switches the auto sampler to the blank position and after a CR, the blank data are taken in the corrected mode, and the blank mean signal (E_{bft}) and SD (σ_{bft}) are printed for each element chosen. Again the data for each point in the run can be printed out if desired. If the above measurements are taken with the lamp blocked, then the mean and SD in the total background emission signal are obtained.

After the blank measurement, the program tells the operator that an analyte solution is to be measured. The program switches the auto-sampler to the sample position, and the user inserts the sample capillary tube from the autosampler into the desired solution. After a CR, the data are collected and the mean (E_{bft}) and SD (σ_{ft}) of the total signal are calculated and printed for each element chosen. The data for all runs can be printed out if desired. Next the analyte fluorescence shot noise ($(\sigma_f)_s$ from equation 18), the net analyte fluorescence mean signal (E_f from equation 10), $(S/N)_{bk}$ (from equation 16), and S/N (from equation 15) for each element are printed

out.

The operator is requested to input the concentration of the analyte solutions run in mg/L. The detection limits are calculated (from equation 17) and printed in mg/L.

If the above blank and analyte measurements are made the HCL's blocked, data are obtained about the analyte emission noise (the same section of the program which does the dark measurements is used for emission measurements).

If more than one run was requested at the beginning of the sequence, the program goes through the dark, blank, and sample measurement scheme for the number of runs requested. After this the operator can request more runs with the same experimental parameters, change the experimental parameters before more runs, or end the experiment. A sample printout for a characterization run is shown in Figure 17.

If the calibration curve option is chosen, the operator is asked to input the number of standards to be run and the concentration of standards in mg/L for each element. On a signal from the operator (CR), the program obtains a blank measurement and then a sample measurement through control of the autosampler. This is repeated for each standard solution. After all the standards have been run, a calibration data table is printed out which indicates, for each element and standard, the net fluorescence signal and the corresponding standard solution concentration in mg/L. Also other information such as the blank signal and SD, and the total signal and SD, are printed out after each sample (blank or standard) is run.

Figure 17. MULTI-AD computer program sample output.

RUN

HC#1
HC#2
HC#3
HC#4

TIME ON
T1=10

% TIME ON
PC=12.5

OF LAMP
LM=4

RESISTOR VALUE
R=6.7

H.C. AVE. MAMP CURRENTS

H.C. #1 CURRENT
C1=13

H.C.#2 CURRENT
C2=14

H.C.#3 CURRENT
C3=15

H.C.#4 CURRENT
C4=15

T1=10	PC=12.5	LM=4	R=6.7
C1=13	C2=14	C3=15	C4=15

ARE THESE VALUES CORRECT? YES=1, NO=0
ANS=1

READY TO READ CURRENT! PUSH (CR).

PEAK TO PEAK CURRENTS

H.C.#1 CURRENT=110 MAMP
H.C.#2 CURRENT=118 MAMP
H.C.#3 CURRENT=127 MAMP
H.C.#4 CURRENT=127 MAMP

Figure 17. continued

READ MORE YES=1, NO=0
ANS=0

OF LAPS
LP=100

OF POINT
PT=20

RF VALUE (M-OHM)
RF=1

CF VALUE (P-F)
CF=100

OF RUNS
RN=1

PMT VOLTAGE
PM=1000

CALIBRATION CURVE YES=1, NO=0
ANS=0

DO YOU WANT DARK DATA? YES=1, NO=0
DK=1

COVER ENTRANCE SLIT & PUSH (CR).

DARK DATA

DARK AVE & STD DIV.

4	2	4	8
6.81	6.20	5.36	5.74

PRINT DATA YES=1, NO=0
ANS=0

RUN BLANK PUSH (CR) TO START.

BLANK DATA

BLANK AVE & STD DIV.

26	66	875	2828
14.59	11.68	14.77	18.07

Figure 17. continued

PRINT DATA YES=1, NO=0
ANS=0

RUN SAMPLE PUSH (CR) TO START.

SAMPLE DATA

TOTAL SIG AVER & STD DIV.

410	2196	1074	11383
16.30	29.04	19.83	63.67

PRINT DATA YES=1, NO=0
ANS=0

RMS SHOT NOISE (VOLTAGE)

4.2113728E-04	2.2556523E-03	1.1031742E-03	1.1692209E-02
---------------	---------------	---------------	---------------

NET SIGNAL

384	2130	199	8555
-----	------	-----	------

NET SIGNAL/BLANK STD DIV.

26.3	182.4	13.5	473.4
------	-------	------	-------

NET SIGNAL/TOTAL NOISE

17.5	68.0	8.0	129.3
------	------	-----	-------

CONC. OF SOLN. #1 (PPM)
G1=1

CONC. OF SOLN. #2 (PPM)
G2=1

CONC. OF SOLN. #3 (PPM)
G3=1

CONC. OF SOLN. #4 (PPM)
G4=1

DETECTION LIMITS (PPM)

76.0	11.0	148.0	4.0
------	------	-------	-----

Figure 17. continued

EXTRA RUN YES=1, NO=0
ANS=0

Next the operator inputs the numbers of two standards to calculate the slopes in signal units per mg/L for each element upon a signal from the operator, the signals for the blank and unknown solutions are obtained and the blank signal and SD, the unknown total signal and SD, and the net signal for the unknown are printed out during the measuring process. The concentration of each element in the unknown is calculated from the ratio of the net unknown signal and appropriate slope and printed.

At this point, the operator can choose different standards for the slope calculations. In this case the program recalculates the slopes and the concentration of each element in the previously run unknown.

The above process is repeated for the number of runs chosen. After this, the operator can stop or make more runs with the same or new parameters. Figure 18 shows a copy of a typical output for a calibration run from the point a calibration run is chosen.

Solution Preparation

Ten elements, Au, Cd, Co, Cu, Fe, Mg, Mn, Ni, Pb, and Zn, were selected to be used in different experimental studies. Standard stock solutions of approximately 1000 $\mu\text{g/mL}$ of these elements were prepared by dissolving a suitable amount of a primary standard of each element in a proper solvent such as an acid or deionized distilled water. The primary standards used were the pure metals for Au, Co, Cu, Fe, Ni, and Zn, and the compounds CdO , MgO , $\text{MnSO}_4 \cdot \text{H}_2\text{O}$, and $\text{Pb}(\text{NO}_3)_2$, for Cd, Mg, Mn, and Pb, respectively. Typically 500 mL of stock solution were

Figure 18. Computer program sample output for calibration curve measurements.

CALIBRATION CURVE YES=1, NO=0

ANS=1

OF STANDARDS

SD=3

INTER THE CONCENTRATION OF STANDARDS.

1	1
2	2.5
3	10

OF RUNS PER SAMPLE

RN=1

CALIBRATION CURVE DATA

DO YOU WANT DARK DATA? YES=1, NO=0

DK=0

RUN BLANK PUSH (CR) TO START.

BLANK DATA

BLANK AVE & STD DIV.

110	46	702	388
66.12	61.5	59.09	70.27

RUN SAMPLE PUSH (CR) TO START

SAMPLE DATA

TOTAL SIG AVER & STD DIV.

198	1103	923	3821
69.25	75.03	78.27	107.32

DO YOU WANT DARK DATA? YES=1, NO=0

DK=0

RUN BLANK PUSH (CR) TO START.

Figure 18. continued

BLANK DATA

BLANK AVE & STD DIV.

64	22	717	355
65.45	47.26	72.98	48.23

RUN SAMPLE PUSH (CR) TO START.

SAMPLE DATA

TOTAL SIG AVER & STD DIV.

502	2490	1208	9086
148.88	86.87	97.44	218.07

DO YOU WANT DARK DATA? YES=1, NO=0
DK=0

RUN BLANK PUSH (CR) TO START.

BLANK DATA

BLANK AVE & STD DIV.

60	10	693	361
59.28	55.58	72.66	73.33

RUN SAMPLE PUSH (CR) TO START.

SAMPLE DATA

TOTAL SIG AVER & STD DIV.

1561	7601	3012	32859
265	155.85	164.58	656.85

CONC. NET AVE. SIGNAL.

1	88	1057	221	3433
2.5	438	2468	491	8731
10	1501	7591	2319	32498

Figure 18. continued

WHAT ARE THE 1ST & 2ND POINTS FOR THE SLOPE CALC.

1ST=1
2ND=3

SLOPE OF CALIB. CURVES

157 726 233 3229

DO YOU RUN UNKNOWN YES=1, NO=0
ANS=1

DO YOU WANT DARK DATA? YES=1, NO=0
DK=0

RUN BLANK PUSH (CR) TO START.

BLANK DATA

BLANK AVE & STD DIV.

69	28	713	353
64.41	54.17	52.79	62.52

RUN SAMPLE PUSH (CR) TO START

SAMPLE DATA

TOTAL SIG AVER & STD DIV.

436	201	1275	2375
121.73	69.41	90.32	100.30

NET UNK. SIGNAL.

367 173 562 2022

CONCENTRATION OF UNK.

2.34 0.24 2.41 0.63

CALCULATE THE SLOPE AGAIN YES=1, NO=0
ANS=0

EXTRA RUN YES=1, NO=0
ANS=0

prepared and about 10 mL of concentrated nitric acid was added before dilution to make the solution 2% (v/v) in nitric acid. Addition of nitric acid to each standard solution prevents the loss of analyte by adsorption on the walls of its storage container.

From these stock solutions, a series of lower concentration standard solutions were prepared by dilution to be approximately 0.1, 2.5, 5, 10, 25, 50, 100, 250, 500, and 750 $\mu\text{g/mL}$ in each element. Multiple element standard solutions were prepared in a similar way by dilution of stock solutions. These solutions were preserved by the previously described method and stored in available glass or polyethylene bottles.

All the glassware including storage bottles were soaked in 50% nitric acid and rinsed with deionized distilled water each time before use.

RESULTS AND DISCUSSION

Introduction

To evaluate the capabilities and limitations of the automated multielement TMS AF instrument, an extensive experimental study was conducted and the results of these studies are presented in this section. The first subsection is concerned with the optimization of critical variables in the single element AF mode. The second subsection presents the results for single element AF measurements of 10 elements under optimized conditions. The results are presented in the form of calibration curves, S/N curves and detection limits. The third subsection deals with measurements of four elements in the multielement AF mode in two types of flames. Nondispersive AF multielement measurements are discussed in the final section.

In all these studies, mode 2 or 3 was used. In these modes, the microcomputer is used for control of experimental variables and data acquisition. This allows the operator to change conveniently the magnitude of experimental variables with software rather than through time consuming hardware changes. Computer controlled data acquisition and calculation saves a considerable amount of the operator's time by reducing post-measurement calculation time.

Optimization Studies

Effect of type of lamp pulsing circuit

In the instrumental section, two configurations were presented for pulsing the HCL's. In the unregulated configuration (Figure 3B), the lamp current is determined by a ballast resistor and the

resistance of the lamp. In the regulated configuration (Figure 13), a feedback circuit is used to maintain the lamp current constant even if the lamp resistance varies.

To compare these two configurations, the radiation from the Cu HCL was focused with the entrance lens directly on the entrance slit and pulsed with a 10 ms pulse width and 12.5% duty cycle. Each data point is the sum of 100 laps (8 s total acquisition time). Twenty data points were collected for each configuration and the mean signal, SD, and S/N were automatically calculated and reported by the micro-computer. The relative standard deviation (RSD) is calculated from the inverse of the S/N. The means and RSD's from ten such runs were averaged. This whole experiment was repeated on two separate occasions and the results are reported in Table IV.

Table IV. Effect of Lamp Pulsing Configuration on Precision^a

Experiment No.	With Feedback Circuit		Without Feedback Circuit	
	Mean Signal ^b	%RSD	Mean Signal ^b	%RSD
1	25	0.15	22	1.5
2	18	0.18	18	1.3

^aThe experiments were performed in mode 3 under the following conditions: R_f , 1 M Ω ; $(i_{rms})_{HCL}$, 4 mA; ℓ , 100; PMT voltage, 400 V; t_p , 10 ms; t_d , 0.2 ms; t_r , 0.1 ms; %DC, 12.5; wavelength, 325 nm.

^bpeak photocathodic current $\times 10^{11}$ A.

The results in Table IV indicate that the feedback configuration increases the lamp output stability by about a factor of ten compared to operation without current feedback. Therefore the feedback configuration was used for all further studies, unless otherwise noted. Signal shot noise is insignificant in that the %RSD would be less than 0.01% if signal shot noise was limiting.

Effect of data acquisition mode

In mode 2, the V/F converter (Figure 9, dashed line) is used for data acquisition and the signal is integrated over the whole lamp pulse except during the delay time t_d . An ADC is used for data acquisition in mode 3 (Figure 9, solid line) where the number of data points acquired during a lamp pulse is determined by the pulse width (t_p) chosen and t_d .

The radiation from the Co HCL was focused with the entrance lens on the entrance slit. A beam splitter was placed between the HCL and the lens to reduce the lamp signal so measurements would be resolution limited. For each mode, 20 data points were collected where each data point represents the sum of the signals from 100 laps. The mean signal, SD, and S/N from the 20 data points were calculated and reported by the computer. The RSD was calculated from the S/N. The experiment was performed for low and high lamp currents as well as with 10 and 1 ms pulse widths. The delay time was 0.5 ms for both modes. For mode 3, 48 data acquisitions were made collected during a given 10 ms pulse and 3 data acquisitions were made acquired during a 1 ms pulse. For each condition, 6 runs of 20 data points were made

and the average mean signal and RSD of these runs are reported in Table V.

Table V. Comparison Between Modes 2 and 3^a

t_p (ms)	$(i_p)_{\text{HCL}}$ (mA)	ADC			V/F		
		Mean Signal ^d	%RSD	%Rel. Res. ^e	Mean Signal ^d	%RSD	%Rel. Res. ^f
10 ^b	27	4.7	0.36	0.15	5.7	0.7	0.38
1 ^b	27	4.7	1.7	0.60	6.2	6.4	6.5
1 ^c	295	210	0.37	0.01	270	0.39	0.15

^aPMT voltage, 1000 V; R_f , 1 M Ω ; τ , 0.1 ms; wavelength, 241 nm;
 $(i_{\text{rms}})_{\text{HCL}}$, 3 mA; t_d , 0.5 ms; ℓ , 100.

^b%DC, 12.5.

^c%DC, 1.

^dpeak photocathodic current $\times 10^{15}$ A.

^ecalculated from $(2.4 \times 10^{-3}) / (E_p(q\ell)^{1/2})$

^fcalculated from $\ell^{1/2} / N$.

The results in Table V indicate that a significant difference between the two systems appears only for a small pulse width in combination with a low HCL peak current. The results from this study are in harmony with the conclusions from Table III about the resolution limitations of mode 2 for small pulse widths.

The calculated relative resolution for both modes is also shown in Table V. These agree reasonably well with the experimental RSD's. Because the light levels measured were low, the signal shot noise is on the order of the readout resolution. Mode 3 was used for all

other studies, unless otherwise noted, because of the resolution limitations of mode 2 for small lamp pulse widths.

Delay Time and Time Constant

When current is applied to a HCL, it takes a finite time for the I/V converter output to reach its maximum value due to time constant of the I/V converter, the response time of HCL pulsing circuit and the response time of HCL. The delay time (t_d) before data acquisition should be long enough that the signal reaches near its maximum value. However, t_d should not be too long as this restricts the data collection period (t_c). In mode 3 of operation, it takes about 0.2 ms to acquire and store a data point. For short pulse widths, a long delay time, significantly limits the number of readings per pulse.

The effect of the I/V time constant (τ) and t_d was evaluated by making measurements with the radiation from the Zn HCL focused on the entrance slit with the entrance lens. Table VI show how mean and the S/N of the HCL signal depends upon τ where t_d is adjusted to a constant value of 0.15 ms. Four readings were taken during each 1.0 ms pulse. The mean signal and S/N reported are the average from 3 runs of 20 data points.

The data indicate that the larger τ causes about a 3% decrease in signal and about a 50% improvement in S/N. The signal decreases with a larger τ because the lamp signal has not reached its maximum value when the data collection starts. The S/N improves because the noise equivalent bandpass is reduced with a larger τ . This reduces the noise observed by the ADC.

Table VI. Effect of Time Constant^a

τ (ms)	Mean Signal ^b	S/N ^c
0.03	37	23
0.1	36	36

^arms HCL current, 5 mA; t_p , 1 ms; %DC, 12.5; ℓ , 100; R_f , 1 M Ω ; PMT voltage, 1000 V.

^bMean peak photocathodic current $\times 10^{16}$ A.

^cMean signal divided by standard deviation.

The effect of delay time on the mean signal and S/N is shown in Table VII. The conditions are the same as in the previous experiment (Table VI) except τ is kept constant at 0.1 ms and t_d and the number of readings per pulse are varied.

Table VII. Effect of Delay Time

Delay Time (ms)	# of Readings	Mean Signal ^a	S/N
0.3	4	36	31
0.5	3	37	31

^aMean peak photocathodic current $\times 10^{16}$ A.

Table VII shows that increasing t_d from 0.3 to 0.5 ms reduces the number of readings per pulse from 4 to 3 and increases the mean signal by about 4% because the lamp signal reaches its maximum before data collection starts. The S/N does not change significantly.

Theoretically the noise should increase by a factor of $(4/3)^{1/2}$ due to

the decreased number of readings. This is not observed because of the uncertainty in measuring the S/N and the slight increase in the signal. For all further measurements, a τ of 0.1 ms and a t_d of 0.5 ms were employed, unless otherwise noted.

Effect of HCL peak current on the lamp signal

In AF measurements, high intensity sources are employed to achieve better detection limits. In this and other research, HCL's are operated in a short pulse width, high peak current mode to produce a large radiant intensity during the pulse. Pulsed HCL's have been shown (42,57) to produce better S/N's than DC operated lamps in AF measurements because the total noise observed from the flame is reduced by acquiring data only during the HCL pulse.

To determine the effect of the HCL peak current on the radiant power output, a 1 ms pulse width was chosen. This is the minimum t_p provided by the software written which uses a microcomputer timer to generate the pulses. The radiation from the HCL's was focused on the entrance slit with the entrance lens. Five data points were collected for each HCL peak current, and each data point consists of 1 lap. The maximum HCL rms current chosen was 10 mA which is 2/3 of maximum rms current allowed for the HCL's used. The minimum duty cycle allowed by the program is 1% which yield a maximum peak HCL peak current of about 1000 mA or 1 A. Higher HCL currents can damage the HCL load resistor (Figure 3) or the HCL. The HCL peak current can be changed two ways as shown in equation 3. Either the percent duty cycle (%DC) can be varied with a constant rms HCL current ($(i_{rms})_{HCL}$) or $(i_{rms})_{HCL}$ can be changed with a constant %DC.

Figures 19 and 20 show the dependence of lamp intensity on HCL peak current. For the data in Figure 19, $(i_{rms})_{HCL}$ was kept constant at 10 mA and the peak HCL current was changed by changing the duty cycle from 1 to 12.5% for the Co and Cu HCL's. In the case of Figure 20, the %DC was kept constant at 1% and $(i_{rms})_{HCL}$ was varied from 1 to 10 mA to change the HCL peak current for the Co, Zn, and Cu HCL's.

In both experiments, the log-log plots are linear with slopes of 1.06 - 1.47 over most of the HCL current range studied. A negative deviation in the plots is observed for the Zn HCL at about 900 mA and for the Co HCL at about 700 mA. This negative deviation could be due to self-absorption and self reversal. Self-absorption in HCL's occurs when photons emitted by excited atoms within the emitting volume are reabsorbed by other ground state atoms before escaping. This is more likely to occur at higher currents because a larger or denser cloud of atoms is produced at the surface of the cathode. Self-reversal occurs when the radiation from the center of the emission line of the atoms in the center of emitting volume is absorbed to a greater extent than radiation in the wings of the emission profile (50, 52-53).

Piepmeyer (50, 52-53) observed line profile changes during the application of current pulses to HCL's due to self-reversal and self-absorption. The results of one study (52) showed that, for a given HCL and current, the amount of self-absorption decreases with decreasing modulation frequency; the best line profile shape is obtained at a pulse duration of about 1 ms; and for a given frequency, self-reversal increases with increasing peak HCL current.

No significant difference was observed between the two modes of

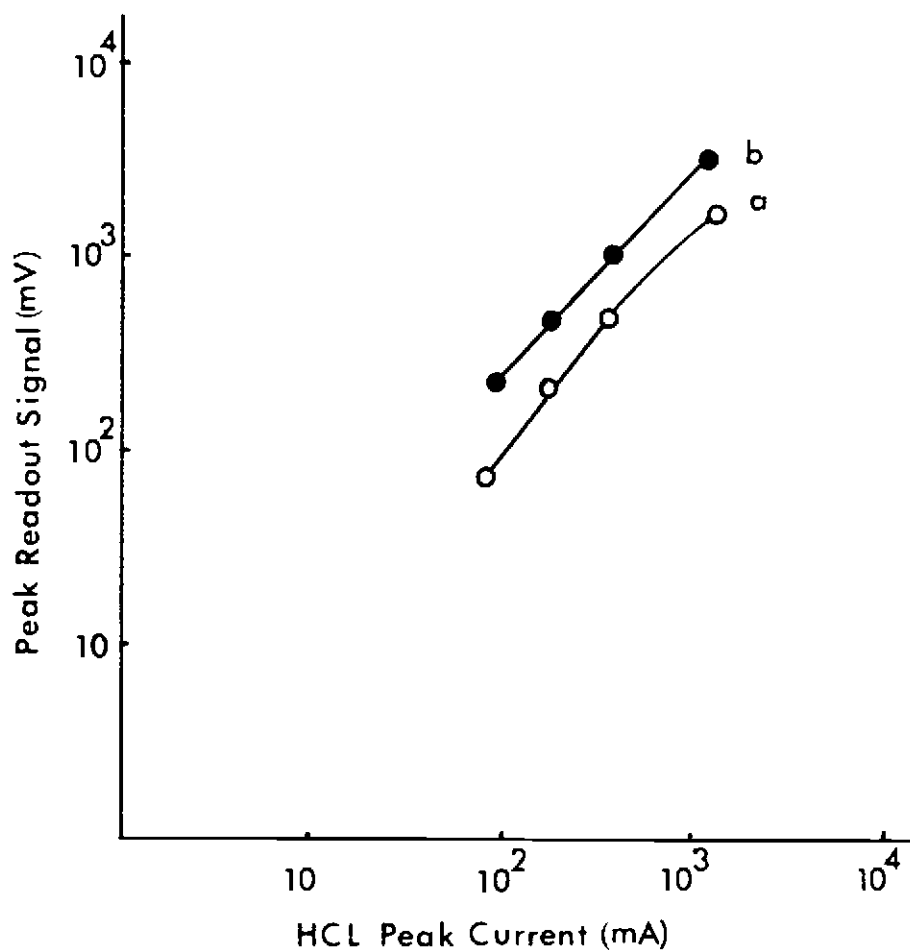


Figure 19. Dependence of the HCL signal on peak HCL current with a variable duty cycle. a, Co HCL ($\lambda = 241$ nm); b, Cu HCL ($\lambda = 325$ nm); R_f , 1 M Ω ; τ , 0.1 ms; t_d , 0.5 ms; ℓ , 1; PMT voltage, 400 V; $(i_{rms})_{HCL}$, 10 mA; t_p , 1 ms; # of readings per pulse, 3.

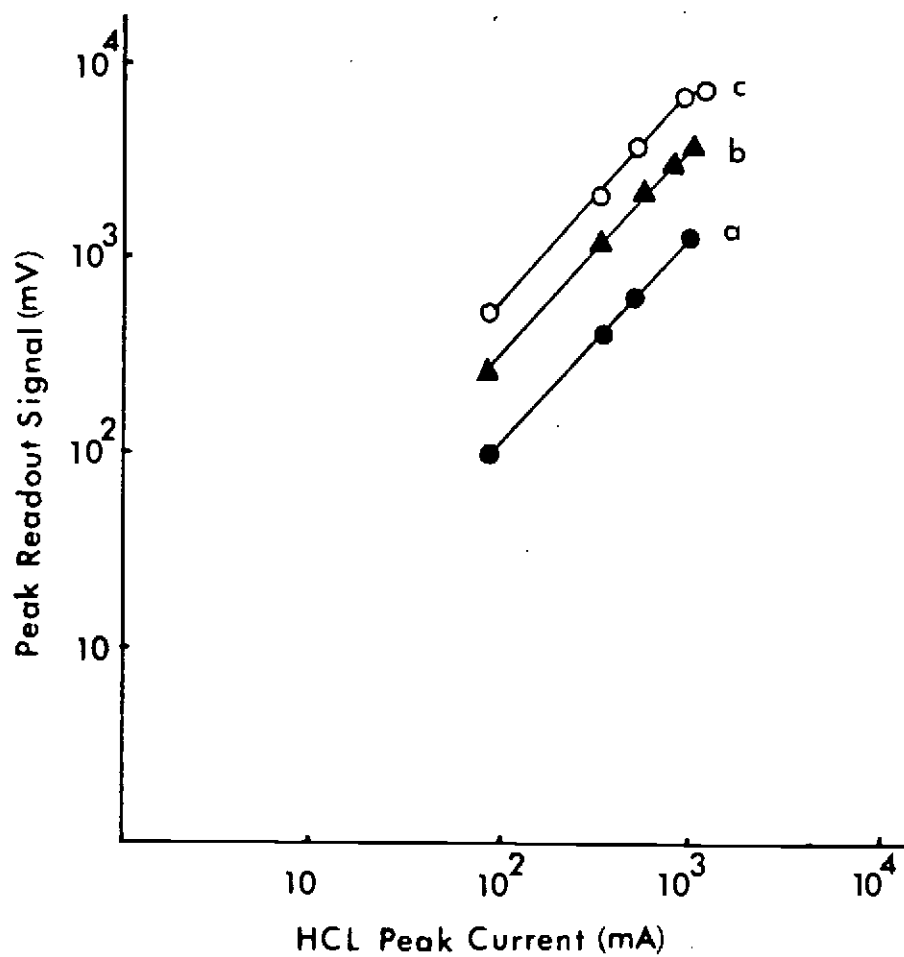


Figure 20. Dependence of HCL signal on HCL peak current with a constant duty cycle. a, Cd HCL ($\lambda = 224$ nm); b, Cu HCL ($\lambda = 325$ nm); c, Zn HCL ($\lambda = 214$ nm); conditions same as Figure 19 except %DC = 1.

varying the HCL peak current. Both modes yield the same log-log slope for the Cu HCL. Mode 1 (variable %DC) was used to vary the HCL peak current in most further studies.

Burner head comparison

The three burner heads available were compared under identical conditions with Co as the analyte (10 mg/L) to choose the burner head to use for the rest of the study. Table VIII show the results of the this study.

Table VIII. Burner Head Comparison^a

Burner Head	Signal ^b	(S/N) _{bk}	S/N
Meker with safety collar	4.2	150	36
capillary	2.6	52	23
Meker	3.5	91	27

^aThe means and S/N's reported are the means for two runs of 20 data points; ℓ , 100; $(i_{rms})_{HCL}$, 10 mA; %DC, 12.5; burner height, 2.8 cm; H₂ flow rate, 4.4 L/min; air flow rate, 5.6 L/min; t_p , 10 ms; R_f , 1 M Ω ; PMT voltage, 1000 V; wavelength, 241 nm.

^bpeak photocathodic analyte fluorescence signal $\times 10^{15}$ A.

The Meker burner with the safety plug provides the best S/N's while the capillary burner yields the worst S/N's. The Meker burner (without a safety collar) was chosen for all further studies because

it provides reasonable S/N's and be used with the water cooling and argon gas sheathing. Water cooling maintains the burner head at lower temperature during long operation times and reduces the possibility of combustion of gases inside of the burner head. Argon gas sheathing increases the S/N as discussed in a later section.

The capillary burner head can also be used with Ar gas sheathing and is safe with respect to flashback. The long capillary tubes in the capillary burner head do not allow the flame to burn back into the nebulizer chamber if the burning velocity exceeds the gas supply velocity. However, the loss in S/N with this burner is significant.

Burner height

The burner height is defined as the distance from the top of the burner head to the optical axis as defined by the center of the entrance slit of the monochromator. It must be optimized for the best S/N for each element and set of experimental conditions. An initial burner height optimization study was conducted with copper (10 mg/L) and the Meker burner head to establish the general region of optimum burner height. Later on in single element studies, it is shown that there is not a significant difference in the optimum region of burner height for most elements.

Figures 21, 22, and 23 show plots of S , S/N , and $(S/N)_{bk}$ vs burner height for two different H_2 flow rates. Figure 21 indicates that the maximum signal is obtained for burner height values in the 1.5 - 2.5 cm region. The signal is larger with a larger H_2 flow rate. As Figure 22 shows, the best S/N is obtained at lower burner

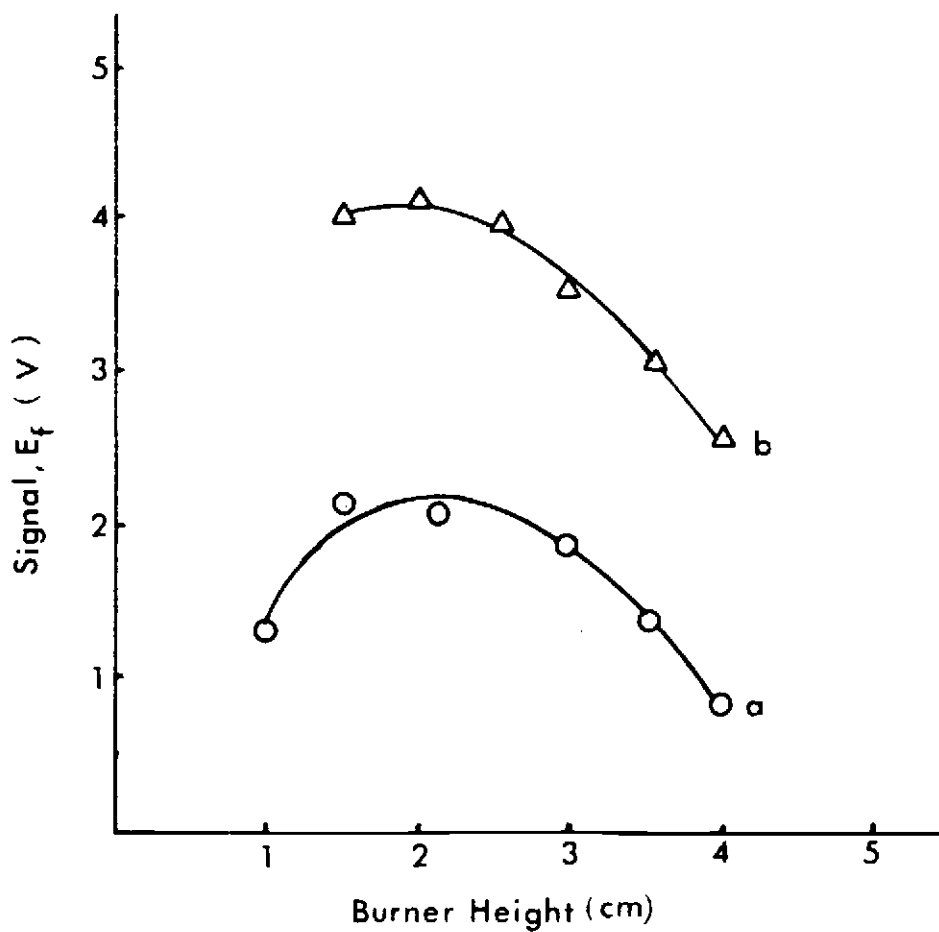


Figure 21. Dependence of signal on burner height. a, H_2 flow rate = 0.8 L/min; b, H_2 flow rate = 2.8 L/min; t_p , 10 ms; $(i_{rms})_{HCL}$, 10 mA; %DC, 12.5; number of data points, 10; ℓ , 25; air flow rate, 4.6 L/min; 10 mg/L Cu solution; R_f , 1 M Ω ; E_{PMT} , 1000 V; number of runs, 1; t_d , 0.5 ms; λ , 325 nm.

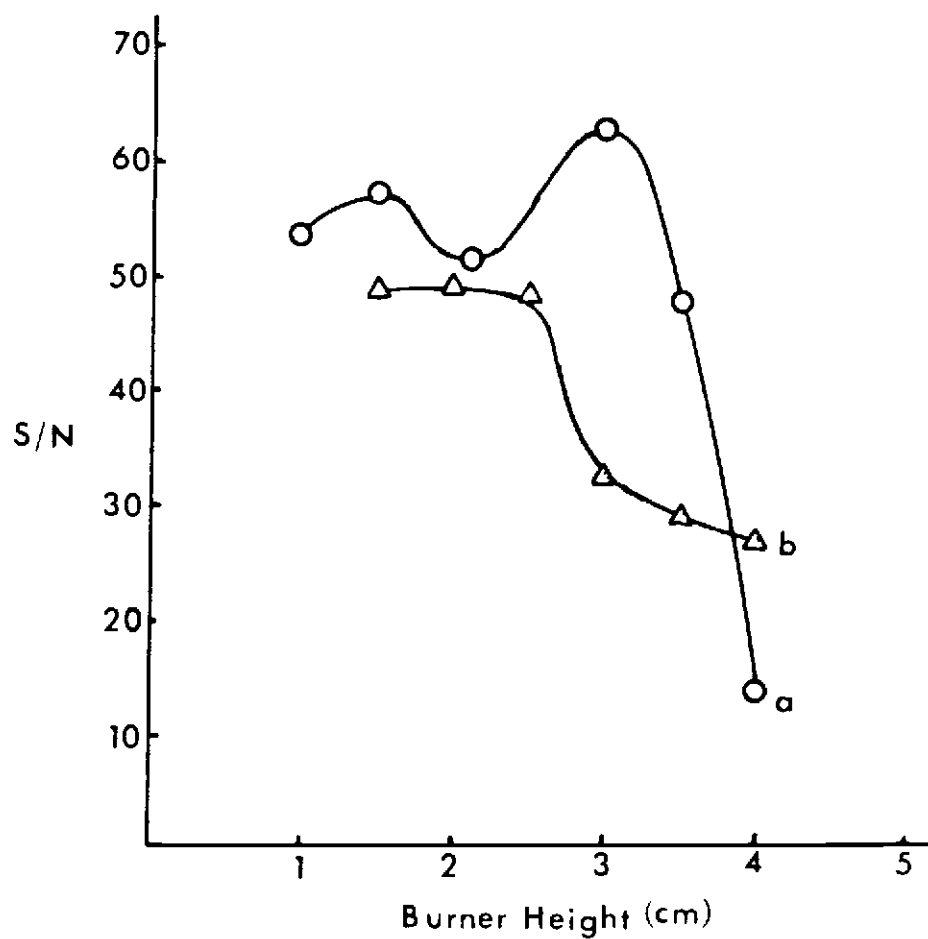


Figure 22. Dependence of S/N on burner height. a, H_2 flow rate = 0.8 L/min; b, H_2 flow rate = 2.8 L/min; other experimental conditions are the same as Figure 21.

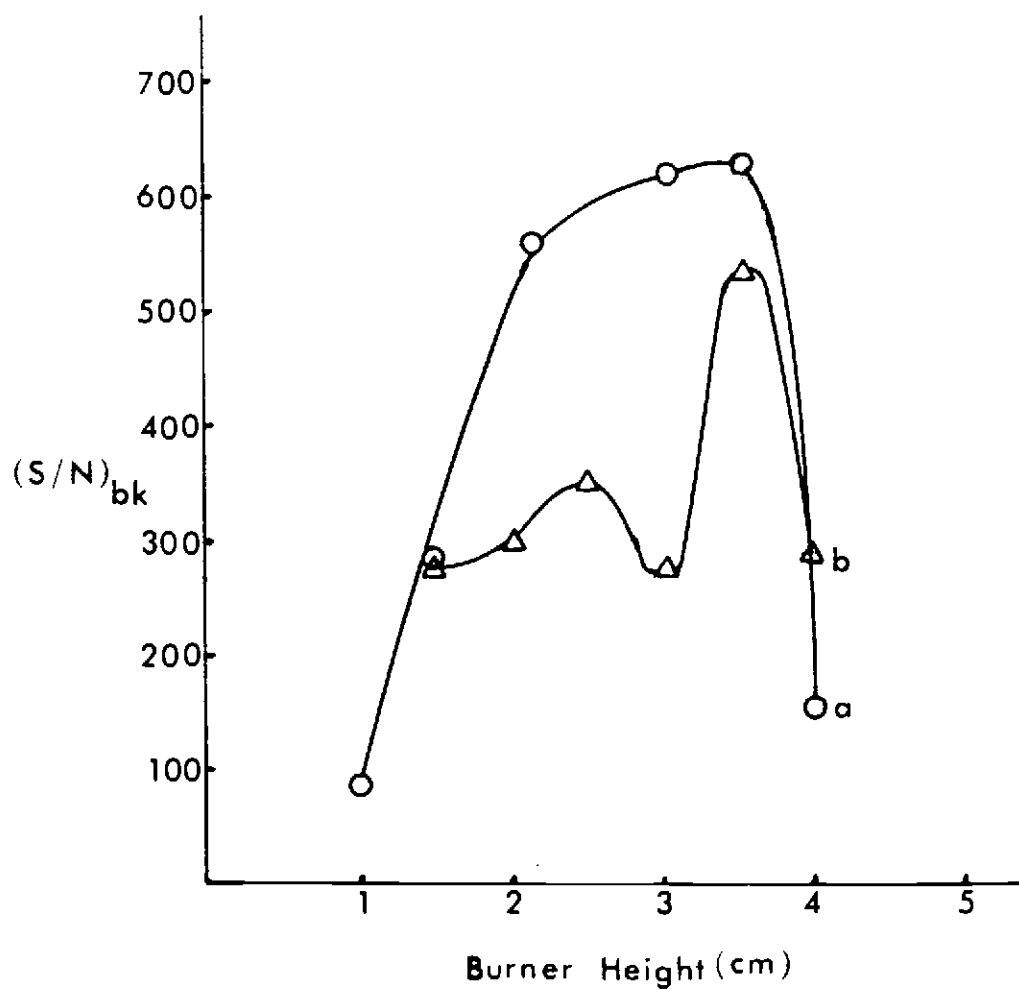


Figure 23. Dependence of $(S/N)_{bk}$ on burner height. a, H_2 flow rate = 0.8 L/min; b, H_2 flow rate = 2.8 L/min; other experimental conditions are the same as Figure 21.

heights (1.5 - 3 cm). This occurs because the signal is greater at lower burner heights but the noise (σ_F) is fairly independent of burner height. The S/N is better at the lower H_2 flow rate. The noise increases slightly with burner height at the higher H_2 flow rate and decreases slightly with burner height for the lower H_2 flow rate.

The plots of $(S/N)_{bk}$ versus burner height (Figure 23) show a broad optimum between 2 and 3.5 cm for the lower H_2 flow rate. The S/N optimum is at a larger burner height than the signal optimum because the background noise (σ_{bft}) decreases with increasing burner height as the background signal decreases. The magnitude of $(S/N)_{bk}$ is generally lower with the larger H_2 flow rate because of increased background signal and noise. For further studies, a burner height of 2.0 - 3.5 cm was used as this range provides the best S/N's.

Air flow rate

It was decided to optimize the air flow rate first since it controls the solution nebulization rate. The hydrogen flow rate was later varied to optimized the flame stoichiometry. Argon gas sheathing was employed in this and further studies to reduce the flame background emission signal and noise. Table IX show the effect of air flow rate on the solution flow rate. As expected the solution flow rate increases with increasing air flow rate.

The effect of the air flow rate on the S/N and $(S/N)_{bk}$ for Cu and Mg is show in Figure 24. Both S/N's are best at an air flow rate of 4.6 - 4.8 L/min for both elements and this air flow rate range was used for further studies. The blank noise (σ_{bft}) is relatively

Table IX. Effect of Air Flow Rate on Solution Flow Rate

Air Flow Rate (L/min)	Solution Flow Rate (mL/min)
1.9	0
3.2	1.3
4.0	3
4.8	4
5.7	6

independent of the air flow rate so that the increase in $(S/N)_{bk}$ with increasing flow rate is due primarily to an increase in the AF signal with flow rate. The decrease in $(S/N)_{bk}$ at the highest air flow rate is due to an increase in σ_{bft} .

H₂ flow rate

The H₂ flow rate is a critical variable to optimize. For a constant air flow rate, the H₂ flow rate affects the flame stoichiometry which in turn affects the atomization efficiency and background emission signal and noise. The dependence of the AF signal, S/N, and $(S/N)_{bk}$ on the H₂ flow rate over the 0.8 - 5.6 L/min range was studied for Ni, Co, Fe, Mn, Mg, Cu, Au, Pb, Zn, and Cd.

One goal of this study was to determine the optimum H₂ flow rate for each of the test elements. Another goal was to determine what set of elements could be measured under near optimum conditions in a multielement mode with the same H₂ flow rate.

For the elements Au, Zn, Cd, and Cu, the AF signals are relatively independent (within a factor of 2) of the H₂ flow rate. For the other six elements, plots of the AF signal vs H₂ flow rate

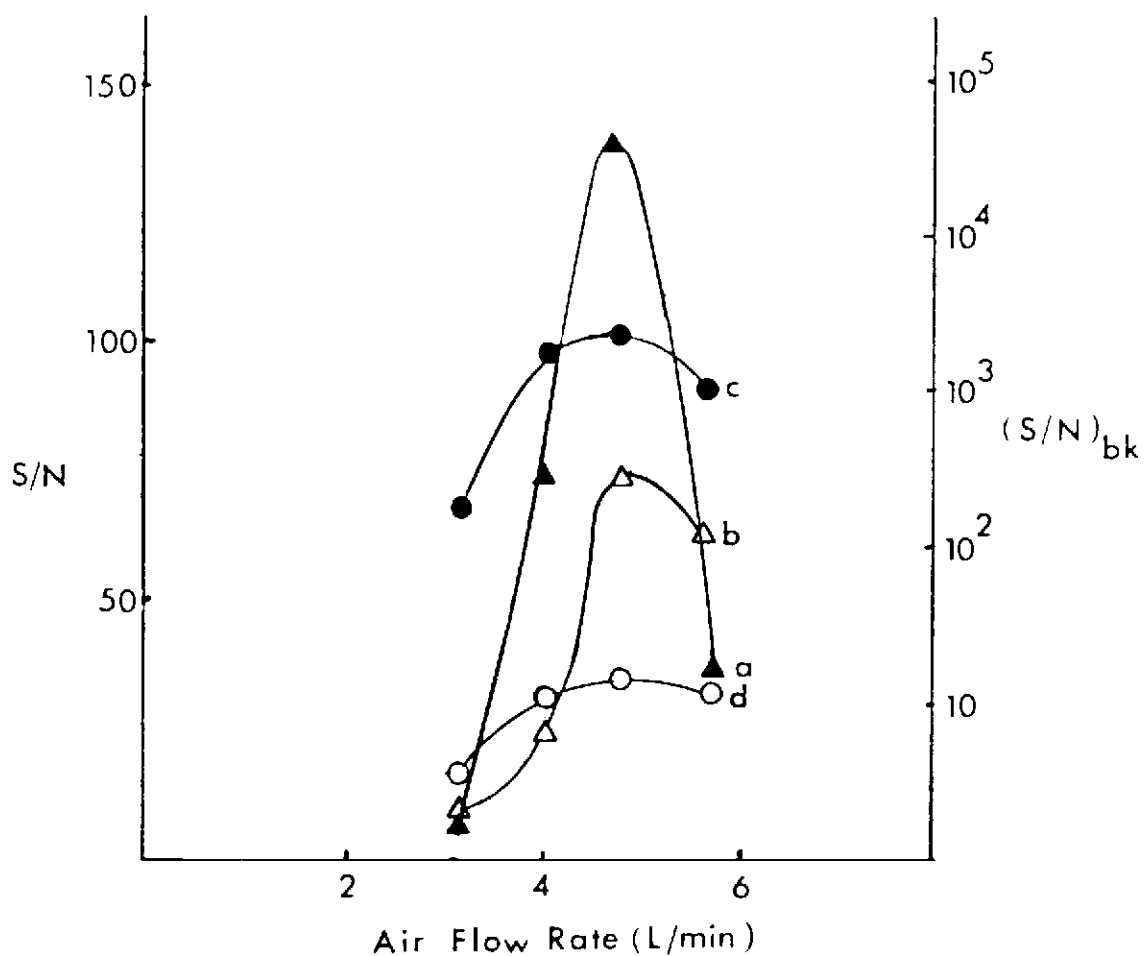


Figure 24. Dependence of S/N and $(S/N)_{bk}$ on air flow rate. a, S/N for Mg; b, S/N for Cu; c, $(S/N)_{bk}$ for Mg; d, $(S/N)_{bk}$ for Cu; $(i_{rms})_{HCL}$, 15 mA; H_2 flow rate, 3.7 L/min; Argon flow rate, 4.4 L/min; number of data points, 30; ℓ , 100; burner height, 2 cm; %DC, 12.5; R_f , 1 M Ω ; E_{PMT} , 1000 V; concentrations, 10 mg/L; number of runs, 1; wavelengths (in nm), Mg (285), Cu (325); t_p , 1 ms.

show an initial dramatic increase in the AF signal up to a point followed by a plateau region. For Co, Pb, and Ni, the AF signal is relatively constant above a H_2 flow rate of about 2.5 L/min, while for Mg, Mn, and Fe, the plateau region does occur until about 3.5 L/min. Apparently a fuel rich flame is required for more complete atomization of these latter 6 elements. Figure 25 show the dependence of the AF signal for Mg on H_2 flow rate which is typical of the elements that are more difficult to atomize.

For the elements that are easier to atomize (Au, Zn, Cd, and Cu), the $(S/N)_{bk}$ is independent of H_2 flow rate within a factor of two for Cd and Zn. For Au and Cu, the $(S/N)_{bk}$ and hence detection limits, are better by a factor of 2 - 3 at low H_2 flow rates (e.g., 1 L/min) because the background emission noise is less in a leaner flame.

In the case of elements that are more difficult to atomize (Ni, Co, Fe, Mn, Pb, and Mg), the blank noise (σ_{bft}) is relatively independent of the H_2 flow rate. Therefore the dependence of the $(S/N)_{bk}$ on H_2 flow rate tracks the dependence of the AF signal. The $(S/N)_{bk}$ becomes relatively independent of the H_2 flow rate above 2.5 - 3.5 L/min. This type of dependence is also illustrated in Figure 25 for Mg.

Based on the air flow rate, the oxygen flow rate is about 1 L/min. Thus a 2 L/min H_2 flow rate should be required for a stoichiometric flame. For the elements more difficult to atomize, the flame must significantly fuel rich for the best results.

Argon flow rate

Argon (Ar) gas was used as sheathing gas to reduce the

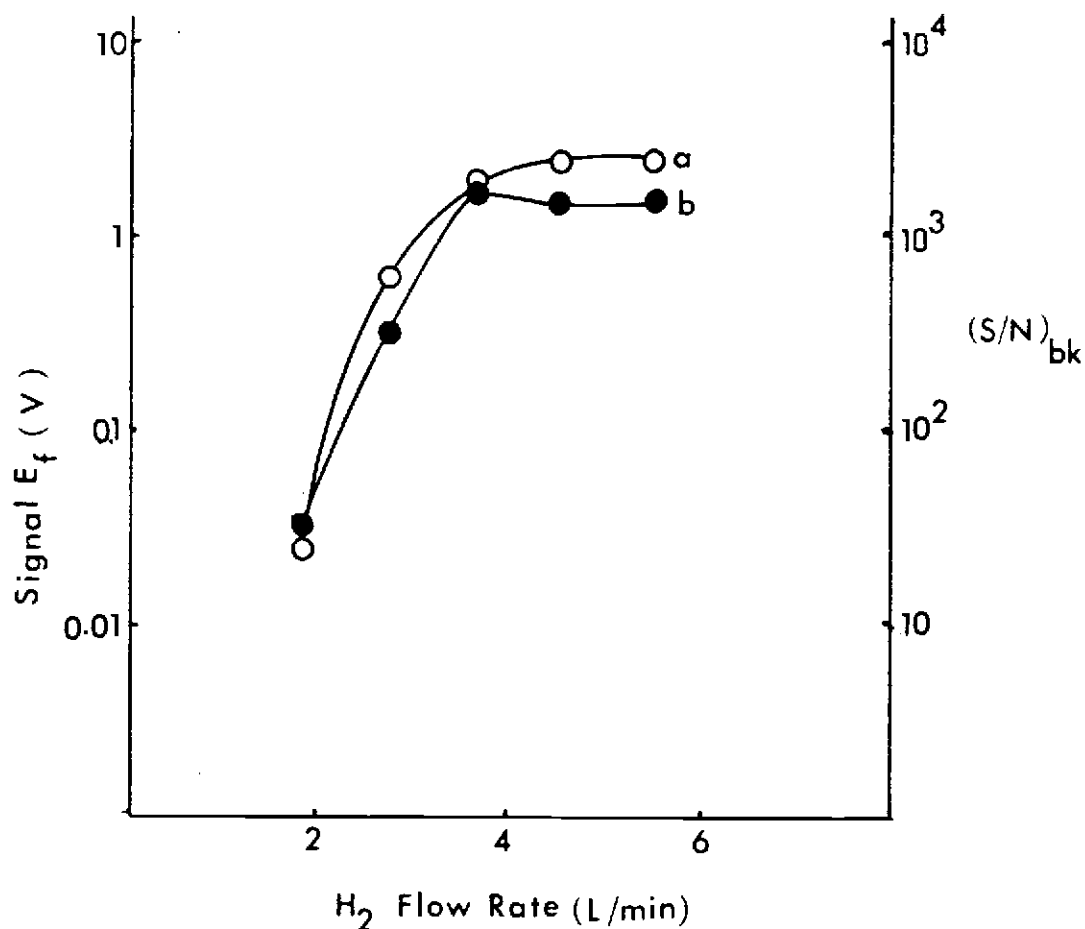


Figure 25. Dependence of AF signal and $(S/N)_{bk}$ on H_2 flow rate for Mg. a, peak fluorescence signal in V; b, $(S/N)_{bk} = E_f/\sigma_{bft}$; air flow rate, 4.8 L/min; Ar flow rate, 4.0 L/min; t_p , 1 ms, $(i_{rms})_{HCL}$, 8 mA; %DC, 12.5; number of data points, 20; l , 100; 5 mg/L Mg solution, R_f , 1 M Ω ; E_{PMT} , 1000 V; number of runs, 1; burner height, 2.8 cm; λ , 285 nm.

concentration of quenchers in the flame which decrease the AF signal and to reduce the flame background emission signal and noise by preventing entrainment of air. The AF signal and $(S/N)_{bk}$ for Cu, Mg, Cd, and Zn (0.5 mg/L) were determined with Ar flow rates of 0, 2.2, and 3.8 L/min with low and high H_2 flow rates and the results are shown in Table X. A 1 ms pulse width, 12.5% duty cycle, and 2.5 cm burner height were used.

Table X. Dependence of AF Signal, Blank Noise, and $(S/N)_{bk}$ on Ar Flow Rate^a

Ar Flow Rate (L/min)	Element	H_2 Flow Rate, 0.80 L/min			H_2 Flow Rate, 4.6 L/min		
		E_f (mV)	σ_{bft} (mV)	$(S/N)_{bk}$	E_f (mV)	σ_{bft} (mV)	$(S/N)_{bk}$
0	Cd	16	0.64	25	15	4.4	3.3
2.2	Cd	18	0.76	24	17	3.2	5.1
3.8	Cd	19	0.86	22	15	1.9	7.7
0	Cu	19	0.76	25	45	4.2	11
2.2	Cu	39	0.82	47	49	3.6	13
3.8	Cu	43	1.0	42	49	1.7	29
0	Mg	--	0.75	--	410	4.1	99
2.2	Mg	--	0.72	--	650	3.0	220
3.8	Mg	--	0.80	--	800	1.8	430
0	Zn	1.3	0.59	2.3	--	4.3	--
2.2	Zn	2.4	0.50	4.8	--	3.4	--
3.8	Zn	3.3	0.53	6.2	--	1.9	--

^aNumber of runs, 1; number of data points, 20; ℓ , 100; E_{PMT} , 1000 V; R_f , 1 M Ω ; wavelengths (in nm), Cd (229), Cu (325), Mg 285, Zn (214); rms HCL currents (in mA), Cd (14), Cu (14), Mg (14), Zn (13).

At the lower H_2 flow rate (0.8 L/min), the signal for Mg was insignificant as expected in a lean flame. The blank noise is primarily dark current noise so that the Ar flow rate has little effect

on σ_{bft} . For Cd, the Af signal and S/N are independent of Ar flow rate. For Zn and Cu, the AF signal and $(S/N)_{\text{bk}}$ increase about a factor of 2.5 as the flow rate is increased from 0 to 3.8 L/min.

With a higher H_2 flow rate (4.6 L/min), the blank noise increases a factor of 2 - 8 depending on the element due to the more luminous nature of the flame. The blank noise is primarily due to flame background emission noise. The Zn AF signal was too small to measure reliably at the concentration tested. The use of a 3.8 L/min Ar flow rate relative to no sheathing improves the $(S/N)_{\text{bk}}$ for Cd and Cu by a factor of 2 and 3, respectively, due to a reduction in background emission noise. For Mg, the $(S/N)_{\text{bk}}$ is enhanced by about a factor of 4 due to both an increase in signal and reduction of noise. The increase in the Mg AF signal may be due in part to a richer flame in the absence of air entrainment.

For all further studies, Ar sheathing at 3.8 L/min or slightly higher was employed. Although the effect of sheathing is negligible for some elements, improvements of a factor of 2 - 4 in $(S/N)_{\text{bk}}$ and detection limits are realized for some elements.

Dependence of AF signals on HCL peak current

A previous study in this section indicated that the HCL signal increases in a near linear fashion with respect to HCL peak current except near peak currents of 1 A. At higher HCL peak currents, the source line profile may be significantly broadened or exhibit self-absorption effects. Under these conditions, the AF signal is not expected to be proportional to the HCL signal since the fraction of

the source radiation absorbed decreases with significant line broadening.

To provide information to optimize the HCL peak current, the dependence of the AF signal on peak HCL current was measured at one concentration for each of the test elements with a 1 ms pulse width. The HCL peak current was increased by decreasing the %DC (typically from 12.5 to 1.25%) with a constant HCL rms current. The results are shown in Figures 26 and 27. The conditions for these measurements and important characteristics of these plots are presented in Table XI.

Table XI. Conditions and Characteristics for Plots of the i_{AF} Calibration Sensitivity versus HCL Peak Current^a

Element	Conc. (mg/L)	λ (nm)	H ₂ Flow Rate (L/min)	(i_{rms}) _{HCL} (mA)	Slope ^b	Critical (i_p) _{HCL} ^c (mA)
Au	5	267	1.5	12	0.35	(2)
Cd	2.5	224	0.8	8	0.75	150
Co	5	241	3.7	12	1.0	(1)
Cu	5	325	0.8	13	1.1	400
Fe	11	248	3.7	15	1.0	(1)
Mg	2	285	3.7	8	0.25	(2)
Mn	10	279	5	16	1.0	(1)
Ni	2	232	3.7	15	0.90	(1)
Pb	50	283	0.8	6	0.45	(2)
Zn	2.5	214	2.8	13	0.25	(2)

^aair flow rate, 4.8 L/min; flame height, 2.8 cm; E_{PMT} , 1000 V; R_f , 1 M Ω ; # of runs, 1; # of data points, 20; t_p , 1 ms; ℓ , 100.

^blog-log slope for linear curves or for lower portion of non-linear curves.

^capproximate peak HCL current where log-log slope is less than 0.5; (1) and (2) indicate that the slope is greater or less than 0.5, respectively, over whole HCL peak current range studied.

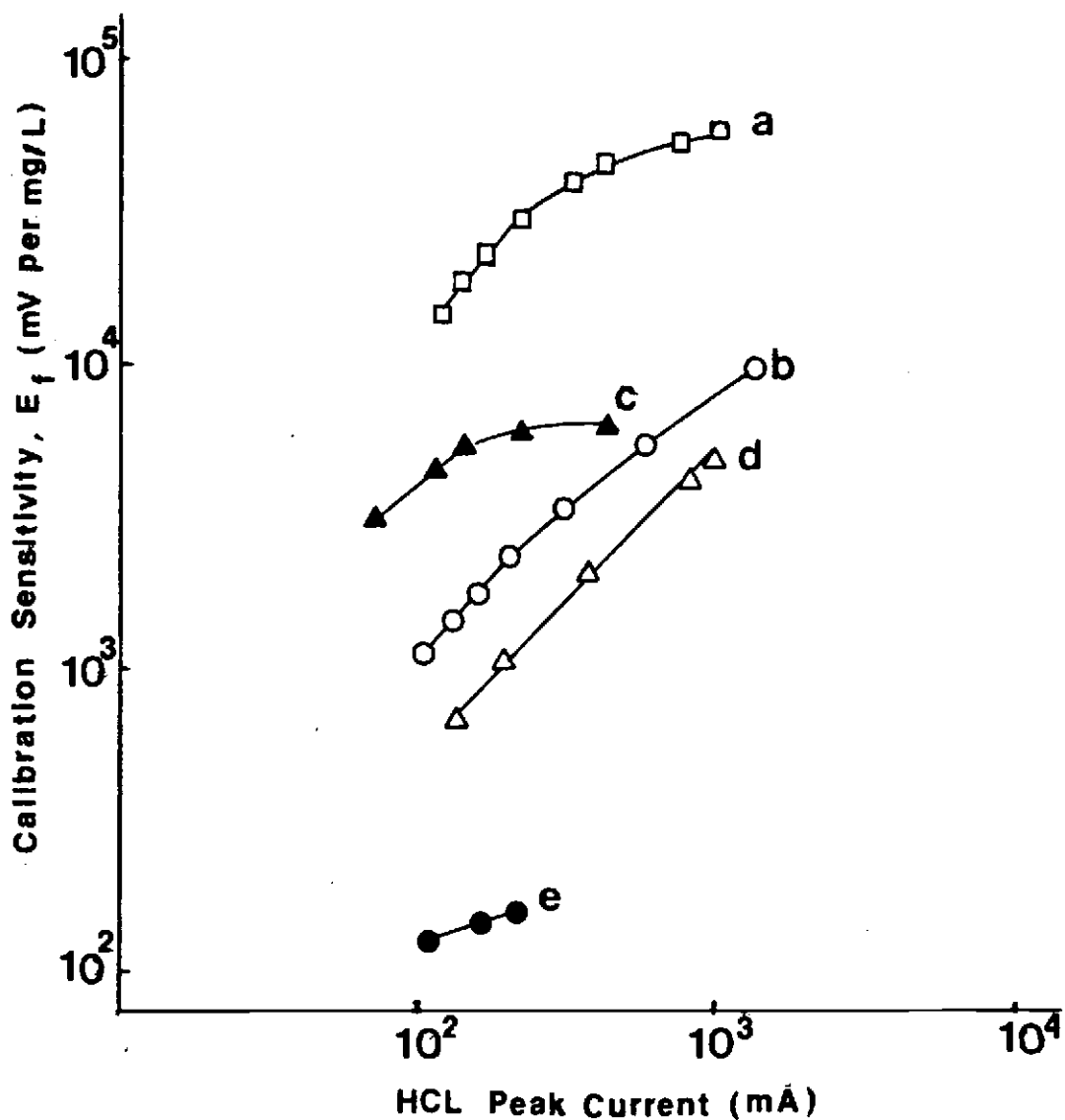


Figure 26. Dependence of calibration sensitivity on HCL peak current for Au, Cd, Co, Cu, Fe. a, Cu; b, Co; c, Cd; d, Fe; e, Au; see Table XI for experimental conditions.

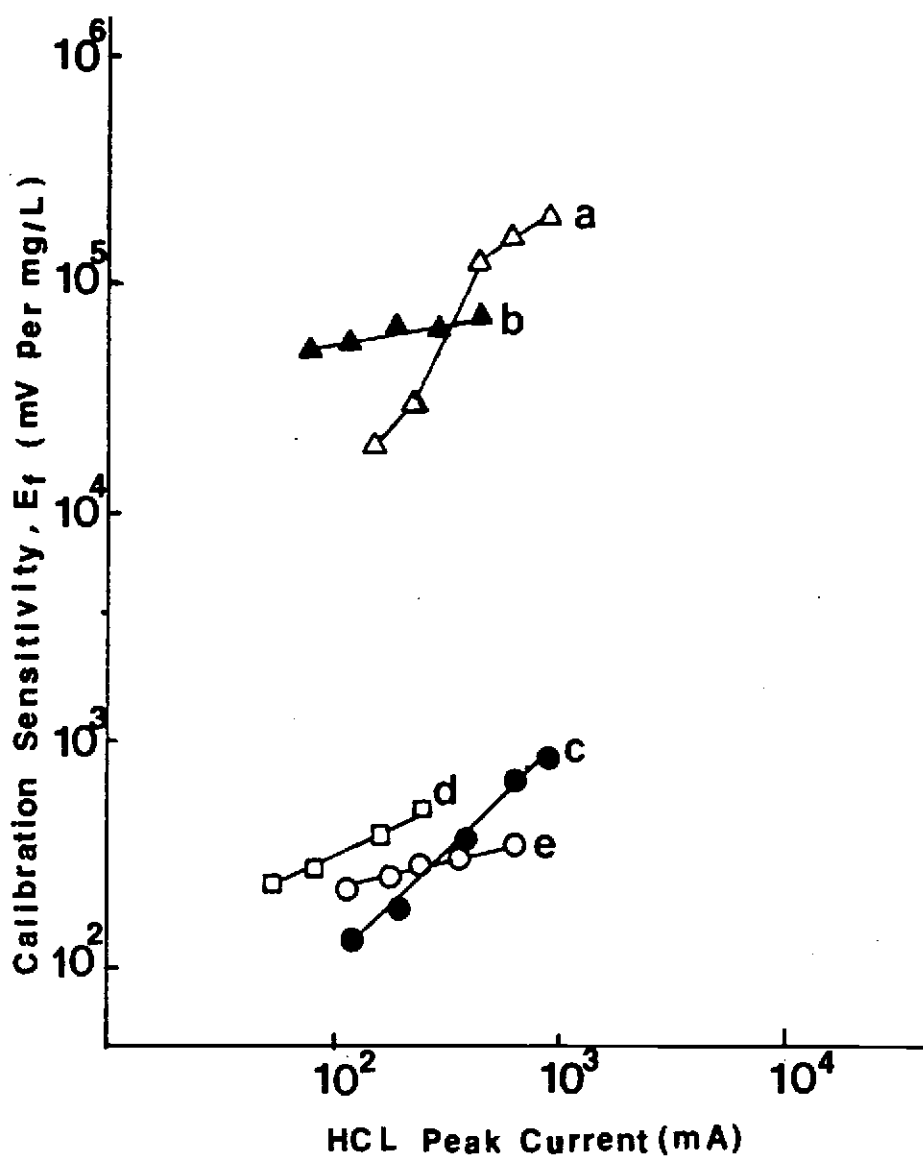


Figure 27. Dependence of calibration sensitivity on HCL peak current. a, Mn; b, Mg; c, Ni; d, Pb; e, Zn; see Table XI for experimental conditions.

Note that plots of $(S/N)_{bk}$ versus $(ip)_{HCL}$ show the same dependence as the curves in Figure 26 and 27 since the background noise is constant with a constant HCL pulse width. For a given pulse width, the highest allowable HCL peak current provides the largest peak AF signal and hence $(S/N)_{bk}$.

To optimize the $(S/N)_{bk}$, and hence the detection limit which is inversely proportional to $(S/N)_{bk}$, one must also consider the total time for a data collection run which is the product of the lap time and number of laps ($t_L \ell$). To keep total lap measurement constant, then ratio $\%DC/t_p$ must be kept constant (equation 2). Thus with a larger pulse width, the $\%DC$ must be corresponding larger. For a constant HCL rms current, an increased $\%DC$ requires that the peak HCL current be reduced (equation 3). Under these conditions (constant measurement time and HCL rms current) the smallest pulse width and largest possible HCL peak current do not necessarily provide the best $(S/N)_{bk}$.

The $(S/N)_{bk}$ is calculated from equation 16 as E_f/σ_{bft} . For white noise, σ_{bft} is proportional to $(t_p)^{-1/2}$ because the averaging time increases with pulse width (i.e. $\sigma_{bft} \propto \Delta f^{1/2} \propto t^{-1/2}$). The peak signal E_f decreases with increasing t_p (for a given HCL rms current and lap time) but the exact relationship depends on the element.

Consider the case where t_p is decreased from 10 to 1 ms with a corresponding decrease in $\%DC$ from 12.5 to 1.25% and factor of ten increase in peak HCL current. The background noise increases by a factor of $(10)^{1/2}$. If there is a linear relationship between the AF peak signal (E_f) and peak HCL current, the peak AF signal is ten times

larger at a 1 ms pulse width providing an improvement in $(S/N)_{bk}$ of $(10)^{1/2}$. However, if the peak AF signal is only larger by a factor of $(10)^{1/2}$ or less at the smaller t_p , the $(S/N)_{bk}$ is the same or worse than with a 10 ms pulse width.

The data in Figures 26 and 27 can be used to pick the optimum HCL peak current and pulse width for a given lap time. For elements (Co, Fe, Mn, Ni) for which the log-log slope is greater than $1/2$ (see Table XI) over the whole current range studied, the optimum current is the highest value and a small pulse width and large %DC should be used. For Au, Mg, Pb, and Zn, the slope is less than $1/2$ over the whole current range studied and the lowest peak current and large t_p and %DC provides the best $(S/N)_{bk}$. With Cd and Cu the critical peak current specified in Table XI should be used because above this HCL peak current, the log-log slope is less than $1/2$ and $(S/N)_{bk}$ would be less.

Cadmium is one of elements for which there is little gain in AF signal at higher peak HCL currents (see Figure 26). The decrease in $(S/N)_{bk}$ for Cd with a fixed lap time of 80 ms is illustrated in Figure 28. Here the %DC is varied from 12.5 to 1.25% to increase the peak HCL current. The pulse width is decreased from 10 to 1 ms to keep the lap time constant. Above a peak HCL current of 330 mA, the loss in $(S/N)_{bk}$ is obvious. Above this current, the peak AF increases little but the background noise increases significantly due to a smaller pulse width.

Figure 28 shows the results for the same type of study with Co. With Co the log-log slope is 1.0 over the range of peak HCL current studied (Figure 26) so there is little change in $(S/N)_{bk}$ with HCL peak

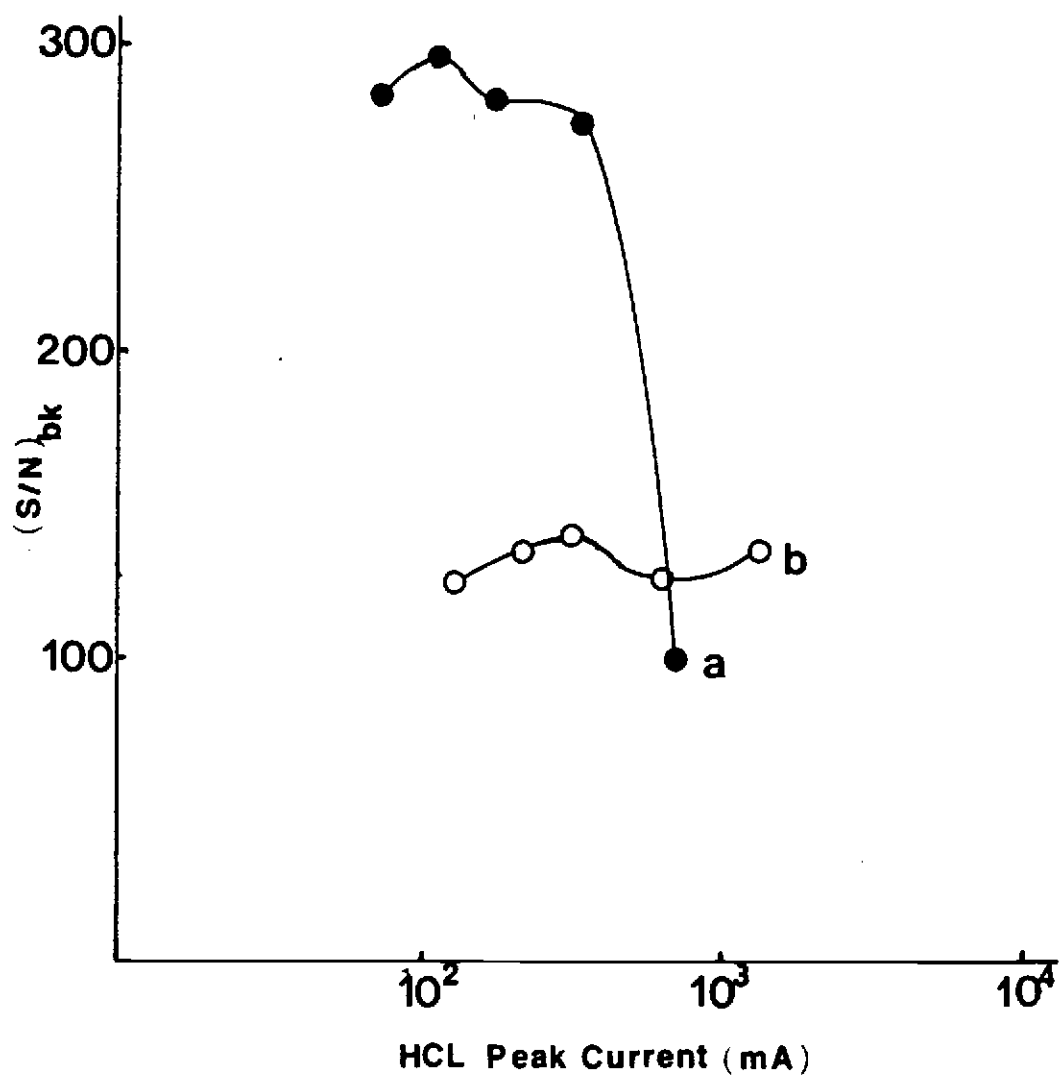


Figure 28. Dependence of $(S/N)_{bk}$ on HCL peak current for Cd and Co. a, Cd; b, Co; experimental conditions same as in Table XI except with a fixed lap time and $(i_{rms})_{HCL}$ of 15 mA for Co.

current.

At higher analyte concentrations, analyte fluorescence shot or flicker noise may be limiting. Under signal shot noise limiting conditions, the best S/N for a given pulse width is obtained at the highest HCL peak current. With the restriction of a fixed total measurement time, the S/N is proportional to $(E_f t_p)^{1/2}$. For many elements, the relative signal shot noise is less with a larger t_p and smaller $(i_p)_{\text{HCL}}$ because E_f is proportional to t_p^{-x} where x is smaller than 1.

Single Element Measurements

Detection limits

The information from the optimization studies was used to establish the conditions to measure the detection limits for the ten test elements in the single element mode (i.e. one slit open and one lamp pulsed at a time). With a lap time of 80 ms or total measurement time of 8 s for 100 laps, the %DC and pulse width were varied to find the values yielding the best detection limits. The optimum conditions and detection limits achieved are reported in Table XII.

For Au, Cd, Mg, Pb, and Zn the optimum pulse width is larger (i.e. 10 ms) and the optimum HCL peak current is smaller (i.e. 50 - 144 mA) than for the other elements. As previously noted for these elements, higher HCL peak currents provide little increase in the AF signal but a larger pulse width reduces the blank noise and improves the detection limit.

At the detection limit dark current noise is limiting or signifi-

Table XII. Single Element AF Detection Limits^a

Element	Wavelength (nm)	DL ($\mu\text{g/L}$)	t_p (ms)	%DC	$(i_{\text{rms}})_{\text{HCL}}$ (ms)	i_p (mA)	H ₂ Flow Rate (L/min)	k^b	σ_{bft}^c	σ_d^d
Au	267	218	10	12.5	12	96	1.5	1.4	1.5	0.95
Cd	224	4.6	10	12.5	15	127	0.8	51	1.2	0.92
Co	241	26	2	2.5	15	614	3.7	4.1	5.3	3.0
Cu	325	3	2	2.5	15	614	0.8	480	7.5	2.9
Fe	248	50	2	2.5	16	652	4.6	21	5.3	4.0
Mg	285	0.8	10	12.5	16	136	3.7	2000	7.8	0.76
Mn	279	7	3.2	4	16	414	5.0	410	14	2.3
Ni	232	36	2	2.5	18	736	3.7	16	3.0	3.0
Pb	283	1030	10	12.5	6	52	0.8	0.47	2.4	0.84
Zn	214	21	10	12.5	13	111	2.3	12	1.3	1.0

^anumber of data points, 20; ℓ , 100; R_f , 1 M Ω ; E_{PMT} , 1000 V; air flow rate, 4.8 L/min; Ar flow rate 3.8 - 4.2 L/min; # of runs, 1; flame height, 2.8 cm.

^bcalibration slope, peak photocathodic current signal $\times 10^{19}$ A/ $\mu\text{g/L}$.

^cphotocathodic rms background noise $\times 10^{17}$ A.

^dcathodic rms dark noise $\times 10^{17}$ A.

cant ($\sigma_{\text{bft}} \cong \sigma_{\text{dt}}$) for Au, Cd, Co, Fe, Ni, and Zn. For the other elements flame background emission noise limits the detection limit.

Calibration and precision curves

Five of the test elements, Cd, Co, Cu, Mg, and Zn were studied in more detail. All of these elements except Co were used by Salin (1) and in this research for multielement AF measurements. Repetitive measurements were made for each element in the single element mode over a large concentration range with a 1 ms pulse width. From this data the peak fluorescence signal (E_f), σ_{ft} , σ_{bft} , σ_{dt} , and σ_F were calculated. The results are presented in the form of calibration curves of E_f versus analyte concentration and of precision curves of the RSD in E_f (σ_F/E_f) versus analyte concentration. The total analyte emission noise (σ_{et}) was measured at high concentrations with the lamp off to determine if σ_{et} is a significant noise component. The shot noise in the analyte fluorescence signal was also calculated and compared to σ_{ft} to determine if fundamental shot noise is limiting at any concentrations.

All the calibration curves (Figure 29) exhibit typical behavior for AF measurements. The AF signal is linear with respect to analyte concentration at low analyte concentration. At moderate concentration negative deviation occurs. The AF signal is approximately 5% below the signal predicted by extrapolation of the linear portion of the calibration curve at concentrations of 5, 50, 50, 25, and 25 mg/L for Cd, Co, Cu, Mg, and Zn, respectively. At high analyte concentrations, a plateau region is observed (Co) or the AF signal passes through a

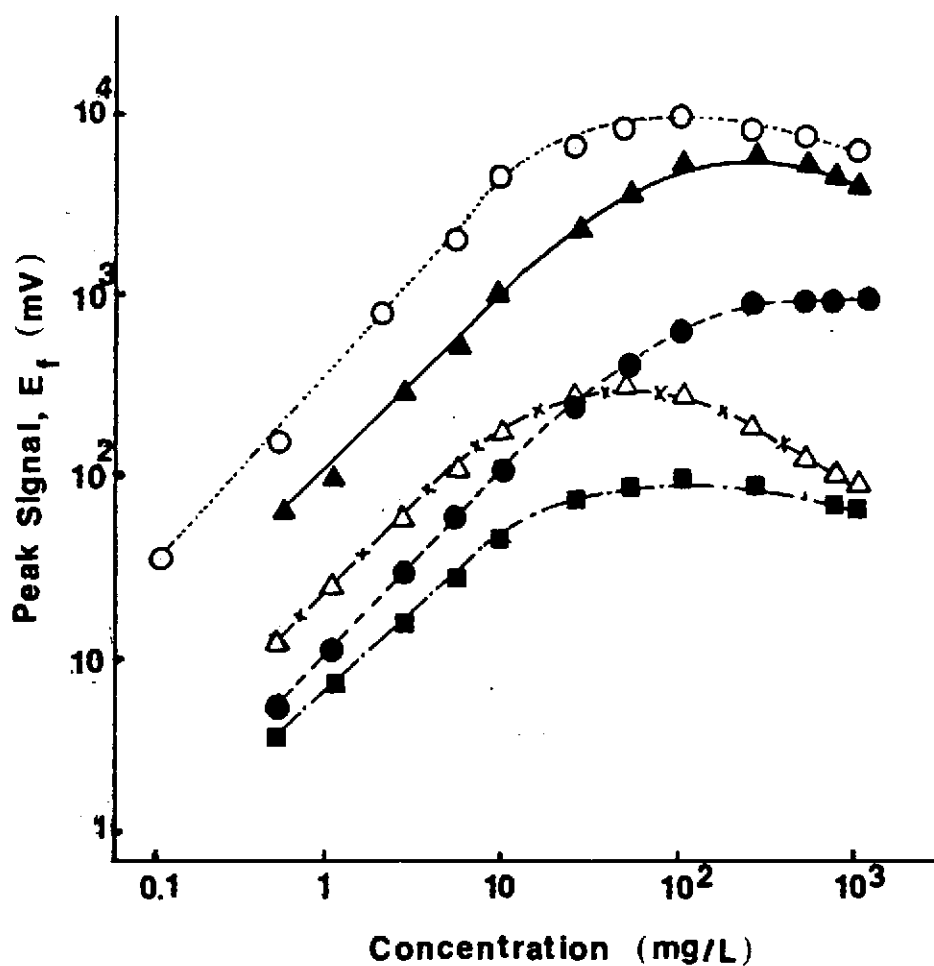


Figure 29. Single element calibration curves. Δ , Cd; \bullet , Co; \blacktriangle , Cu; \circ , Mg; \blacksquare , Zn; conditions same as in Table XII except:

Element	%DC	$(i_{rms})_{HCL}$ (mA)	$(i_p)_{HCL}$ (mA)
Cd	4	8	211
Co	2	12	576
Cu	2	12	606
Mg	2	12	622
Zn	2	13	625

maximum and decreases at the highest concentrations (Cd, Cu, Mg, Zn).

The non-linear behavior is caused by several factors. Firstly, there is an inherent non-linear relationship between the fluorescence signal and concentration at high concentrations because the fraction of the source radiation absorbed at higher concentrations is not proportional to analyte concentration. Secondly, this effect is accentuated by source line broadening. The atomic absorption coefficient varies over the source profile. Thirdly, the prefilter or inner effect reduces the source intensity that reaches the viewed central part of the flame. Fourthly, the post filter effect or self-absorption results in attenuation of the fluorescence radiation. Fluorescence photons from the central viewed part of the flame are reabsorbed by analyte atoms in the outer part of the flame.

The degree of non-linearity caused by these affects increases with analyte concentration because the absorbance increases with analyte concentration. The prefilter effect causes the decrease in the AF signal at the highest concentrations. The concentration where the maximum in the calibration curve is reached varies with the element because the absorption coefficients and source profile widths of the elements are different.

The precision curves (Figure 30) all exhibit the same type of general behavior as noted for AF measurements of Cu by Bower and Ingle (84). At low concentrations, the precision improves as the concentration increases because the signal is increasing faster than the noise. The noise is relatively constant because the blank noise is dominant or significant and independent of the analyte concentration.

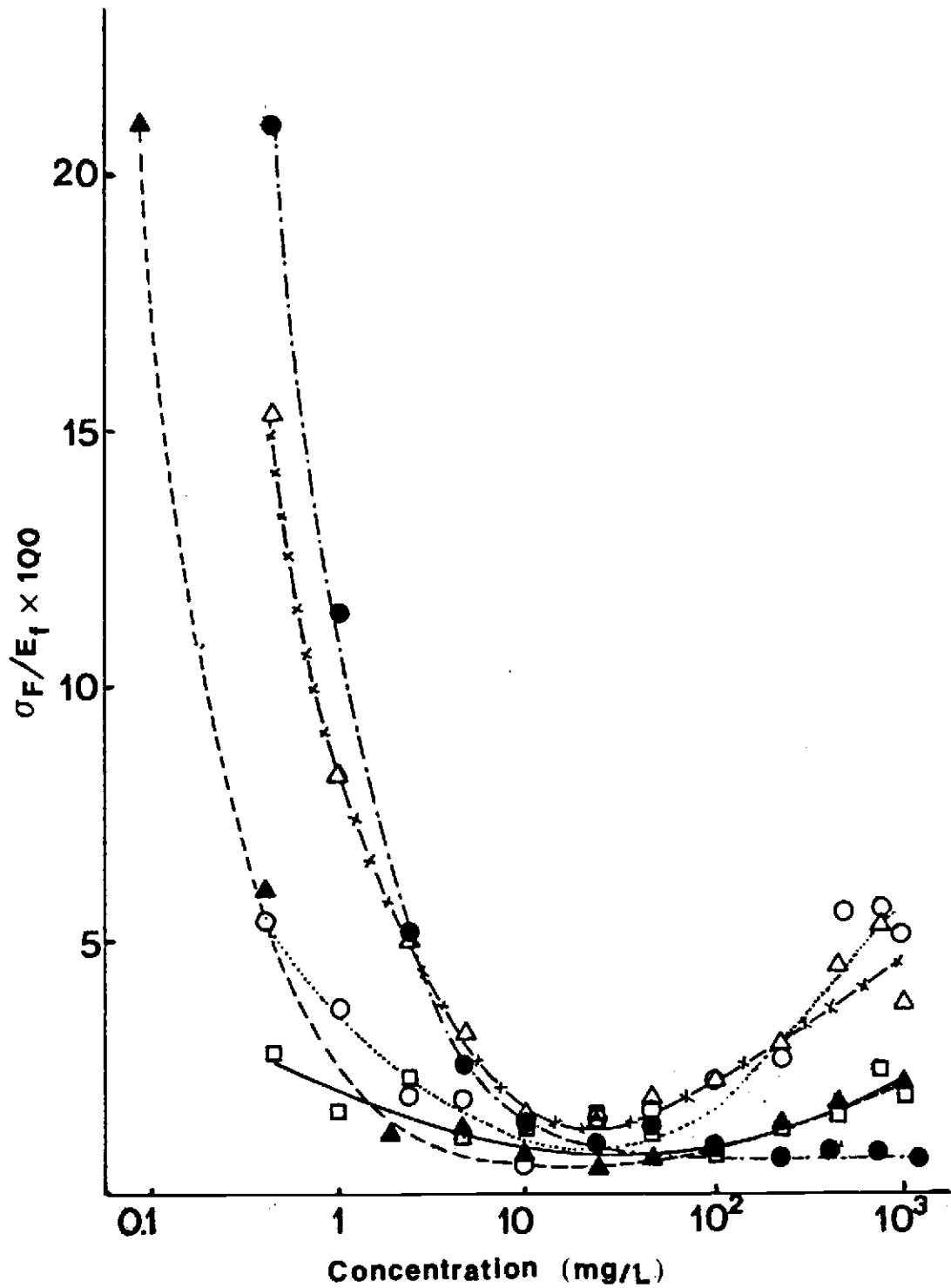


Figure 30. Single element precision curves. \circ , Cd; \bullet , Co; \square , Cu; \blacktriangle , Mg; \triangle , Zn; conditions same as Figure 29.

In the moderate concentration range, the precision is relative constant (1 - 2% RSD). In this region, analyte fluorescence shot or flicker noise is dominant. At the highest concentrations (100 - 1000 mg/L) the precision decreases for all elements except Co. According to Bower and Ingle (84), this decrease in precision can be due to an increase in the analyte fluorescence flicker factor or in analyte emission noise.

Other measurements and calculations revealed more about the limiting noise sources. For Cd, Cu, and Zn the blank noise is primarily dark current or amplifier-readout noise ($\sigma_{dt} \cong \sigma_{bft}$). For Co and Mg, background emission is the limiting component of the blank noise ($\sigma_{bft} \cong 2 \sigma_{dt}$ for Co and $\sigma_{bft} \cong 10 \sigma_{dt}$ for Mg).

No significant analyte emission noise ($\sigma_{bft} > 0.5 \sigma_{et}$) at the highest concentrations for Cd, Co, or Zn. For Cu and Mg, analyte emission is significant ($\sigma_{et} \cong 2 \sigma_{bft}$) at the highest concentration. However the analyte emission noise is insignificant compared to the analyte fluorescence noise ($\sigma_{ft} \gg \sigma_{et}$). Thus analyte emission noise does not account for the loss in precision at high concentrations observed for four of the elements.

Theoretical shot noise calculations were used to determine if fluorescence shot is significant in some cases. Since analyte fluorescence flicker and shot noise are proportional to the first power and square root of the fluorescence signal, respectively, signal shot noise is more likely to be significant for elements with a less intense fluorescence signal (smaller calibration sensitivity) and at lower concentrations. The calibration sensitivities for Mg and Cu are

the highest (see Figure 29). For Mg, analyte fluorescence shot noise is not limiting at any concentration and analyte fluorescence flicker noise is dominant ($\sigma_F > 3 \sigma_{bft}$) at and above 5 mg/L. With Cu, analyte fluorescence flicker noise is dominant at and above 5 mg/L but significant between 0.5 and 2.5 mg/L.

The lower calibration sensitivities for Co, Zn, and Cd make it more likely that signal shot noise is dominant. Above 2.5 mg/L for Co, blank noise becomes insignificant and signal shot noise is limiting to the highest concentrations. The RSD becomes constant above 250 mg/L because the AF signal is relatively independent of concentration. For Cd and Zn, blank noise becomes insignificant above 1 and 2.5 mg/L, respectively, and signal shot noise is limiting or significant ($(\sigma_f)_s > 0.5 \sigma_F$) up to 50 and 100 mg/L, respectively. Above these latter concentrations, analyte fluorescence flicker noise becomes dominant.

The difference in the limiting noise at high concentrations for Co compared to Cd or Zn can be explained in terms of the calibration curves. For Zn and especially Cd, the negative deviation in the calibration is worse at lower concentrations than for Co. Also the calibration curve goes through a maximum for Zn and Cd but not for Co. These calibration curves effects are caused by larger pre- and post absorption effects for these elements. The fluctuations in these absorption effects enhance the relative analyte fluorescence flicker noise as discussed by Bower and Ingle (84). Thus the absolute noise remains constant or even increases even though the AF signal is relatively constant or decreasing. The analyte fluorescence flicker fac-

tor (i.e. the ratio of the absolute analyte flicker noise to the AF signal) increases at higher concentrations. Thus the decrease in precision at high concentrations observed for Cd, and to a less extent for Cu, Zn, and Mg, is due to greater relative analyte fluorescence flicker noise at concentrations where inner filter and self-absorption effects are larger.

Multielement Measurements

Four elements, Cd, Cu, Mg, and Zn, were selected for multielement measurements. These four elements were picked from the 10 elements studied under single element conditions. The wavelengths for these four elements span the entire range of the exit slit mask (Zn at the lowest wavelength and Cu at the highest wavelength). The results of the single element studies showed that there is not a set of optimum conditions shared by all four elements. Thus it is necessary to choose and chase a compromise set of conditions for multielement measurements.

Optimization studies

For the multielement measurements, four slits were opened. Compared to single element measurements with one slit open, this change is expected to increase the total background emission signal and noise observed and possibly caused excess light problems (i.e. fluorescence of one element excited and observed when another element's HCL is pulsed on).

It was decided to use a 10 ms pulse width since this is optimum with an 8 s total measurement time for all four elements except Cu.

An extensive optimization study was carried out in which the AF signal and $(S/N)_{bk}$ for each element was determined in the multielement mode at H_2 flow rates of 0.8, 1.9, 3.7, 4.6, and 5.6 L/min with Ar flow rates of 0, 2.2, and 3.8 L/min at each H_2 flow rate. This measurement sequence was repeated at flame heights of 1, 2, 2.5, and 3.3 cm.

The results of these studies are essentially the same as obtained in the optimization studies for single element measurements. The highest $(S/N)_{bk}$'s and best detection limits are obtained with a flame height between 2 and 3 cm and an Ar flow rate of about 4 L/min. For Zn, Cu, and Cd, a low H_2 flow rate is optimal while a high H_2 flow rate is best for Mg.

An excess light problem was noted only for the Zn HCL. This lamp has a substantial Cu impurity. When the Zn HCL is pulsed on, Cu aspirating into the flame, fluorescence from Cu passes through the Cu slit and causes a falsely high Zn signal (approximately 50% for equivalent concentrations).

To eliminate this problem, an interference filter with central wavelength of 225.0 nm was placed in front of Zn HCL to eliminate Cu line from the Zn HCL. Unfortunately the Zn AF signal was severely attenuated too because this filter has a throughput of about 10%. Therefore, a filter was not used and an interference calibration curve was made for the AF signal that a given concentration of Cu would produce in the Zn channel. This interference calibration curve was used for the appropriate correction of the Zn AF data.

Calibration curves and detection limits

Because the H_2 flow rate is the most critical variable to optimize for

the four test elements, detection limits and calibration curves were determined at the H₂ flow rates of 0.8 and 3.7 L/min. The calibration curves are shown in Figure 31 and the detection limit, noise, and calibration slope data are presented in Table XIII.

Table XIII. TMMS Multielement AF Detection Limits^a

Element	0.8 L/min H ₂ Flow Rate			3.7 L/min H ₂ Flow Rate			DL ^d (μg/L)	DL ^e (μg/L)
	DL (μg/L)	k ^b	σ _{bft} ^c	DL (μg/L)	k ^b	σ _{bft} ^c		
Cd	10	4.3	2.2	51	3.7	9.6	90	4.6
Cu	4	17	3.8	9	21	8.9	50	3
Mg	150	0.37	3.2	1	160	10	100	0.8
Zn	110	0.54	2.9	245	0.53	6.5	200	21

^aE_{PMT}, 1000 V; R_f, 1 MΩ; t_d, 0.5 ms; t_p, 10 ms; ℓ, 100; %DC, 12.5; Ar flow rate, 4 L/min; number of runs, 2; number of data points, 20; burner height 2.5 cm; air flow rate, 4.8 L/min; (i_p)_{HCL}'s (mA), Cd (119), Cu (127), Mg (127), Zn (110).

^bcalibration slope, peak photocathodic current signal x 10¹⁸ A/μg/L.

^cphotocathodic rms background noise x 10¹⁷ A.

^ddetection limits obtained by Salin under TMMS multielement AF mode (1).

^edetection limits obtained under TMMS single element AF mode (Table XII).

For Cu, Zn, and Cd, the calibration curves and slopes are very similar at both H₂ flow rates and only the calibration curves for the lower H₂ flow rate is shown in Figure 31. The multielement detection limits for Cu, Zn, and Cd at the lower H₂ flow rate are only a factor

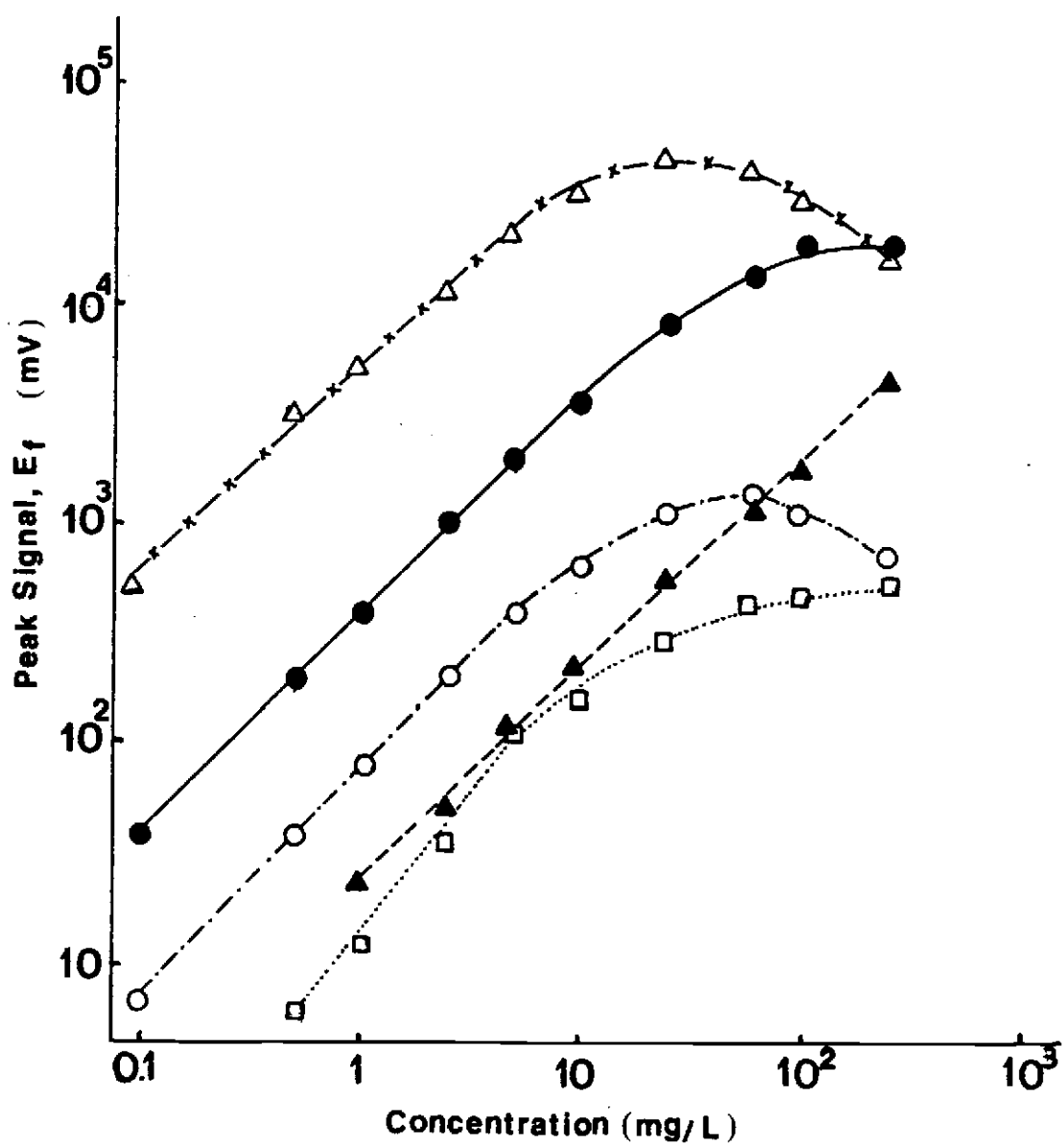


Figure 31. TMS multi-element calibration curves. \circ , Cd; \bullet , Cu; \blacktriangle , Mg; \square , Zn; \triangle , Mg (H_2 flow rate 3.7 L/min); conditions same as in Table XIII, except t_p , 1 ms.

of 2 worse than the optimized single element detection limits. The worse detection limits are caused by the larger blank noise observed when more slits are open.

With the higher H_2 flow rate, the detection limits for Cu, Zn, and Cd are a factor of 2 - 5 worse than at the lower H_2 flow rate. This is caused primarily by the increased flame background emission noise in the richer flame.

The two calibration plots for Mg in Figure 31 show the dramatic effect of H_2 flow on the atomization efficiency for Mg. The detection limit for Mg at the higher H_2 flow rate is essentially the same as obtained under single element conditions but is a factor of 400 worse at the lower H_2 flow rate. The calibration curve for Mg in the richer flame starts to bend at a concentration of about 20 mg/L, but there is no evidence of bending in calibration curve in the leaner flame up to 250. This indicates that self absorption and inner filter effects are substantially less important in the leaner flame. Only a small fraction of the Mg is in the atomic form that can cause these effects.

Table XIII also shows that the multielement detection limits achieved in this study are significantly better than obtained by Salin (1) for Cd, Cu, and Zn at the low H_2 flow rate and for Mg at the higher H_2 flow rate. The multielement detection limits achieved in this work for Cd and Zn are also a factor of 2 and 5 better, respectively, than those reported by Palermo and Crouch (73) for multielement non-dispersive time multiplex AF measurements.

Air/acetylene flame results

The multielement determination on Cd, Cu, Mg, and Zn was briefly

studied with an air/acetylene flame as the atomizer. A different flame has different atomization, quenching and background emission characteristics.

The effect of acetylene flow rate and flame height were briefly studied to determine approximate optimum conditions. Argon sheathing was found to reduce the flame background emission noise by about a factor of 2. The calibration slope, blank and dark current noise and detection limit data are reported in Table XIV. The detection limits and calibration slopes obtained with the air/H₂ flame are also given for comparison purposes.

Table XIV. TMMS Multielement AF Air/C₂H₂ Flame Detection Limits^a

Element	(i _p) _{HCL} (mA)	DL (mg/L)	k ^b	σ _{bft} ^c	σ _d ^d	DL ^e (mg/L)	k ^e
Cd	119	0.8	3.7	1.4	1.5	0.05	3.7
Cu	128	0.1	26	1.7	1.8	0.009	21
Mg	128	0.02	158	1.4	2.0	0.001	160
Zn	110	4	0.77	1.7	1.7	0.25	0.53

^aC₂H₂ flow rate, 0.8 L/min; air flow rate, 4.6 L/min; Ar flow rate, 4.3 L/min; R_f, 1 MΩ; PMT, 1000 V; t_p, 10 ms; τ, 0.1 ms; t_d, 0.5 ms; %DC, 12.5; burner height, 2.5 cm; ℓ, 100.

^bcalibration slope, peak photocathodic current x 10¹⁵ A/mg/L.

^cphotocathodic rms background noise x 10¹⁵ A.

^dcathodic rms dark current noise x 10¹⁷ A.

^eDL and calibration slope (peak photocathodic current x 10¹⁵ A/mg/L) for multielement measurements in H₂/air flame with 3.7 L/min H₂ flow rate (from Table XIII).

The detection limits are about 15 times higher with the air/C₂H₂ flame compared to those obtained with the fuel rich air/H₂ flame. This loss of detectability is the result of much higher background emission signal and noise with the hydrocarbon flame, primarily due to excitation of carbon containing molecules (e.g., CN and CO). The background emission noise is about 15 times greater with C₂H₂ rather than H₂ as the fuel and dark current noise is insignificant. The calibration slopes for a given element are approximately the same in both flames. This indicates that the atomization and quenching characteristics are similar for both flames.

Nondispersive AF Multielement Measurements

Multielement AF measurements of Cu, Mg, and Mn in an air/H₂ flame were briefly studied in the nondispersive mode. As described in the Experimental Section, interference filters, instead of the monochromators, are used to isolate the AF signals (see Figure 8 and Table I). The filter with a wavelength of maximum transmittance of 285.2 nm was used for Mg and Mn with resonance lines of 285.2 nm and 279.5 nm, respectively. The filter with a wavelength maximum of 322.5 nm was employed to isolate the Cu resonance line at 324.7 nm.

Optimization

Most experimental conditions were set to the optimum values determined from single element and multielement optimization studies in the TMMS mode. In particular, the H₂ flow rate must be high (e.g. 3-4 L/min) for Mn and Mg to ensure good atomization. The distances between the flame and entrance lens and between the filters and

entrance lens were optimized. The optimized distance between the flame and the entrance lens is 3 in., which is equal to focal length of entrance lens, and the distance between filters and lens is 0.25 in. This position of the entrance lens collimates the fluorescence radiation and ensures that both filters are filled with the collected radiation.

Calibration curves and detection limits

The calibration curves for all three elements under multielement measurements conditions with a 12.5% duty cycle are shown in Figure 32 (curves a-c). All the curves exhibit severe nonlinearity at high concentrations as previously noted with dispersive AF measurements. For Mn only, the AF signal passes through a maximum and decreases at the highest concentrations.

The detection limit, noise, and calibration slope data are presented in Table XV. All conditions are the same as used to obtain the calibration curves except that the PMT voltage is 800 V instead of 400 V. The detection limit, blank noise and calibration slope data obtained with the same flame under dispersive conditions are also given for comparison.

The data indicate that the detection limits for Cu and Mg are approximately a factor of 4 and 16 worse, respectively, in the TMMF mode compared to the TMMS mode. This occurs because the blank noise is about 40 times greater in the nondispersive mode. The bandpass of the filters is about 2.5 times greater than the spectral bandpass of the monochromator. Thus the background emission signal, and hence the background emission noise is much greater when filters are used. The

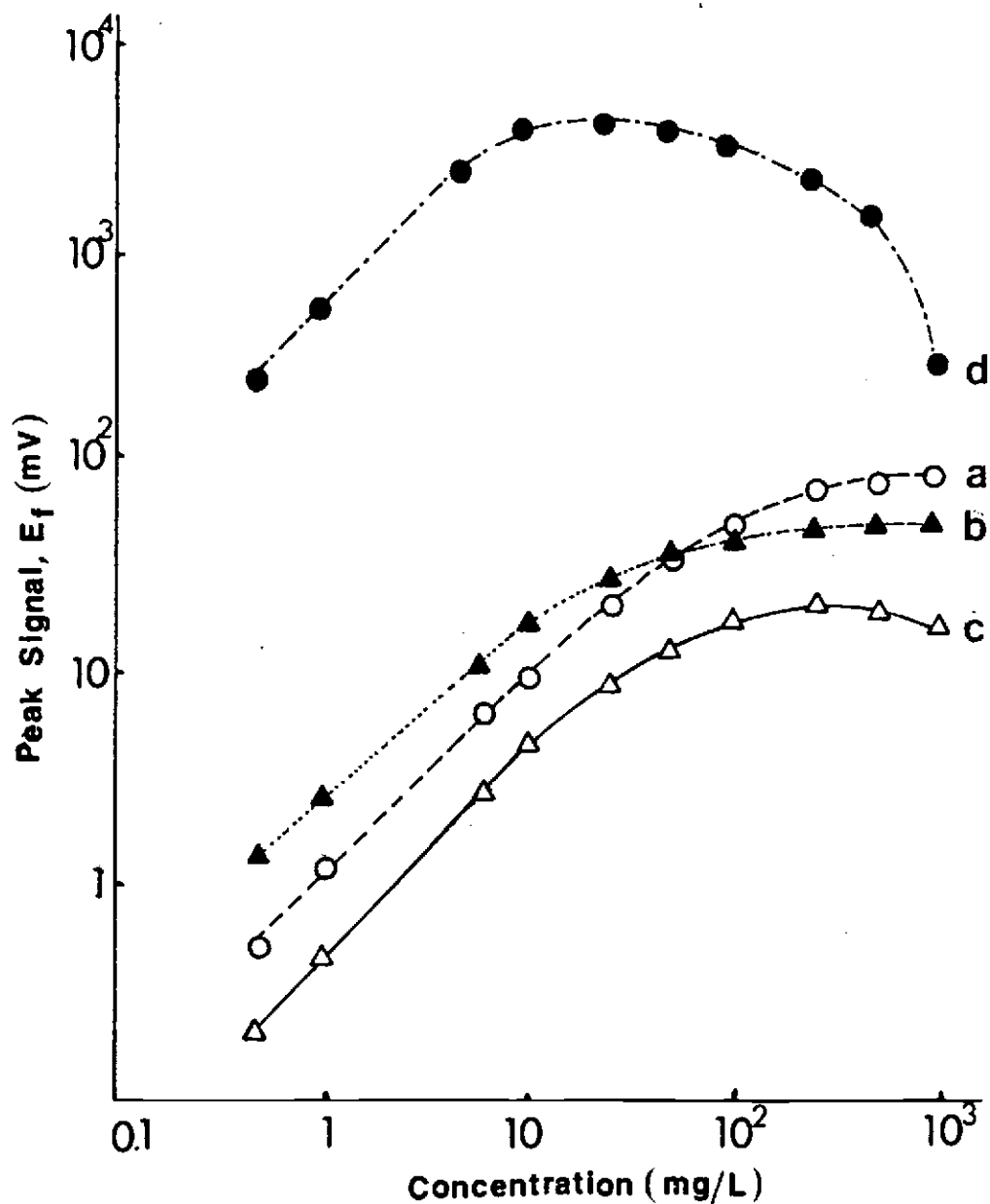


Figure 32. TMMF AF multi-element calibration curves. a, Cu; b, Mg; c, Mn; d, Cu (%DC = 2.5); E_{pMT} , 400 V for curves a, b, and c and 800 V for curve d; R_f , 1 M Ω ; %DC, 12.5; burner height, 2.5 cm; air flow rate, 4.7 L/min; Argon flow rate, 4.3 L/min; H_2 flow rate, 3.8 L/min; ℓ , 100; number of data points, 20; peak HCL currents, Cu (137 mA at 12.5 %DC and 614 mA at 2.5 %DC), Mg (137 mA), Mn (135 mA); t_p , 10 ms (2 ms for Cu with 2.5 %DC); number of runs, 1.

Table XV. TMMF Multielement AF Detection Limits^a

Element	DL ($\mu\text{g/L}$)	k^b	σ_{bft}^c	σ_d^d	DL ^f	k^f	σ_{bft}^f
Cu	33	2.4	4.0	4.2	9	0.21	0.089
Mg	16	4.8	3.7	5.7	1	1.6	0.10
Mn	76	0.99	3.8	3.3	-	-	-
Cu ^e	12	39	25	54	-	-	-

^aconditions same as specified in caption of Figure 32 except E_{PMT} , 800 V.

^bcalibration slope, peak photocathodic current $\times 10^{16}$ A/ $\mu\text{g/L}$.

^cphotocathodic rms background noise $\times 10^{15}$ A.

^dcathodic rms dark current noise $\times 10^{17}$ A.

^emeasurements with t_p , 2 ms; %DC, 2.5; and $(i_p)_{\text{HCL}}$, 614 mA.

^fDL, calibration slope (peak photocathodic current $\times 10^{16}$ A/ $\mu\text{g/L}$), and blank noise ($\times 10^{15}$ A) for multielement TMS measurements in H_2 /air flame with 3.7 L/min H_2 flow rate (from Table XIII).

calibration slopes with the filters are about a factor of 10 and 3 greater for Cu and Mg, respectively. Thus the throughput or optical efficiency of the filter based system is greater than that of the monochromator based configuration. However, the increase in optical efficiency does not compensate for the greater increase in the blank noise. The enhancement in optical efficiency is less for Mg than Cu because the Mg filter has a smaller peak transmittance.

The precision curve for Cu is shown in Figure 33 (curve a). The RSD decreases with increasing concentration up to about 5 mg/L. Above

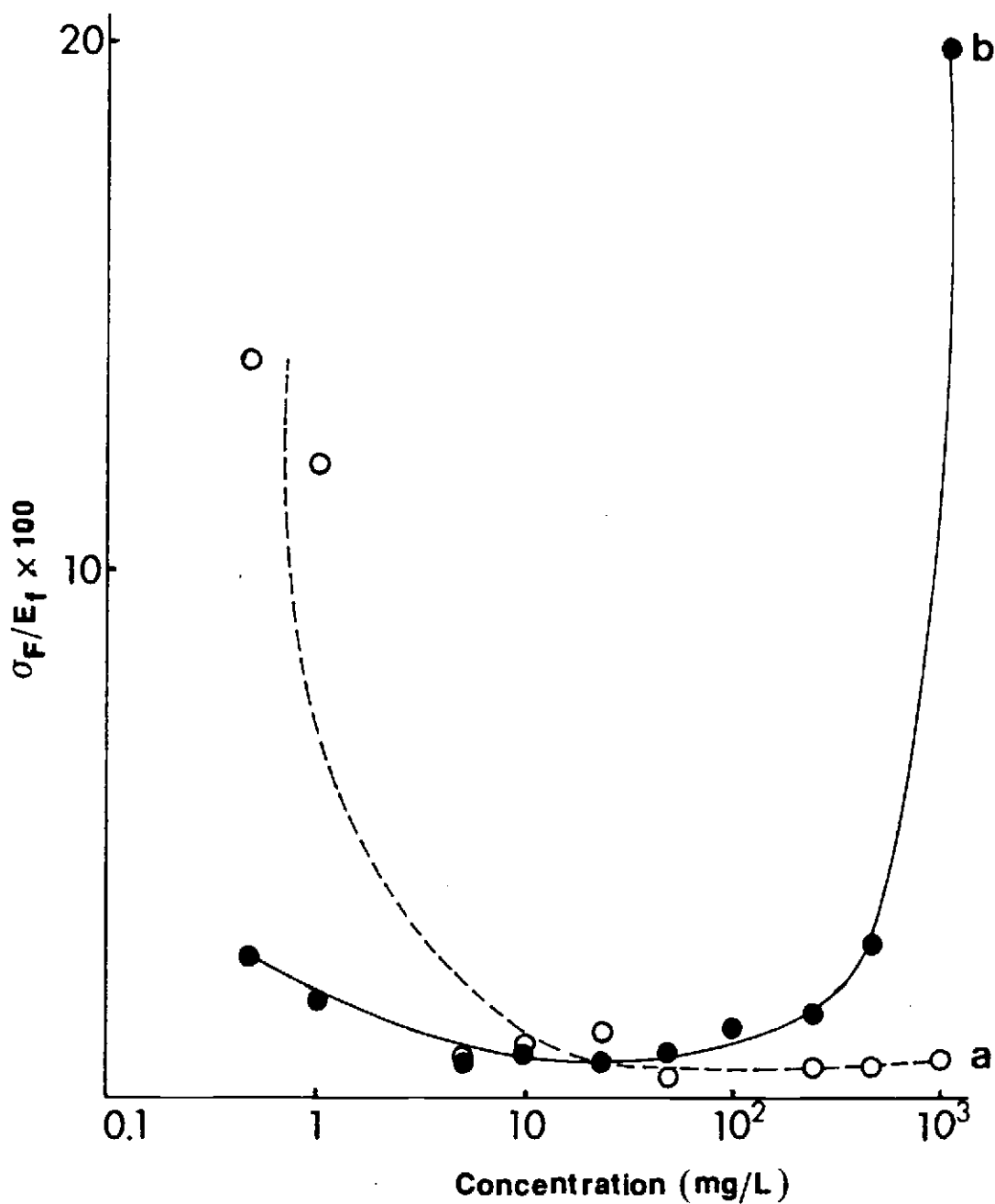


Figure 33. TMMF precision curves for Cu. a, Cu (%DC = 12.5); b, Cu (%DC = 2.5); other experimental conditions are the same as specified for Table XV.

this concentration, blank noise is not limiting and the RSD is independent of the concentration and typically 0.5 - 1.0%. Similar results were obtained for Mg and Mn although the concentration at which the RSD became independent of concentration is higher (10 and 25 mg/L, respectively). Theoretical shot noise calculations indicate that analyte fluorescence shot noise is not limiting at any concentration for any of the elements and suggest that analyte fluorescence flicker noise is limiting at high concentrations.

Separate measurements were made to determine the source of the blank noise. Dark current noise is insignificant compared to flame background emission noise. The noise with the flame on and the blank aspirating is about twice as great with the HCL's on as opposed to off. This increased noise can be attributed to noise in the signal due to reflected or scattered light. The scattering signal is expected to be more significant when using a filter instead of a monochromator because the large bandpass of the filters may pass both scattered resonance and nonresonance line radiation from the HCL's.

A separate experiment was carried out in which the only Cu HCL was pulsed at a peak current about five times higher than in the previous multielement TMMF experiment. The results are reported in the last row of Table XV and as curves d and b in Figures 32 and 33, respectively. The detection limit is improved about a factor of 3 by using a higher excitation intensity which produces a calibration slope about 16 times larger. As shown in Figure 32, the calibration curve for Cu changes significantly with HCL peak current. With a higher peak current (curve d), the maximum AF signal occurs at about 25 mg/L.

Above this concentration, the AF signal decreases significantly and the AF signals at 0.5 and 1000 mg/L are approximately equal. This would indicate that line broadening or self-reversal affects in the HCL emission line profile are very significant at higher currents which enhances nonlinearity due to prefilter effects.

The precision curves for Cu at the two HCL peak currents are also quite different as show in Figure 33. At moderate concentrations, the RSD's are comparable. However, with the higher HCL peak current (curve b), the RSD is lower at low concentrations but larger at higher concentrations. The precision is better at low concentrations because the Cu AF signal is larger relative to the blank noise. The decrease in precision at high concentrations relates to the negative slope of the calibration curve at high concentrations as previously noted in TMS single element studies. Fluctuations in the large pre- or post filter absorption cause the relative analyte fluorescence noise to increase.

CONCLUSIONS

Numerous modifications and computerization of time multiplex multiple slit spectrometer has resulted in a powerful spectrometer for multielement AF measurements. Incorporation of a microcomputer with appropriate software greatly enhances the versatility and ease of use of the spectrometer. The user through the computer terminal can select the magnitude of numerous experimental variables. This allows the operator to examine different experimental conditions during optimization studies in a relatively very short period of time. Automated data acquisition, reporting of data and reporting of the results of complex calculations significantly reduces the post-analysis time. Useful calculation options include blank signal subtraction, calculation of S/N's, detection limits, analyte fluorescence shot noise, and the concentration of the analyte in an unknown.

Modification of the HCL pulsing circuitry along with computer control allow critical parameters such as HCL peak current and width to be easily varied through software control. Use of feedback control for the HCL current circuitry was one of the more significant changes because it improved the stability of the HCL output signal by an order of magnitude. The system also measures and reports the actual HCL operating current so that the operator can confirm that the desired conditions were selected.

Control of the mode of data acquisition and of data acquisition parameters has proved to be very useful. Data can be digitized with a V/F converter and counter or with an ADC. The ADC mode was found to

be optimal for pulse widths of 4 ms or less because the readout resolution is better than in the V/F mode. Selection of the delay time after initiation of the HCL pulse before data acquisition is critical in S/N optimization. User selection of the number of pulses for which data are acquired and the number of repetitive runs is particularly useful for S/N optimization.

Several hardware changes improved the performance of the instrument. The new Meker burner head allows the use of an Ar gas sheathed flame. Argon gas sheathing can increase the AF signal by reducing the concentration of quenchers in the flame and reduce the flame background emission signal and noise. For many elements studied, the Ar sheathing improved detection limits by a factor of 2 - 4. An automated sampler allows computer controlled introduction of a blank or analyte solution. This option is particularly useful for optimization studies.

The improved design of the multielement AF instrument and ability to optimize lamp parameters such as pulse width and peak current provides excellent single element detection limits that are 3 - 7 better for 9 elements and 50 times better for Mg than achieved with the TMMS instrument designed by Salin (1). Of the many variables optimized, the H₂ flow rate and HCL peak current are the most critical. A fuel rich air/C₂H₂ flame is required for the best detection limits for more difficult to atomize elements like Ni, Fe, Mn, Pb, and Mg. For elements such as Au, Mg, Pb, Cd, and Zn the AF signal increases little above HCL peak currents of about 200 mA. With these elements and the restraint of a fixed total measurement time, the best detection limits

are achieved with smaller HCL peak currents and large pulse widths (larger duty cycles) because background noise is reduced to a greater extent than the peak AF signal is reduced.

The dependence of precision on analyte concentration for five elements was shown to follow the pattern described by Bower and Ingle (84) for Cu. In particular the precision decreases at high concentrations because the relative analyte flicker noise increases at high concentrations where the AF signal decreases due to large pre- and post-absorption effects. Other studies with Cu showed that the precision at high concentrations is worse with a higher HCL peak current because non-linearity effects are worse due to increased source emission profile broadening and self-reversal. For elements such as Co, Zn, and Cd, analyte fluorescence shot noise is limiting over a large range of concentrations. Thus the S/N could be improved with a higher intensity source.

Multielement AF measurements of Cd, Cu, Mg, and Zn demonstrated the compromises involved in multielement measurements. However, in general the multielement detection limits were improved significantly over those achieved by Salin (1). With a lean air/H₂ flame, the multielement detection limits are about a factor of 2 worse for Cd, Cu, and Zn and 400 times worse for Mg than for optimized single element measurements. In a fuel rich flame, the detection limits are a factor of 2 - 5 worse for Cd, Cu, and Zn but are equivalent for Mg compared to optimized single element detection limits. A fuel rich flame is needed to atomize efficiently Mg but this increases the background emission noise.

With the instrument designed, the same HCL pulse width must be used for all elements in the multielement mode. A smaller pulse width and higher HCL peak current would have improved the Cu detection limit. Clearly optimal multielement detection limits for a given group of elements can be achieved only if the single element detection limits for elements in the group are achieved with similar H_2 flow rates and HCL pulse widths.

The air/ C_2H_2 flame is usually a better atomization source than the air/ H_2 flame. However, for AF measurements, the detection limits were shown to be about 15 times worse with the hydrocarbon flame due to increased background emission noise.

Nondispersive AF measurements of Cu, Mg, and Mn indicated that the optical throughput of the AF signal is higher. However, the larger bandpass of the filters increases the flame background emission and scattering signals and noise observed. This results in a substantial decrease in detectability compared to dispersive AF measurements.

Today no commercial single or multielement flame AF spectrometer is available. This situation is unlikely to change even with the new information provided in this thesis. However, an AF instrument of the TMS design could be useful for multielement analysis of a few easy to atomize elements in a routine analysis situation. In general AF detection limits for some elements are better than achieved with AA or plasma emission spectrometry only if a laser is used for the excitation source. However one commercial (Baird) AF spectrometer is now on the market which uses an ICP as the atomization source. It is based on a nondispersive time multiplex mode of operation using a

separate pulsed HCL and emission filter for each element. The information from this thesis on optimization of the HCL peak current, pulse width, and duty cycle and the data acquisition parameters could be used to optimize the performance of this commercial instrument.

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APPENDICES

APPENDIX I

Complete Control Board

In Figure A1, the circled numbers refer to connections made to fingers 1 through 22 on the PC board. These fingers are connected to a female edge connector to which wires are connected to and from other devices as indicated in Table AI. The configuration and coding for the lap switches are shown in Figure A2 and Table AII. An H refers to high (+5 V) and GND to ground. The coding for the readout switches is detailed in Table AIII.

Figure A1. Control board schematic.

Component	Identification No. or Value	Description
IC1, IC9	SN7404	Hex inverter
IC2	SN74122	Monostable multivibrator (delay monostable)
IC3	SN7400	Quadruple 2-input positive NAND gate (delay and lap gate)
IC4, IC7	SN7493	4-bit binary counter (lap counter)
IC5	SN74221	Dual monostable multivibrator
IC6	SN74161	Synchronous 4-bit binary counter (counter demultiplexer)
IC8	SN7420	Dual 4-input positive NAND gate
IC10	SN7442	BCD-to-decimal decoder (lamp demultiplexer)
IC11	SN7442	BCD-to-decimal decoder (signal demultiplexer)
S1, S2, S3, S4,	8 keys	SPST switch
C1	100 pF	Capacitor
C2	10 μ F	Capacitor
C3	0.022 μ F	Capacitor
C4	0.22 mF	Capacitor
R1, R4	2.2 k Ω	Resistor
R2	10 k Ω	Resistor
R3	100 k Ω	Resistor

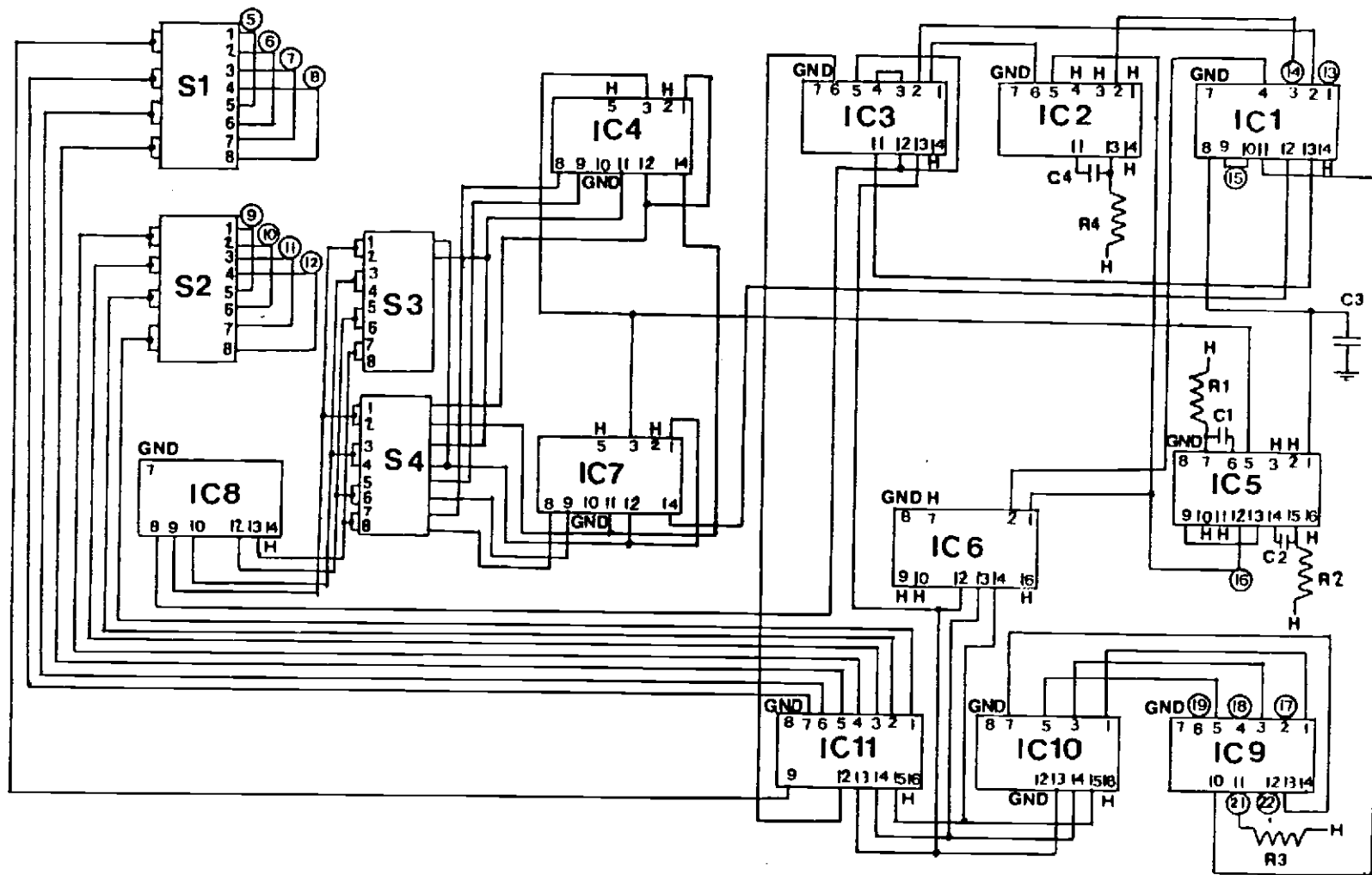


Figure A1.

Table AI. Control Board Pin Description

Pin	Description
1.	GND (system and logic ground)
2.	N.C. (no connection)
3.	N.C.
4.	N.C.
5.	To pin 6 of counter 4 (down channel)
6.	To pin 6 of counter 3 (down channel)
7.	To pin 5 of counter 4 (up channel)
8.	To pin 5 of counter 3 (up channel)
9.	To pin 6 of counter 2 (down channel)
10.	To pin 6 of counter 1 (down channel)
11.	To pin 5 of counter 2 (up channel)
12.	To pin 5 of counter 1 (up channel)
13.	Input signal from V/F converter
14.	CLOCK, from clock PC board pin 10
15.	CLEAR, to all counter PC boards pin 4
16.	RESET, to clock reset, pin 21
17.	To pin 19 of control transistor PC board
18.	To pin 22 of control transistor PC board
19.	To pin 21 of control transistor PC board
20.	To pin 20 of control transistor PC board
21.	START, from variable timer PC board, pin 16, or manual start
22.	+5 V

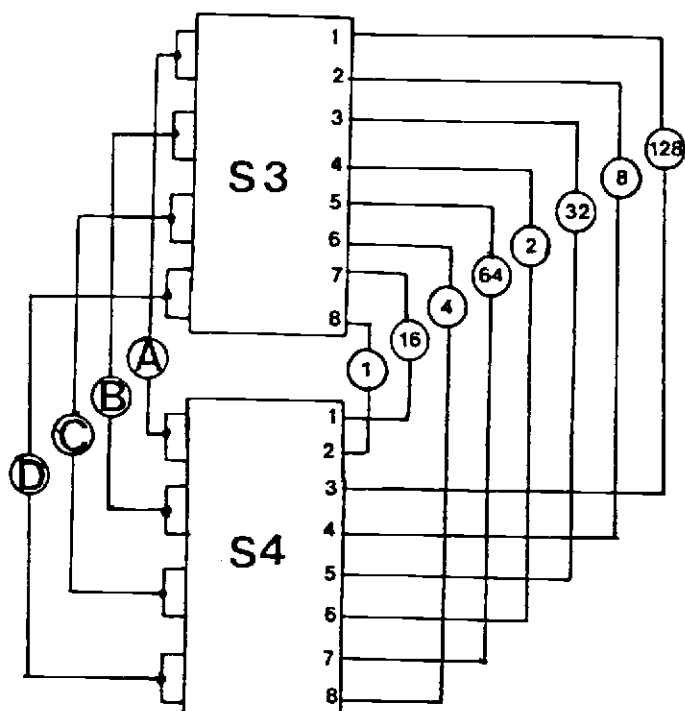


Figure A2. Configuration for lap switch. A, B, C, and D are inputs to NAND gate (IC8), and circled numbers are decimal representations of the binary outputs of the cascaded binary lap counters (IC4 and IC7).

Table AII. Selection of Number of Laps

No. of Laps	S3-Key No. ^a	S4-Key No. ^a	Input to IC8
10	2,4	---	A,B
25	7	2,4	D,A,B
50	3,7	6	B,D,C
100	3,5	8	B,C,D
150	1,4,6,7	---	A,B,C,D
200	1,5	4	A,C,B

^aRefers to which keys to switch to the on position. Each input of the NAND gate may be connected to only one lap counter output.

Table AIII. Readout Switch Coding^a

Channel No.	Counter No.	Switch No.	Key No.
1	1	2	8,6,3,1
2	2	2	8,6,3,1
3	3	1	8,6,3,1
4	4	1	8,6,3,1
1	2	2	7,5,4,2
2	1	2	7,5,4,2
3	4	1	7,5,4,2
4	3	1	7,5,4,2
1	1,2	2	8,7,6,5
2	1,2	2	4,3,2,1
3	3,4	1	8,7,6,5
4	3,4	1	4,3,2,1

^aTo send signal from HCL1 or channel 1 of signal demultiplexer (IC11) to up-down counter and readout system 1, keys 8, 6, 3, and 1 of switch no. S2 must be switched to the on position and keys 2, 4, 5, and 7 switched to the off position.

APPENDIX II

5-Digit Display Readout

IC1 - IC5 (N7447, BCD-to-seven segment decoder/driver) in Figure A3 are TTL monolithic devices consisting of the necessary logic to decode a BCD coded signal to seven segment readout plus selected signs. They provide open collector output transistors for directly driving LED displays IC6 - IC10 (MAN72, Monsanto LED display) through 200 Ω resistors R1 - R35. External connections to IC1 - IC5 are described in the caption for Figure A3.

Figure A3. 5-digit display readout schematic.

Pin	Description
4	C input - from least significant up-down counter
5	B input - from least significant up-down counter
8	C input - from 2nd up-down counter
9	B input - from 2nd up-down counter
12	C input - from 3rd up-down counter
13	B input - from 3rd up-down counter
16	C input - from 4th up-down counter
17	B input - from 4th up-down counter
20	C input - from most significant counter
21	B input - from most significant counter
22	+5 V
A	GND
B	A input - from least significant up-down counter
C	D input - from least significant up-down counter
F	A input - from 2nd up-down counter
H	D input - from 2nd up-down counter
L	A input - from 3rd up-down counter
M	D input - from 3rd up-down counter
R	A input - from 4th up-down counter
S	D input - from 4th up-down counter
V	A input - from most significant up-down counter
W	D input - from most significant up-down counter

All other pins are not connected.

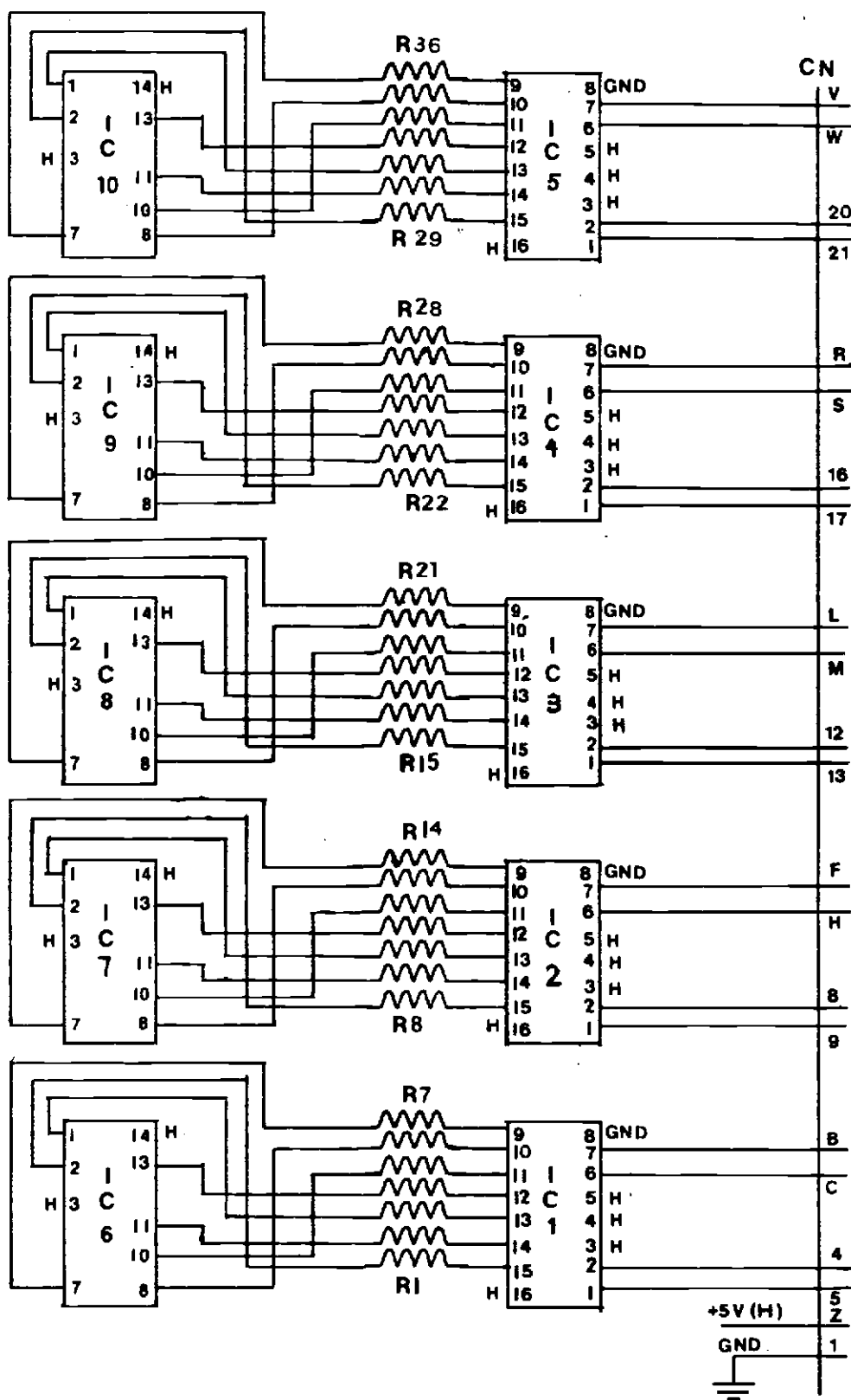


Figure A3.

APPENDIX III

1 MHz Crystal Clock Board

The 1 MHz resonant output frequency of the crystal is divided with decade counters to provide the frequencies from 10 Hz - 1 MHz. All the frequencies are accessible from separate pins of edge connector. Any one frequency at a time can be obtained from pin 12 as selected from a 7-key SPST switch (only one key must be in on position at a time) (Figure A4).

This clock is constructed on a PC board and located in the Vector cage. Pin 10 of this clock board is connected to pin 14 of control board to provide appropriate pulses. Also pin 12 is connected to pin 14 of the automated start switch board. RESET, pin 21 is an input from the CLEAR of control board. Pin 18 (INT) is oscillator output which is connected externally to pin 17 (EXT) which is the external oscillator input to the rest of the clock system.

Figure A4. 1 MHz crystal clock board schematic.

Component	Identification No. or Value	Description
F	1 MHz	Quartz crystal oscillator
IC1-IC5	SN7490	Decade counter
IC6-IC10	SN7400	Quadruple 2-input positive NAND gate
R1,R2	680 Ω	Resistor
R3	150 Ω	Resistor
R4	1 k Ω	Resistor
C1	5 pF	Capacitor
C2	10 pF	Capacitor

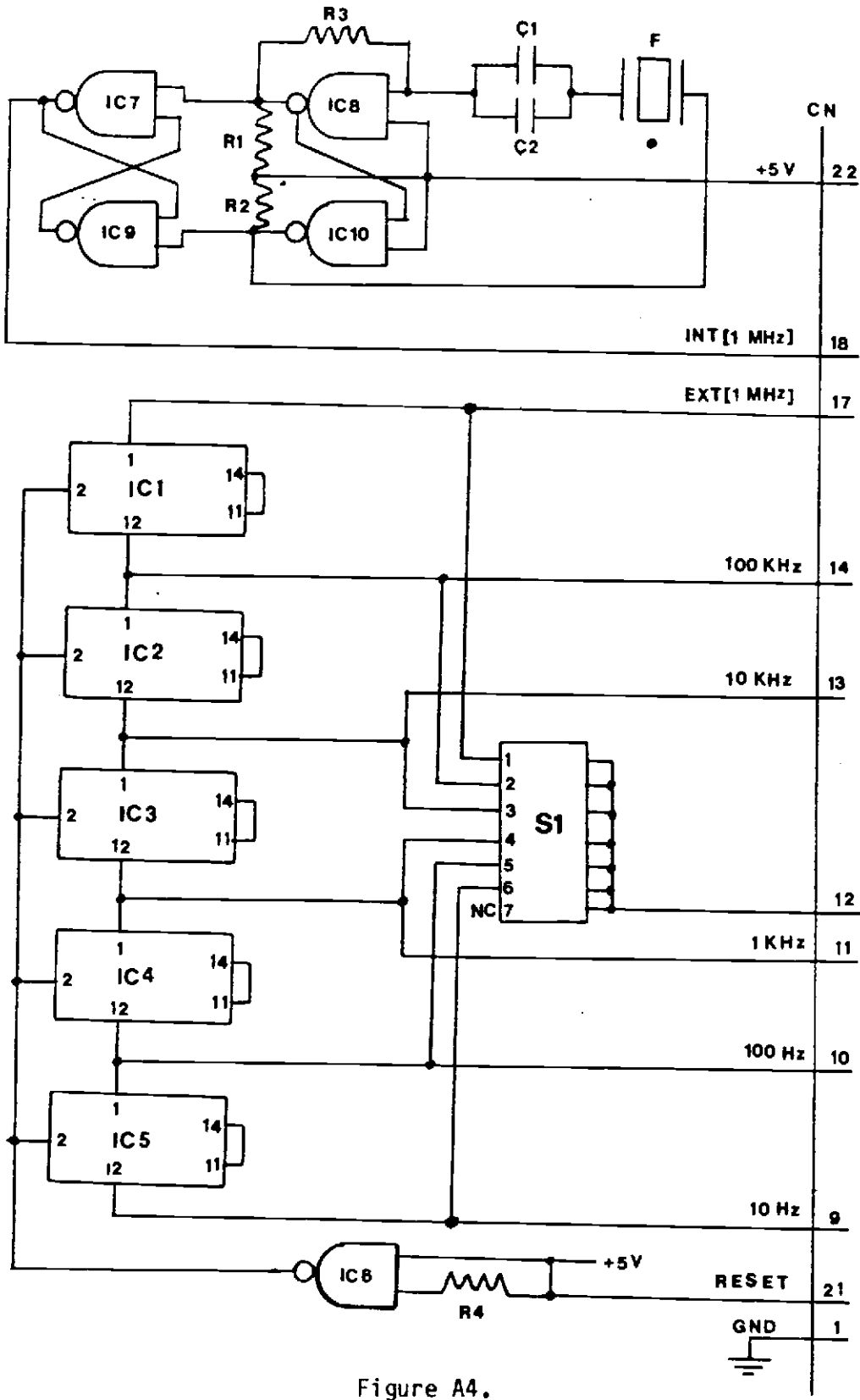


Figure A4.

APPENDIX IV

Automated Start Switch

The automated start switch circuit is based on a 555 timer which operates in the one shot monostable mode. The circuit shown in Figure A5 was constructed on a PC board with a 22 pin finger edge connector. A logic 0 pulse from pin 12 of the clock board (10 Hz frequency) to the input of IC2 drives the output of IC2 to logic 1 (high). The circuit will remain in this state until the set time is elapsed. This period is given by $t = 1.1 RC$ where C can be selected to be 1, 4.7 or 10 μF with switch S1 and R can be varied from 1.5 to 2.5 $M\Omega$ with potentiometer R1.

Also, a manual start switch is available which is basically a momentary push button switch connected to the back of the instrument which can generate a logic 0 pulse. The system can be switched between the manual or automated start mode through a SPDT switch installed on the front of the instrument (Figure A10). The start switch (manual or automated) output is connected to pin 21 of control board.

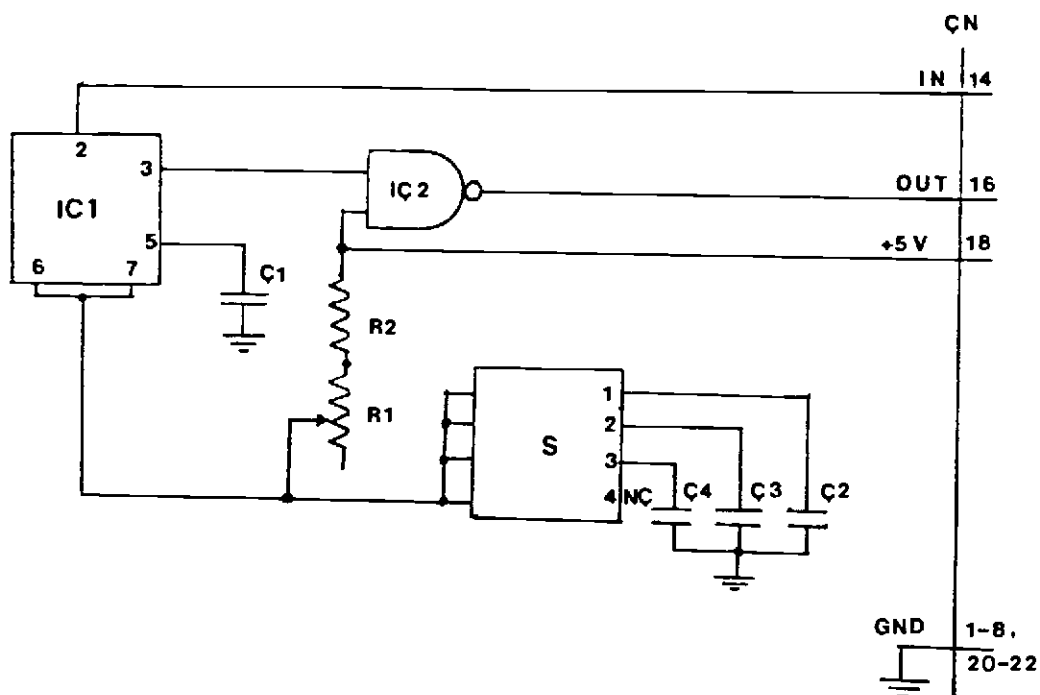


Figure A5. Automated start switch schematic. IN, timer input from pin 12 of the clock board; OUT, to control board pin 21 (START); IC1, NE555 Timer; IC2, SN7400, Quadruple 2-input positive NAND gate; S1, 4 key, SPST switch; C1, C2, C3, and C4 are 0.01, 10, 4.7, 1 μ F capacitors, respectively; R1, 1 M Ω , 10 turn potentiometer; R2, 1.5 M Ω resistor; CN, connection edge.

APPENDIX V

Changes, Additions, and Expansion

In order to make SYM-1 more versatile according to our needs, the following changes were made:

A. Automated Log-on (80)

To log-on a current loop device like a TTY, a "Q" is entered at the device. To provide this option, the following jumpers on the SYM-1 were changed:

Jumpers CC-32 and BB-31
changed to CC-31 and BB-32

B. I/O Line Addition

To be able to use PB4-PB7 at AC00, the following changes were made on SYM-1:

Jumpers B-16 and A-2
changed to B-18 and A-3

C. Basic ROMs Addition

To install two-4Kx8 BASIC ROMs chips at locations C000 to CFFF and D000 to DFFF, the following jumpers have to be changed on SYM-1:

Jumpers B-2, C-2, F-5, G-5, K-11, L-12, and M-13 are removed.

Jumpers B-1, C-1, F-2, G-2, K-11, K-12, L-12, and L-13 are added.

D. Tape Recording Improvement

For better tape reliability (81), the following hardware

modification was made on SYM-1 board:

- a) Changing R94, R95, and R96 to 100 Ω .
- b) Removing R87 and R126.
- c) Installing a 2.2 k Ω resistor from the right end of R94 to the right end of R126
- d) Removing right end of CR28 and connecting it to left side of R87
- e) Removing right end of CR29 and connecting it to left side of R94.
- f) Installing R97 (1 k Ω) and C16 (0.22 μ F).

E. EPRM Board Address Boundaries

Each 8K bank on EPROM board can be addressed separately. The switch at the right hand side corresponds to the upper 8K bank and the one at the left hand side to the lower 8K bank. Table AIV has the address boundaries and corresponding key (it can be used for both switches).

F. LBM Key Positioning

The proper position of the switches on the LBM board is indicated in Table AV.

G. RAM Board Addressing

Each 8K block of RAM board can be addressed separately through switches A and B. The RAM was located from 2000 to 5FFF with switches A and B in the positions given in Table AVI.

Table AIV. EPROM Board Address Boundaries

Key No.	Address Boundaries
1	0000-1FFF
2	2000-3FFF
3	4000-5FFF
4	6000-7FFF
5	8000-9FFF
6	A000-BFFF
7	C000-DFFF
8	E000-FFFF

Table AV. LBM Key Positioning

Key No.	Position
1	X (no difference)
2	Closed (monitor)
3	X
4	Closed (I/O)
5	X
6	Closed
7	Closed
8	X
9	X
10	Closed

8K Basic

Table AVI. Addressing RAM Board

Key No.	Switch A (2000-3FFF)	Switch B (4000-5FFF)
1	Closed	Open
2	Open	Closed
3	Open	Open
4	Closed	Closed
5	Closed	Closed
6	Closed	Closed

APPENDIX VI

Mode 2 and 3 I/O Port Connections

The I/O ports from connectors A, B, C, and D (Figure 10A) are connected to appropriate electronic parts of the instrument through a series of parallel ribbon cables. Table AVII describes the connection to each bit of the above I/O ports.

For mode 2 which the 2-byte up-down counter is used, there is a shortage of I/O ports. This problem was solved by using the two I/O ports from connector A for both the counter board and the ADC. In the mode 2, at the beginning of the program the ADC is needed for adjusting the HCL currents. When the actual measurements start, the ADC is not needed anymore, and instead the 2-byte up-down counter is needed to count the frequencies proportional to the signals. Therefore the two I/O ports from connector A is disconnected from the ADC and connected to counter board. At appropriate times, messages appear at the terminal to indicate that the user should change the connections. Connections between the 2-byte up-down counter and the I/O ports from connector A are shown in Table AVIII.

Table AVII. I/O Port Connections for Mode 2 and 3

Bit No.	Address	Description
	A000	To DAC
0		Strobe (STB)
1		Input, bit 9
2		10
3		11
4		12
5-7		N.C.
	A001	To DAC
0		Input, bit 1
1		2
2		3
3		4
4		5
5		6
6		7
7		8
	A800	To ADC
0		Start conversion
1		Conversion mode
2		Enable
3		Line select A0
4		A1
5		A2

Table AVII Continued

Bit No.	Address	Description
6		End conversion
7		N.C.
	A801	To ADC
0		Output, bit 5
1		6
2		7
3		8
4		9 and 1
5		10 and 2
6		11 and 3
7		12 and 4
	AC00	
0		To HCL, 1 ^a
1		2
2		3
3		4
4		N.C.
5		HCL control to HCL pulser board
6		N.C.
7		Clock to control board
	AC01	
0		N.C.

Table AVII Continued

Bit No.	Address	Description
1		Automated sampler
2-7		N.C.

^aThese lines are actually connected to the input of the HCL's pulse control AND gates on HCL pulser board.

Table AVIII. Extra I/O Port Connections for Mode 2

Bit No.	Address	Description
	A800	To 2-byte up-down counter
0		Clear
1		Gate
2		Low control
3		High control
4		Up-down control
5-7		N.C.
	A801	To 2-byte up-down counter
0		Data bit, 1
1		2
2		3
3		4
4		5
5		6
6		7
7		8

APPENDIX VIII

Baud Rate Generator

The baud rate generator circuit (Figure A6) was constructed on PC board and added to the keyboard/printer interface system. One of four output clock rates are selected with switch S3 as shown in Table AIX.

Table AIX. Output Clock Rate

Key Position ^a				Rate Select		Rate
1	2	3	4	B	A	
1	0	1	0	0	0	X1
1	0	0	1	0	1	X8
0	1	1	0	1	0	X16
0	1	0	1	1	1	X64

^a1 = Closed, 0 = Open

The MC14411 bit rate generator chip can generate a wide range of output frequencies as shown in Table AX. Any of these frequencies can be selected through switches S1 or S2. Normally keys 2 and 3 on switch S3, and key 5 on switch S2 are closed.

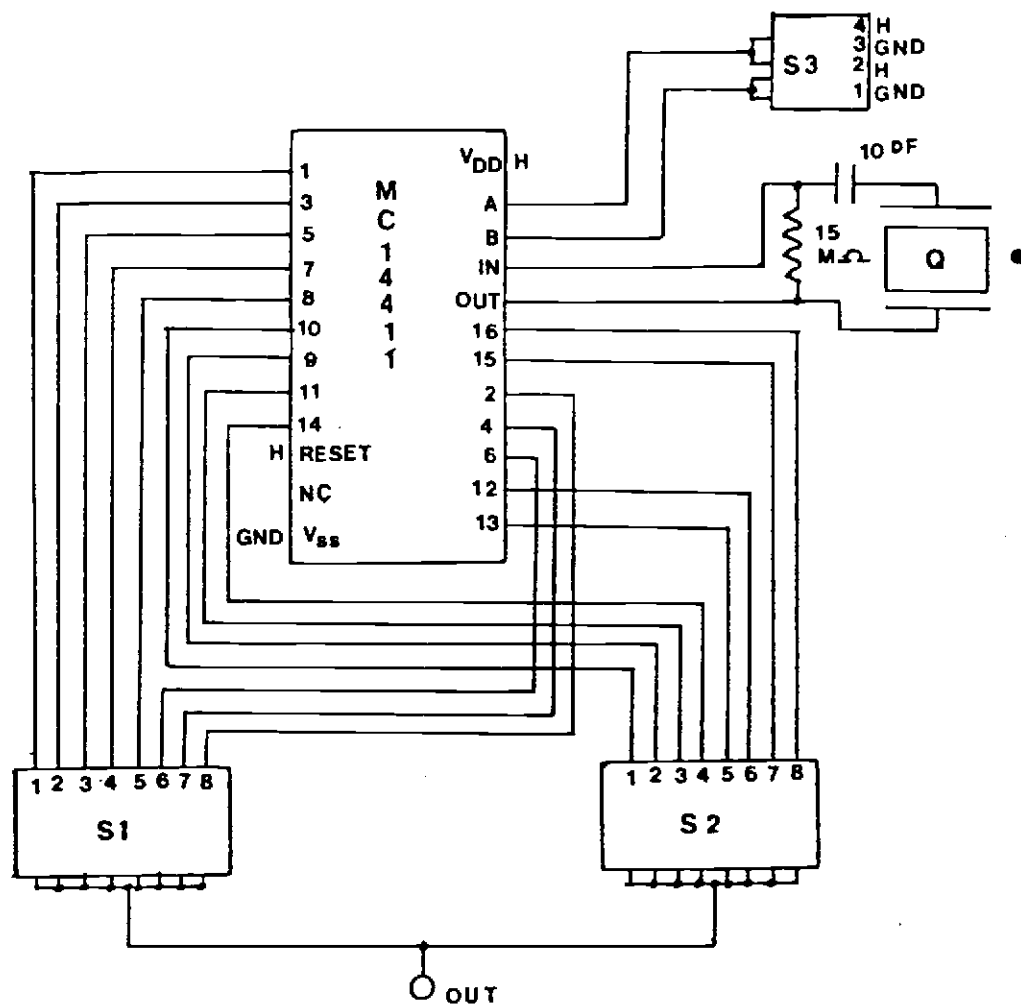


Figure A6. Baud rate generator. S1 and S2, 8 key SPST switch; S3, 4 key SPST switch; Q, 1.8432 MHz quartz crystal oscillator.

Table AX. Frequencies Generated by MC14411 Chip

Switch	Key No.	Output Rate (Hz)			
		X64	X16	X8	X1
S1	1	614.4k	153.6k	76.8k	9600
	2	460.8k	115.2k	57.6k	7200
	3	307.2k	76.8k	38.4k	4800
	4	230.4k	57.6k	28.8k	3600
	5	153.6k	38.4k	19.2k	2400
	6	115.2k	28.6k	14.4k	1800
	7	76.8k	19.2k	9600	1200
	8	38.4k	9600	4800	600
S2	1	19.2k	4800	2400	300
	2	12.8k	3200	1600	200
	3	9600	2400	1200	150
	4	8613.2	2153.3	1076.6	134.5
	5	7035.5	1758.8	879.4	109.9
	6	4800	1200	600	75
	7	921.6k	921.6k	921.6k	921.6k
	8	1.843M	1.843M	1.843M	1.843M

APPENDIX IX

2-Byte Multiplexed Up-Down Counter

The circuit (Figure A7) is built on PC board and placed in the Vector cage beside the other PC boards. The signal from I/V can be switched between this board and ADC through a SPDT switch in the switch box (Figure A10).

The data are transferred into the SYM-1 through eight I/O lines by employing TRI-STATE multiplexing of the data lines. IC5-IC8 are under the control of two SYM-1 I/O lines, Buss Control (BC) 1 and 2. When BC1 is high, IC7 and IC8 are enabled and data bits zero through seven are presented to the SYM-1 I/O port for transfer into memory, and when BC2 is high, IC5 and IC6 are enabled and bits eight through fifteen are presented.

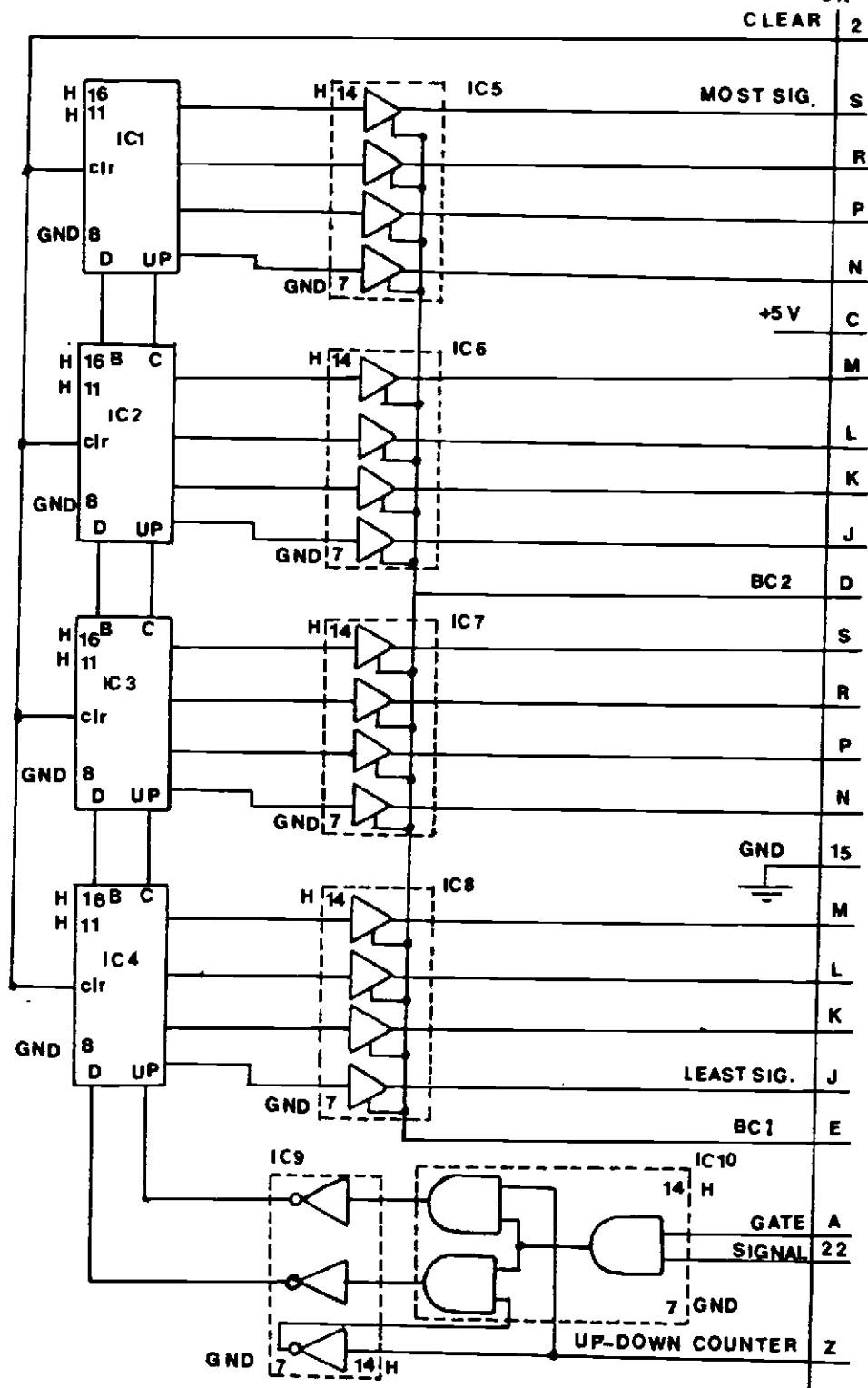


Figure A7. 2-byte multiplexed up-down counter. IC1-IC4, SN74193, synchronous 4-bit binary up-down counter; IC5-IC8, SN74126, tri-state quad buffer hex inverter; IC9, SN7404, quadruple 2-input positive AND gate; CN, connection edge.

APPENDIX X

HCL Pulser Board

A HCL pulser was constructed on PC board (Figure A8). The SYM-1 clock (from a 6522's (AC00) timer) is input to a 4-bit counter. The outputs of this counter go to a BCD-to-decimal decoder which decodes a four bit BCD number to one of ten outputs (the D input is kept low all the time). The decoder outputs (pins 1, 3, 5, and 7) are connected to a TRI-STATE HEX buffers which are controlled by the C. A logic zero signal to the control line allows the signals from the decoder to pass through buffers and this is denoted the free running mode. These signals are used to turn the HCL's on and off one at a time (up to four HCL's). The timer from the 6522 is programmed in a way that the pulse width of the decoder's outputs is the same as chosen pulse width for HCL's under software control. All four I/O lines (12, 14, 16, and 18, inputs of AND gates) are programmed high in the free running mode.

When software controls the pulsing through the four I/O lines (12, 14, 16, and 18), the control line (E) is set high to isolate the NAND gates from the inputs to the TRI-STATE buffers. This is the software control mode.

Figure A8. HCL pulser board schematic.

Pin	Description
A-D	GND
E	HCL pulsing control line from PB5 (AC00)
H	Sampler control in PA (AC01
J	Sampler control to front panel
K	+5 V
M	Clock from PB7 (AC00)
P	HCL 2 control line out to HCL current reg. board
S	HCL 1 control line out to HCL current reg. board
U	HCL 4 control line out to HCL current reg. board
W	HCL 3 control line out to HCL current reg. board
X-Z	GND
1-11	GND
12	HCL 1 control line in from PB0 (AC00)
14	HCL 2 control line in from PB1 (AC00)
16	HCL 3 control line in from PB2 (AC00)
18	HCL 4 control line in from PB3 (AC00)
19-22	GND

All other pins are not connected

Components: IC1, SN74161, synchronous 4-bit counter; IC2, SN7442, BCD-TO-decimal decoder; IC2-IC7, 741S368, tri-state hex buffer; IC8-IC11, SN7408, quadruple 2-input positive AND gate; CN, connection edge.

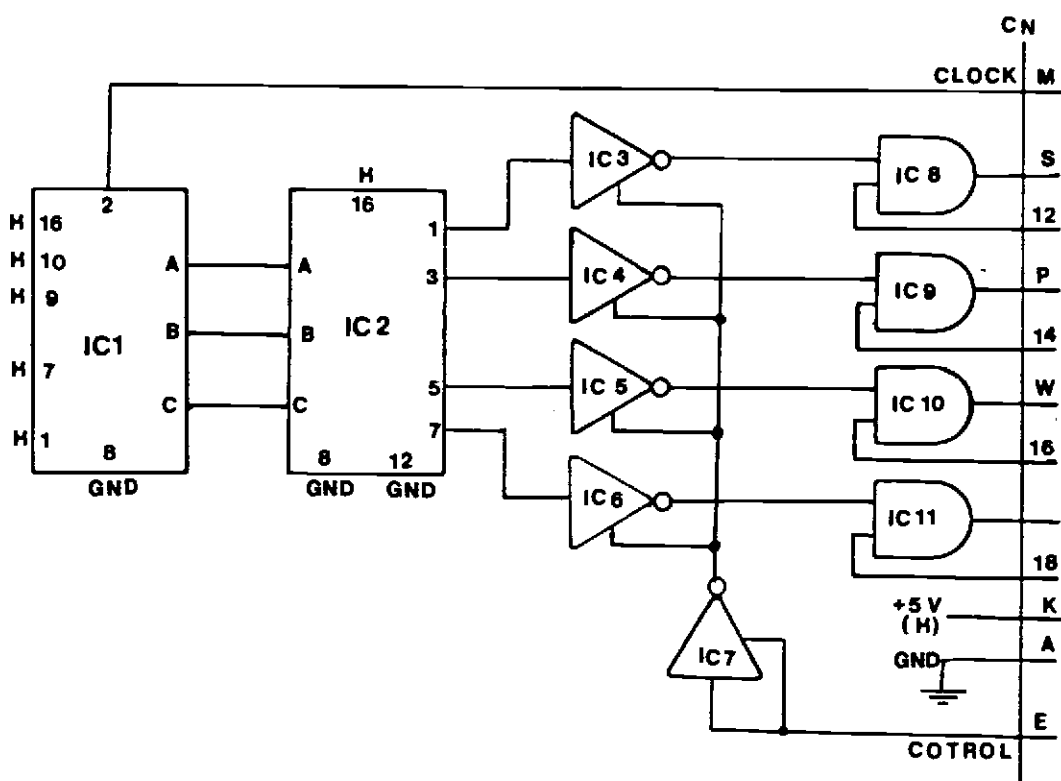


Figure A8.

APPENDIX XI

DAC Output Buffer

The circuit shown in Figure A9 was added to the previously designed DAC circuit (83) to improve the performance of DAC.

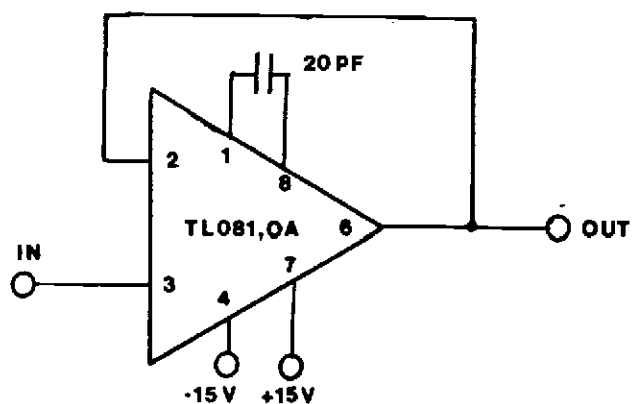


Figure A9. DAC output buffer. IN from pin 22 DAC 80 chip (Figure 14, (83), out; to pin Y (20) of DAC board connection edge.

APPENDIX XII

Mode Selection Switch Box

A set of seven switches were installed in front of the PC board's cage. Through these switches, three modes of operation are selected. Figure A10 shows the location of each switch on the box and each switch's function is described in Table AXI.

Table AXI. Switch Box Functions

Switch	Function
S1,S2	Switches the HCL pulse control between mode 1 (control board) and mode 2 or 3 (computer control).
S3	Disconnects the +5 V from unused PC boards (e.g. in mode 2 and 3 it disconnects clock, auto start, four up-down counters, four digital displays and control board).
S4	Switches V/F output signal between 2-byte multiplexed up-down counter and four up-down counters.
S5	Directs the I/V output to ADC or to V/F
S6	Switches between +5 V and DAC as input voltage for HCL pulsing current control.
S7	Selects between manual and automated start switch.

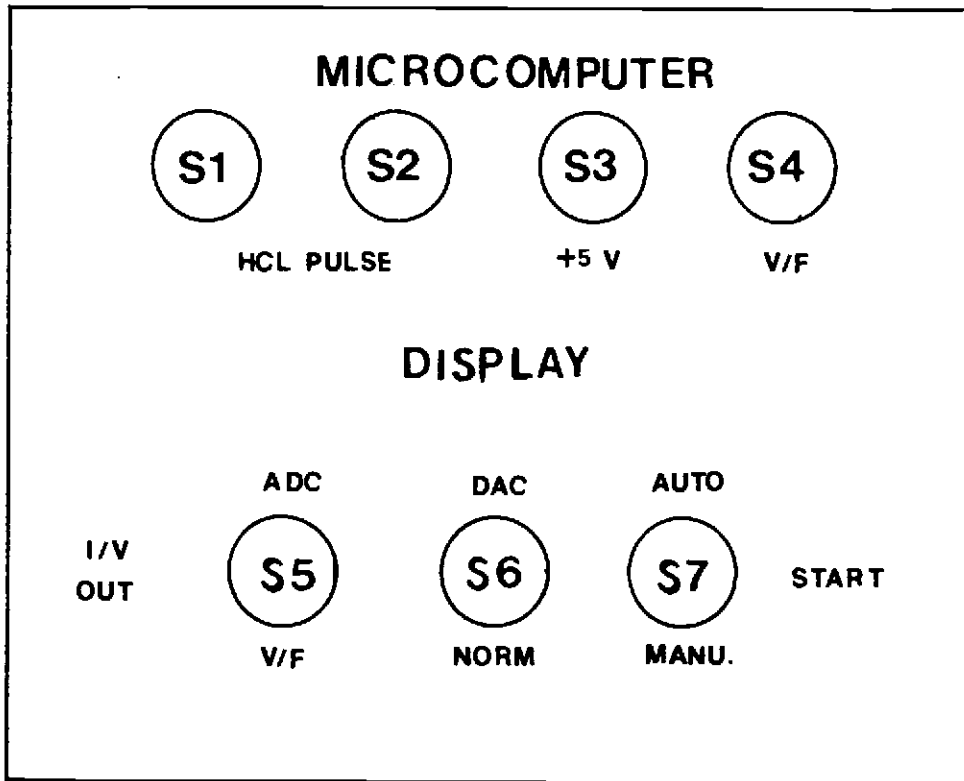


Figure A10. Switch box diagram. S1 and S2, DPDT switches, S3-S7 SPDT switches; for mode 1, all switches down (S7 can be up or down); for mode 2, S1-S4, and S6 up, and S5 down; for mode 3, all switches up.

APPENDIX XIII

Computer Program Operation

The programs for operation in both mode 2 and mode 3 are recorded on cassette tape. For each mode of operation there are two programs: 1) a BASIC program which handles operator input, calculations, and presentation of results 2) an assembly program for operations requiring higher speed such as data acquisition, pulsing of HCL's, HCL current control, DAC and ADC control, and clock programming. The assembly program is loaded first, with the μ C in the monitor mode as described in SYM-1 manual (80). Next the BASIC program is loaded. This is done by first typing G 6B00 with the μ C still in the monitor mode. The μ C jumps to BASIC mode, and is ready to load the BASIC program as described in Brown's Basic Enhancement manual (82).

The programs used for mode 2 are "MULTI-VF" for the BASIC part of program and "3B" for the assembly part, and for mode 3, are "MULTI-AD" and "2B" for the BASIC and the assembly parts, respectively. The listings of the programs follow.

MULTI-VF

```
5 REM THIS PROG TAKES DATA FROM MEMORY, COMPUTES AVR., STD DIV & S/N
10 PRINT
15 DIM L1(35),L2(35),L3(35),L4(35),M1(20),M2(20),M3(20),M4(20),M5(20)
20 PRINT
25 PRINT "HC #1"
30 PRINT "HC #2"
35 PRINT "HC #3"
40 PRINT "HC #4"
45 REM TO START PULSING LAMPS.
50 PRINT
55 PRINT"CHANGE A800-CONNECTION FROM V/F TO A/D & PUSH (CR)"
60 Z=USR(3"8A58",00)
65 PRINT
70 PRINT" TIME ON"
75 INPUT" T1=";T1
80 POKE 20480,T1
85 PRINT
90 PRINT" %TIME ON"
95 INPUT" PC=";PC
100 PRINT
105 PRINT" # OF LAMP"
110 INPUT" LM=";LM
115 POKE 20481,LM
120 PRINT
125 REM RESISTOR USED FOR POWER TRANSISTOR (EMIT-GND)
130 PRINT" RESISTOR VALUE"
135 INPUT" R=";R
140 PRINT
145 T2=T1*((100/(PC*LM))-1)
150 POKE 20483,01
155 IF T2<255 THEN A=T2: GOTO 170
160 A=INT((T2/5)+.5)
165 POKE 20483.05
170 POKE 20482,A
175 IF T1>T2 THEN PRINT"LARGE %TIME ON": GOTO 50
180 CK=(T1+1000/2)-2
185 A=INT(CK/256)
190 POKE 20515,A
195 B=CK-(A*256)
200 POKE 20514,B
205 OF=T2-T1
210 POKE 20484.01
215 IF OF<255 THEN A=OF: GOTO 230
220 A=INT((OF/5)+.5)
```

```
225 POKE 20484,05
230 POKE 20485,A
235 ML=LM
240 PRINT"H.C. AVE. MAMP CURRENTS"
245 PRINT
250 C1=0
255 C2=0
260 C3=0
265 C4=0
270 PRINT" H.C.#1 CURRENT"
275 INPUT" C1=";C1
280 PRINT
285 REM CURRENT CORRECTION FOR RESISTOR VALUE.
290 H=(10-R)*PC/2.5
295 V1=(C1*4.2*R)-(H/C1)
300 REM LAMPS' CURRENT CORRECTION FOR PC NOT EQUAL TO 12.5Z
305 MA=(V1*12.5)/PC
310 A=INT(MA/256)
315 IF A<=15 THEN 330
320 PRINT" NOT ACCEPTABLE, CHANGE C1 OR R VALUE": GOTO 53
325 PRINT
330 POKE 20486,A
335 B=MA-(A*256)
340 POKE 20487,B
345 IF ML-1=0 THEN 540
350 PRINT" H.C.# 2 CURRENT"
355 INPUT" C2=";C2
360 PRINT
365 V2=(C2*4.2*R)-(H/C2)
370 MA=(V2*12.5)/PC
375 A=INT(MA/256)
380 IF A<=15 THEN 395
385 PRINT" NOT ACCEPTABLE, CHANGE C2 OR R VALUE": GOTO 50
390 PRINT
395 POKE 20488,A
400 B=MA-(A*256)
405 POKE 20489,B
410 IF ML-2=0 THEN 540
415 PRINT" H.C.#3 CURRENT"
420 INPUT" C3=";C3
425 PRINT
430 V3=(C3*4.2*R)-(H/C3)
435 MA=(V3*12.5)/PC
440 A=INT(MA/256)
445 IF A<=15 THEN 460
450 PRINT" NOT ACCEPTABLE, CHANGE C3 OR R VALUE": GOTO 50
455 PRINT
460 POKE 20490,A
465 B=MA-(A*256)
470 POKE 20491,B
475 IF ML-3=0 THEN 540
```

```

480 PRINT " H.C.#4 CURRENT"
485 INPUT " C4=";C4
490 PRINT
495 V4=(C4*4.2*R)-(H/C4)
500 MA=(V4*12.5)/PC
505 A=INT(MA/256)
510 IF A<=15 THEN 525
515 PRINT " NOT ACCEPTABLE, CHANGE C4 OR R VALUE": GOTO 50
520 PRINT
525 POKE 20492,A
530 B=MA-(A*256)
535 POKE 20493,B
540 AV=(C1+C2+C3+C4)/LM
545 AV=(AV*4.2*R)-(H/AV)
550 A=INT(AV/256)
555 POKE 20494,A
560 B=AV-(A*256)
565 POKE 20495,B
570 PRINT
575 PRINT " T1=";T1,"PC=";PC,"LM=";LM,"R=";R
580 PRINT " C1=";C1,"C2=";C2,"C3=";C3,"C4=";C4
585 PRINT
590 PRINT " ARE THESE VALUES CORRECT? YES=1,NO=0"
595 INPUT " ANS=";Y
600 IF Y=0 THEN 50
605 PRINT
610 PRINT " READY TO READ CURRENT! PUSH (CR). "
615 Z=USR(&"4500",00)
620 REM CURRENT READING BY A/D ACROSS ABOVE RESISTOR
625 A=PEEK(20496)
630 B=PEEK(20497)
635 C=((B*256)+A)*10000/(4095*R)
640 I=INT(C+.5)
645 PRINT
650 PRINT " PEAK TO PEAK CURRENTS"
655 PRINT
660 PRINT " H.C.#1 CURRENT=";I;" MAMP"
665 A=PEEK(20498)
670 B=PEEK(20499)
675 C=((B*256)+A)*10000/(4095*R)
680 D=INT(C+.5)
685 PRINT " H.C.#2 CURRENT=";D;" MAMP"
690 A=PEEK(20500)
695 B=PEEK(20501)
700 C=((B*256)+A)*10000/(4095*R)
705 I=INT(C+.5)
710 PRINT " H.C.#3 CURRENT=";D;" MAMP"
715 A=PEEK(20502)
720 B=PEEK(20503)
725 C=((B*256)+A)*10000/(4095*R)
730 D=INT(C+.5)

```

```
735 PRINT " H.C.#4 CURRENT=";I;" MAHF"
740 PRINT
745 PRINT " READ MORE YES=1,NO=0"
750 INPUT " ANS=";Y
755 IF Y=0 THEN 790
760 PRINT
765 PRINT " ANY CHANGE YES=1,NO=0"
770 INPUT " ANS=";Y
775 PRINT
780 IF Y>0 THEN 235
785 IF Y=0 THEN 605
790 PRINT
795 PRINT"CHANGE A800-CONNECTION FROM A/D TO V/F & PUSH (CR)"
800 Z=USR("&A58",00)
805 PRINT
810 PRINT " # OF LAPS"
815 INPUT " LP=";LP
820 POKE 20504,LP
825 PRINT
830 PRINT " # OF POINT"
835 INPUT " PT=";PT
840 POKE 20505,PT
845 PRINT
850 PRINT " RF VALUE (K-OHM)"
855 INPUT " RF=";RF
860 PRINT
865 PRINT " CF VALUE (P-F)"
870 INPUT " CF=";CF
875 TM=INT((5*RF+CF/50)+.5)
880 DT=TM+.05
885 POKE 20516,TM
890 RD=1000*(T1-DT)
895 TT=T1-DT
900 POKE 20513,01
905 IF RD<=256 THEN A=RD: GOTO 940
910 FOR J=0 TO 251
915 B=5+J
920 A=INT((RD/B)+.5)
925 IF A<=256 THEN 935
930 NEXT
935 POKE 20513,B
940 POKE 20506,A
945 PRINT
950 PRINT " # OF RUNS"
955 INPUT " RN=";RN
960 PRINT
965 PRINT " PNT VOLTAGE"
970 INPUT " PN=";PN
975 PRINT
980 IF PN=400 THEN GM=2.75E03
985 IF PN=500 THEN GM=1.5E04
```

```

990 IF PM=600 THEN GM=6.8E04
995 IF PM=700 THEN GM=2.25E05
1000 IF PM=800 THEN GM=6.8E05
1005 IF PM=900 THEN GM=1.9E06
1010 IF PM=1000 THEN GM=5E06
1015 REM NOISE EQUIVALENT BANDPASS 1/S.
1020 DF=1000/(2*(T1-DT)*LP)
1025 G=(LOG(GM)/LOG(10))/9
1030 GA=10+G
1035 KK=2*1.6E-19*DF*(1+1/(GA-1))
1040 ZA=GM*RF*KK*(1E06)
1045 PRINT" CALIBRATION CURVE YES=1,NO=0"
1050 INPUT" ANS=";CC
1055 IF CC=1 THEN 2500
1060 PRINT
1065 REM ABOVE SECTION INITIALIZES USER DEFINED VARIABLES.
1070 REM THE NEXT SECTION COLLECTS BLANK DATA FROM MEMORY.
1075 Q=0
1080 REM FOR FIRST RUN
1085 PRINT
1090 POKE 44033,00
1095 REM TO START SAMPLER FOR BLANK.
1100 PRINT" DO YOU WANT DARK DATA? YES=1,NO=0"
1105 INPUT" DK=";DK
1110 IF DK=0 THEN 1170
1115 PRINT
1120 PRINT" COVER ENTRANCE SLIT & PUSH (CR)."

```

```
1245 REM TO START SAMPLER FOR SAMPLE.
1250 PRINT" RUN SAMPLE PUSH (CR) TO START."
1255 Z=USR("&"8A5B",00)
1260 PRINT
1265 PRINT "SAMPLE DATA"
1270 PRINT"-----"
1275 Z=USR("&"56E6",00)
1280 REM TO COLLECT SAMPLE DATA
1285 GOSUB 1390
1290 PRINT
1295 PRINT "TOTAL SIG AVER & STD DEV"
1300 PRINT
1305 POKE 44033,00
1310 GOSUB 1790
1315 IF CC=0 THEN 1325
1320 RETURN
1325 GOSUB 2150
1330 D=D+1
1335 IF D<RN THEN 1085
1340 PRINT "EXTRA RUN YES=1 NO=0"
1345 INPUT" ANS=";Y
1350 IF Y=0 THEN 2940
1355 PRINT
1360 PRINT "CHANGE VARIABLES: UPPER SEC.=2, LOWER SEC.=1, NO=0"
1365 INPUT" ANS=";Y
1370 IF Y=0 THEN 1085
1375 IF Y=1 THEN 805
1380 IF Y=2 THEN 50
1385 PRINT
1390 REM THIS SUB TAKES DATA FROM MEMDRY FOR EACH LAMP.
1395 N=PT-1
1400 FOR J=0 TO N
1405 A=PEEK(20550+J)
1410 B=PEEK(20600+J)
1415 C=PEEK(20650+J)
1420 REM A,B,C THREE BYTES WHICH CONTAIN THE JTH
1425 REM DATA POINT A THE LEAST SIG FIG. & C MOST SIG FIG.
1430 D=(C*256)+B
1435 L1(J)=(D*256)+A
1440 A=PEEK(20700+J)
1445 B=PEEK(20750+J)
1450 C=PEEK(20800+J)
1455 D=(C*256)+B
1460 L2(J)=(D*256)+A
1465 A=PEEK(20850+J)
1470 B=PEEK(20900+J)
1475 C=PEEK(20950+J)
1480 D=(C*256)+B
1485 L3(J)=(D*256)+A
1490 A=PEEK(21000+J)
1495 B=PEEK(21050+J)
```



```
1500 C=PEEK(21100+J)
1505 D=(C*256)+B
1510 L4(J)=(D*256)+A
1515 NEXT J
1520 RETURN
1525 REM THIS SUB. FINDS MEANS AND STD DIV. IN BLANK & DARK.
1530 K1=0
1535 K2=0
1540 K3=0
1545 K4=0
1550 N=PT-1
1555 FOR J=0 TO N
1560 K1= K1+L1(J)
1565 K2= K2+L2(J)
1570 K3= K3+L3(J)
1575 K4= K4+L4(J)
1580 NEXT J
1585 K1=K1/PT
1590 K2=K2/PT
1595 K3=K3/PT
1600 K4=K4/PT
1605 PRINT INT(K1+.5),INT(K2+.5),INT(K3+.5),INT(K4+.5)
1610 F1=0
1615 F2=0
1620 F3=0
1625 F4=0
1630 G1=0
1635 G2=0
1640 G3=0
1645 G4=0
1650 FOR J=0 TO N
1655 F1= L1(J)-K1
1660 G1=(F1*F1)+G1
1665 F2= L2(J)-K2
1670 G2=(F2*F2)+G2
1675 F3= L3(J)-K3
1680 G3=(F3*F3)+G3
1685 F4= L4(J)-K4
1690 G4=(F4*F4)+G4
1695 NEXT J
1700 S1= SQR(G1/N)
1705 S2= SQR(G2/N)
1710 S3= SQR(G3/N)
1715 S4= SQR(G4/N)
1720 A=INT(S1*100+.5)/100
1725 B=INT(S2*100+.5)/100
1730 C=INT(S3*100+.5)/100
1735 D=INT(S4*100+.5)/100
1740 PRINT A,B,C,D
1745 PRINT
1750 PRINT"PRINT DATA YES=1,NO=0"
```

```
1755 INPUT "ANS=";Y
1760 PRINT
1765 IF Y=0 THEN 1785
1770 FOR J=0 TO N
1775 PRINT INT(L1(J)+.5),INT(L2(J)+.5),INT(L3(J)+.5),INT(L4(J)+.5)
1780 NEXT J
1785 RETURN
1790 REM THIS SUB. FINDS MEAN & STD DIV. OF TOTAL SIGNAL.
1795 T1=0
1800 T2=0
1805 T3=0
1810 T4=0
1815 N=PT-1
1820 FOR J=0 TO N
1825 T1=L1(J)+T1
1830 T2=L2(J)+T2
1835 T3=L3(J)+T3
1840 T4=L4(J)+T4
1845 NEXT J
1850 T1=T1/PT
1855 T2=T2/PT
1860 T3=T3/PT
1865 T4=T4/PT
1870 PRINT INT(T1+.5),INT(T2+.5),INT(T3+.5),INT(T4+.5)
1875 Z1=ZA*T1/(TT*LP*1E05)
1880 Z2=ZA*T2/(TT*LP*1E05)
1885 Z3=ZA*T3/(TT*LP*1E05)
1890 Z4=ZA*T4/(TT*LP*1E05)
1895 IF Z1<=0 THEN ZA=0: GOTO 1905
1900 ZA=SQR(Z1)
1905 IF Z2<=0 THEN ZB=0: GOTO 1915
1910 ZB=SQR(Z2)
1915 IF Z3<=0 THEN ZC=0: GOTO 1925
1920 ZC=SQR(Z3)
1925 IF Z4<=0 THEN ZD=0: GOTO 1935
1930 ZD=SQR(Z4)
1935 H1=0
1940 N1=0
1945 H2=0
1950 N2=0
1955 H3=0
1960 N3=0
1965 H4=0
1970 N4=0
1975 FOR J=0 TO N
1980 H1=L1(J)-T1
1985 N1=(H1*H1)+N1
1990 H2=L2(J)-T2
1995 N2=(H2*H2)+N2
2000 H3=L3(J)-T3
2005 N3=(H3*H3)+N3
```

```
2010 H4=L4(J)-T4
2015 N4=(H4+H4)+N4
2020 NEXT J
2025 V1=SQR(N1/N)
2030 V2=SQR(N2/N)
2035 V3=SQR(N3/N)
2040 V4=SQR(N4/N)
2045 A=INT(V1*100+.5)/100
2050 B=INT(V2*100+.5)/100
2055 C=INT(V3*100+.5)/100
2060 D=INT(V4*100+.5)/100
2065 PRINT A,B,C,D
2070 GOSUB 1745
2075 PRINT
2080 PRINT" RMS SHOT NOISE (VOLTAGE). "
2085 PRINT
2090 PRINT ZA,ZB,ZC,ZD
2095 PRINT
2100 PRINT "NET SIGNAL"
2105 PRINT
2110 REM THIS SUBROUTINE FINDS THE NET SIGNAL.
2115 X1=T1-K1
2120 X2=T2-K2
2125 X3=T3-K3
2130 X4=T4-K4
2135 PRINT INT(X1+.5),INT(X2+.5),INT(X3+.5),INT(X4+.5)
2140 PRINT
2145 RETURN
2150 PRINT" NET SIGNAL/BLANK STD DIV."
2155 REM THIS SUBROUTINE FINDS RATIO OF NET SIGNAL TO
2160 REM BLANK NOISE & NET SIGNAL TO TOTAL NOISE.
2165 IF S1<=0 THEN 2175
2170 P1=X1/S1
2175 IF S2<=0 THEN 2185
2180 P2=X2/S2
2185 IF S3<=0 THEN 2195
2190 P3=X3/S3
2195 IF S4<=0 THEN 2205
2200 P4=X4/S4
2205 PRINT
2210 A=INT(P1*10+.5)/10
2215 B=INT(P2*10+.5)/10
2220 C=INT(P3*10+.5)/10
2225 D=INT(P4*10+.5)/10
2230 PRINT A,B,C,D
2235 PRINT
2240 PRINT" NET SIGNAL/TOTAL NOISE"
2245 Q1=SQR((S1*S1)+(V1*V1))
2250 Q2=SQR((S2*S2)+(V2*V2))
2255 Q3=SQR((S3*S3)+(V3*V3))
2260 Q4=SQR((S4*S4)+(V4*V4))
```

```
2265 IF Q1=0 THEN 2275
2270 W1=X1/Q1
2275 IF Q2=0 THEN 2285
2280 W2=X2/Q2
2285 IF Q3=0 THEN 2295
2290 W3=X3/Q3
2295 IF Q4=0 THEN 2305
2300 W4=X4/Q4
2305 PRINT
2310 A=INT(W1*10+.5)/10
2315 B=INT(W2*10+.5)/10
2320 C=INT(W3*10+.5)/10
2325 D=INT(W4*10+.5)/10
2330 PRINT A,B,C,D
2335 PRINT
2340 PRINT" CONC. OF SOLN. #1 (PPM)"
2345 INPUT" G1=";G1
2350 PRINT
2355 IF ML-1=0 THEN 2415
2360 PRINT" CONC. OF SOLN. #2 (PPM)"
2365 INPUT" G2=";G2
2370 PRINT
2375 IF ML-2=0 THEN 2415
2380 PRINT" CONC. OF SOLN. #3 (PPM)"
2385 INPUT" G3=";G3
2390 PRINT
2395 IF ML-3=0 THEN 2415
2400 PRINT" CONC. OF SOLN. #4 (PPM)"
2405 INPUT" G4=";G4
2410 PRINT
2415 IF P1=0 THEN Y1=0: GOTO 2430
2420 D1=2*G1/P1
2425 Y1=INT((D1*1000)+.5)/1000
2430 IF P2=0 THEN Y2=0: GOTO 2445
2435 D2=2*G2/P2
2440 Y2=INT((D2*1000)+.5)/1000
2445 IF P3=0 THEN Y3=0: GOTO 2460
2450 D3=2*G3/P3
2455 Y3=INT((D3*1000)+.5)/1000
2460 IF P4=0 THEN Y4=0: GOTO 2475
2465 D4=2*G4/P4
2470 Y4=INT((D4*1000)+.5)/1000
2475 PRINT" DETECTION LIMITS (PPM)"
2480 PRINT"-----"
2485 PRINT Y1,Y2,Y3,Y4
2490 PRINT
2495 RETURN
2500 REM THIS SUB. IS FOR CALIB. CURVE & UKN. CALCULATIONS.
2505 PRINT
2510 PRINT" # OF STANDARDS"
2515 INPUT" SD=";SD
```

```
2520 PRINT
2525 PRINT! INTER THE CONCENTRATION OF STANDARDS."
2530 PRINT
2535 F=S0-1
2540 FOR I=0 TO F
2545 PRINT I+1;
2550 INPUT J
2555 PRINT
2560 M5(I)=J
2565 NEXT I
2570 PRINT
2575 PRINT" CALIBRATION CURVE DATA"
2580 PRINT"-----"
2585 FOR H=0 TO F
2590 A1=0:A2=0:A3=0:A4=0
2595 K=RN-1
2600 FOR I=0 TO K
2605 GOSUB 1060
2610 A1=A1+X1
2615 A2=A2+X2
2620 A3=A3+X3
2625 A4=A4+X4
2630 NEXT I
2635 M1(H)=A1/RN
2640 M2(H)=A2/RN
2645 M3(H)=A3/RN
2650 M4(H)=A4/RN
2655 NEXT H
2660 PRINT" CONC.          NET AVE. SIGNAL."
2665 FOR H=0 TO F
2670 PRINT
2675 PRINT M5(H),INT(M1(H)),INT(M2(H)),INT(M3(H)),INT(M4(H))
2680 NEXT H
2685 PRINT
2690 L=0
2695 PRINT" WHAT ARE THE 1ST & 2ND POINTS FOR THE SLOPE CALC."
2700 INPUT" 1ST=";N
2705 INPUT" 2ND=";K
2710 S1=0:S2=0:S3=0:S4=0
2715 N=N-1
2720 K=K-2
2725 FOR J=N TO K
2730 W=M5(J+1)-M5(J)
2735 S1=(M1(J+1)-M1(J))/W+S1
2740 S2=(M2(J+1)-M2(J))/W+S2
2745 S3=(M3(J+1)-M3(J))/W+S3
2750 S4=(M4(J+1)-M4(J))/W+S4
2755 NEXT J
2760 PRINT
2765 PRINT" SLOPES OF CALIB. CURVES"
2770 PRINT
```

```
2775 PRINT INT(S1+.5),INT(S2+.5),INT(S3+.5),INT(S4+.5)
2780 PRINT
2785 IF L=1 THEN 2875
2790 PRINT" DO YOU RUN UNKNOWN YES=1, NO=0"
2795 INPUT" ANS=";Y
2800 IF Y=0 THEN 2915
2805 A1=0:A2=0:A3=0:A4=0
2810 K=RN-1
2815 FOR H=0 TO K
2820 GOSUB 1060
2825 A1=A1+(X1/RN)
2830 A2=A2+(X2/RN)
2835 A3=A3+(X3/RN)
2840 A4=A4+(X4/RN)
2845 NEXT H
2850 PRINT
2855 PRINT" NET UKN. SIGNAL."
2860 PRINT
2865 PRINT INT(A1+.5),INT(A2+.5),INT(A3+.5),INT(A4+.5)
2870 PRINT
2875 PRINT" CONCENTRATION OF UKN."
2880 PRINT
2885 IF S1=0 THEN A1/S1=0
2890 IF S2=0 THEN A2/S2=0
2895 IF S3=0 THEN A3/S3=0
2900 IF S4=0 THEN A4/S4=0
2905 PRINT A1/S1,A2/S2,A3/S3,A4/S4
2910 PRINT
2915 PRINT" CALCULATE THE SLOPE AGAIN YES=1, NO=0"
2920 INPUT" ANS=";L
2925 PRINT
2930 IF L=1 THEN 2770
2935 GOTO 1340
2940 PRINT
2945 PRINT"CHANGE A800-CONNECTION FROM V/F TO A/D"
2950 END
```

OK

3B

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LINE # LOC      CODE      LINE
0002 0000      ; THIS PROGRAM IS A PART OF A BASIC PROGRAM
0003 0000      ; WHICH RUNS TMMS INSTRUMENT & COLLECT DATA.
0004 0000      ;***** I/O PORTS *****
0005 0000      ;
0006 0000      RRD=$A000      ;DAC'S STR. & 4 HIGH BITS.
0007 0000      RRD=$A002
0008 0000      RAD=$A001      ;DAC'S 8 LOW BITS.
0009 0000      RAD=$A003
0010 0000      DRB=$A402
0011 0000      DRB=$A800      ;ADC'S CONTROL BITS.
0012 0000      DDRB=$A802      ;OR COUNTER CONTROLS.
0013 0000      DRA=$A801      ;ADC'S DATA BITS.
0014 0000      DDRA=$A803      ;OR COUNTER DATA OUTPUT.
0015 0000      PBD=$AC00      ;H.C. LAMP PULSING & CLOCK.
0016 0000      PBD=$AC02
0017 0000      PAD=$AC01      ;SAMPLER CONTROL.
0018 0000      PAD=$AC03
0019 0000      TILL=$AC04      ;LOW-ORDER LATCH TIMER-1.
0020 0000      TICH=$AC05      ;HIGH-ORDER COUNTER.
0021 0000      ACR=$AC0E      ;AUXILIARY CONTROL REGISTER.
0022 0000      PW=$A414      ;1T (1 USEC)
0023 0000      SR=$A417      ;1024T (1 MSEC)
0024 0000      CRLF=$E34D
0025 0000      ;
0026 0000      ;***RESERVED MEMORY LOCATIONS FOR VARIABLES***.
0027 0000      *=$5000
0028 5000      DN      *==+1
0029 5001      LAMP      *==+1
0030 5002      DARK      *==+1
0031 5003      TLOOP      *==+1
0032 5004      TIMLOP      *==+1
0033 5005      OFF      *==+1
0034 5006      CURH1      *==+1
0035 5007      CURL1      *==+1
0036 5008      CURH2      *==+1
0037 5009      CURL2      *==+1
0038 500A      CURH3      *==+1
0039 500B      CURL3      *==+1
0040 500C      CURH4      *==+1
0041 500D      CURL4      *==+1
0042 500E      AVCRH      *==+1
0043 500F      AVCRL      *==+1

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0044 5010      CORL1  *==+1
0045 5011      CORH1  *==+1
0046 5012      CORL2  *==+1
0047 5013      CORH2  *==+1
0048 5014      CORL3  *==+1
0049 5015      CORH3  *==+1
0050 5016      CORL4  *==+1
0051 5017      CORH4  *==+1
0052 5018      LAP     *==+1
0053 5019      POINT  *==+1
0054 501A      RD      *==+1
0055 501B      DACL   *==+1
0056 501C      DACH   *==+1

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LINE # LOC      CODE      LINE
0057 501D      ADCL   *==+1
0058 501E      ADCH   *==+1
0059 501F      LOP    *==+1
0060 5020      LOMP   *==+1
0061 5021      REED   *==+1
0062 5022      CLOCK  *==+2
0063 5024      TM     *==+1
0064 5025      MT     *==+1
0065 5026                *=$00F6
0066 00F6      HOLDER *==+2
0067 00F8      ;
0068 00F8      ;***** MEMORY LOCATIONS RESERVED FOR DATA STORAGE ***
0069 00F8      ;
0070 00F8      ARY11=$5046
0071 00F8      ARY12=$5078
0072 00F8      ARY13=$50AA
0073 00F8      ARY21=$50DC
0074 00F8      ARY22=$510E
0075 00F8      ARY23=$5140
0076 00F8      ARY31=$5172
0077 00F8      ARY32=$51A4
0078 00F8      ARY33=$51D6
0079 00F8      ARY41=$5208
0080 00F8      ARY42=$523A
0081 00F8      ARY43=$526C
0082 00F8      ;*** INITIALIZATION OF DATA DIRECTION ***
0083 00F8      ;
0084 00F8                *=$5500
0085 5500  A9 FF      LDA  #$FF      ;OUTPUT PORT FOR DAC
0086 5502  8D 03 A0   STA  RADD
0087 5505  8D 02 A0   STA  RBDII
0088 5508  A9 0F      LDA  #$0F      ;LAMP PULSING I/O PORT
0089 550A  8D 02 AC   STA  FBDDI
0090 550D  8D 03 AC   STA  FADD      ;SAMPLER I/O PORT

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0091 5510 A9 00          LDA #100          ;ADC DATA INPUT
0092 5512 8D 03 AB      STA DIRA
0093 5515 A9 3F          LDA #3F           ;ADC CONTROL PORT
0094 5517 8D 02 AE      STA DIRB
0095 551A                :
0096 551A                ;**** K.C. LAMP'S CURRENT READING ****
0097 551A                :
0098 551A A9 00          LDA #00           ;CLEAR ALL FOLLOWING LOC.
0099 551C 8D 10 50      STA CORL1
0100 551F 8D 11 50      STA CORH1
0101 5522 8D 12 50      STA CORL2
0102 5525 8D 13 50      STA CORH2
0103 5528 8D 14 50      STA CORL3
0104 552B 8D 15 50      STA CORH3
0105 552E 8D 16 50      STA CORL4
0106 5531 8D 17 50      STA CORH4
0107 5534 A9 59          LMP1 LDA #KRED1    ;LOAD LOW BYTE OF RED1 ADDR.
0108 5536 85 F6          STA HOLDER
0109 5538 A9 55          LDA #>RED1       ;LOAD HIGH BYTE OF ADDR.
0110 553A 85 F7          STA HOLDER+1
0111 553C AD 01 50      LDA LAMP

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LINE #	LOC	CODE	LINE	
0112	553F	8D 20 50		STA LOMP
0113	5542	AD 07 50		LDA CURL1 ;LOAD THE CURRENT FOR #1
0114	5545	8D 1B 50		STA DACL
0115	5548	AD 06 50		LDA CURH1
0116	554B	8D 1C 50		STA DACH
0117	554E	20 63 56		JSR DAK ;CONVERT TO ANALOGE.
0118	5551	A9 01		LDA #01 ;TURN LAMP #1 ON.
0119	5553	8D 00 AC		STA PBI
0120	5556	4C 7B 56		JMP KLOK
0121	5559	AD 1D 50	RED1	LDA ADCL ;LOAD CURRENT READING BY A/D.
0122	555C	8D 10 50		STA CORL1
0123	555F	AD 1E 50		LDA ADCH
0124	5562	8D 11 50		STA CORH1
0125	5565	A9 00		LDA #00 ;TURN OFF THE LAMP.
0126	5567	8D 00 AC		STA PBI
0127	556A	A9 71		LDA #<LMP2
0128	556C	85 F6		STA HOLDER ;SAVE RETURNE ADDR.
0129	556E	4C 93 56		JMP TIMOFF
0130	5571	CE 20 50	LMP2	DEC LOMP
0131	5574	D0 03		BNE TWO
0132	5576	4C 34 55		JMP LMP1
0133	5579	AD 09 50	TWO	LDA CURL2
0134	557C	8D 1B 50		STA DACL
0135	557F	AD 08 50		LDA CURH2

0136	5582	8D 1C 50		STA DACH	
0137	5585	20 63 56		JSR DAK	
0138	5588	A9 02		LDA #02	;TURN LAMP #2 ON.
0139	558A	8D 00 AC		STA PBD	
0140	558D	A9 94		LDA #<RED2	
0141	558F	85 F6		STA HOLDER	
0142	5591	4C 7B 56		JMP KLOK	
0143	5594	AD 1D 50	RED2	LDA ADCL	
0144	5597	8D 12 50		STA CORL2	
0145	559A	AD 1E 50		LDA ADCH	
0146	559D	8D 13 50		STA CORH2	
0147	55A0	A9 00		LDA #00	
0148	55A2	8D 00 AC		STA PBD	
0149	55A5	A9 AC		LDA #<LMP3	
0150	55A7	85 F6		STA HOLDER	
0151	55A9	4C 93 56		JMP TIMOFF	
0152	55AC	CE 20 50	LMP3	DEC LOMP	
0153	55AF	D0 03		BNE THREE	
0154	55B1	4C 34 55		JMP LMP1	
0155	55B4	AD 0B 50	THREE	LDA CURL3	
0156	55B7	8D 1B 50		STA DACL	
0157	55BA	AD 0A 50		LDA CURH3	
0158	55BD	8D 1C 50		STA DACH	
0159	55C0	20 63 56		JSR DAK	
0160	55C3	A9 04		LDA #04	;TURN LAMP #3 ON.
0161	55C5	8D 00 AC		STA PBD	
0162	55C8	A9 CF		LDA #<RED3	
0163	55CA	85 F6		STA HOLDER	
0164	55CC	4C 7B 56		JMP KLOK	
0165	55CF	AD 1D 50	RED3	LDA ADCL	
0166	55D2	8D 14 50		STA CORL3	

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LINE #	LOC	CODE	LINE
0167	55D5	AD 1E 50	LDA ADCH
0168	55D8	8D 15 50	STA CORH3
0169	55DB	A9 00	LDA #00
0170	55DD	8D 00 AC	STA PBD
0171	55E0	A9 E7	LDA #<LMP4
0172	55E2	85 F6	STA HOLDER
0173	55E4	4C 93 56	JMP TIMOFF
0174	55E7	CE 20 50	LMP4
0175	55EA	D0 03	BNE FOUR
0176	55EC	4C 34 55	JMP LMP1
0177	55EF	AD 0D 50	FOUR
0178	55F2	8D 1B 50	STA DACL
0179	55F5	AD 0C 50	LDA CURH4

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0180 55FB 8D 1C 50      STA DACH
0181 55FB 20 63 56      JSR DAK
0182 55FE A9 08          LDA #100      ;TURN LAMP #4 ON.
0183 5600 9D 00 AC      STA PRD
0184 5603 A9 0E          LDA #KRED4
0185 5605 85 F6          STA HOLDER
0186 5607 A9 56          LDA #NRED4
0187 5609 85 F7          STA HOLDER+1
0188 560B 4C 7B 56      JMP KLOK
0189 560E AD 1D 50      REI4 LDA ADCL
0190 5611 8D 16 50      STA CORL4
0191 5614 AD 1E 50      LDA ADCH
0192 5617 8D 17 50      STA CORH4
0193 561A A9 00          LDA #100
0194 561C 8D 00 AC      STA PRD
0195 561F A9 34          LDA #LMP1
0196 5621 85 F6          STA HOLDER
0197 5623 A9 55          LDA #DLMP1
0198 5625 85 F7          STA HOLDER+1
0199 5627 4C 93 56      JMP TIMOFF
0200 562A A9 00          PULS LDA #100      ;TURN THE LAMP OFF.
0201 562C 8D 00 AC      STA PRD
0202 562F 20 4D 83      JSR CRLF
0203 5632 A9 F0          LDA #1F0      ;LAMP PULSING I/O PORT.
0204 5634 8D 02 AC      STA PRDD
0205 5637 A9 C0          LDA #1C0      ;SET REGISTER FOR TIMER-1.
0206 5639 8D 0B AC      STA ACR
0207 563C AD 22 50      LDA CLOCK     ;LOAD TIMER-1 LOW LATCH.
0208 563F 8D 04 AC      STA TILL
0209 5642 AD 23 50      LDA CLOCK+1   ;LOAD TIMER-1 HIGH COUNTER.
0210 5645 8D 05 AC      STA TICH
0211 5648 AD 0E 50      LDA AVCRH     ;LOAD AVE. CURRENT.
0212 564B 8D 1C 50      STA DACH
0213 564E AD 0F 50      LDA AVCRL
0214 5651 8D 1B 50      STA DACL
0215 5654 20 63 56      JSR DAK
0216 5657 A9 00          LDA #100      ;START PULSING.
0217 5659 8D 00 AC      STA PRD
0218 565C 8D 03 AB      STA DDRA     ;PROTECT THE PORTS.
0219 565F 8D 02 AB      STA DDRB
0220 5662 60            RTS
0221 5663 AD 1B 50      DAK LDA DACL     ;LOAD LOW 8 BITS

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LINE # LOC      CODE      LINE
0222 5666 49 FF          EOR #1FF     ;TWO'S COMPLEMENT
0223 5668 8D 01 AB      STA RAD
0224 566B AD 1C 50      LDA DACH     ;LOAD HIGH 4 BITS
0225 566E 49 FF          EOR #1FF

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0226 5670 0A          ASL A           ;SHIFT LEFT FOR STROBE BIT
0227 5671 8D 00 A0    STA RRD
0228 5674 EE 00 A0    INC RRD        ;STROBE DAC
0229 5677 CE 00 A0    DEC RRD
0230 567A 60          RTS
0231 567B AD 00 50    KLOK LDA DN      ;SET THE CLOCK.
0232 567E 8D 17 A4    STA SR
0233 5681 A9 80        WEET LDA #80
0234 5683 2C 02 A4    BIT ORB        ;TEST IF (CR) IS PUSHED.
0235 5686 D0 08        BNE CUT1
0236 5688 2C 17 A4    BIT SR         ;TEST IF IT IS DONE.
0237 568B 10 F4        BPL WEET
0238 568D 4C B4 56    JMP ADK
0239 5690 4C 2A 56    CUT1 JMP PULS
0240 5693 AE 03 50    TIMOFF LDX TLOOP
0241 5696 F0 16        LOOK BEQ BACK
0242 5698 AD 02 50    LDA DARK
0243 569B 8D 17 A4    STA SR
0244 569E A9 80        VEET LDA #80
0245 56A0 2C 02 A4    BIT ORB
0246 56A3 D0 0C        BNE CUT2
0247 56A5 2C 17 A4    BIT SR
0248 56A8 10 F4        BPL VEET
0249 56AA CA          DEX
0250 56AB 4C 96 56    JMP LOOK
0251 56AE 6C F6 00    BACK JMP (HOLDER)
0252 56B1 4C 2A 56    CUT2 JMP PULS
0253 56B4 A9 C5        ADK LDA #C5      ;USE INPUT #1 OF A/D.
0254 56B6 8D 00 A8    STA DRB
0255 56B9 CE 00 A8    DEC DRB        ;START CONVERSION
0256 56BC EE 00 A8    INC DRB
0257 56BF A9 40        LDA #40
0258 56C1 2C 00 A8    TEST BIT DRB    ;TEST FOR END OF CONV.
0259 56C4 D0 FB        BNE TEST
0260 56C6 AD 01 A8    LDA DRA        ;READ 8 HIGH BITS
0261 56C9 8D 1E 50    STA ADCH
0262 56CC A9 C7        LDA #C7      ;TRANSFER 4 LOW BITS
0263 56CE 8D 00 A8    STA DRB
0264 56D1 AD 01 A8    LDA DRA        ;READ 4 LOW BITS
0265 56D4 8D 1D 50    STA ADCL
0266 56D7 A2 04        LDX #04      ;REARRANGE DATA
0267 56D9 10          GO CLC
0268 56DA 4E 1E 50    LSR ADCH
0269 56DD 6E 1D 50    ROR ADCL
0270 56E0 CA          DEX
0271 56E1 D0 F6        BNE GO
0272 56E3 6C F6 00    JMP (HOLDER)
0273 56E6          ;
0274 56E6          ;***** THIS PORTION COLLECT & STORE DATA *****
0275 56E6          ;
0276 56E6 A0 00        LDY #00      ;SET Y AS COUNTER.

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LINE #	LOC	CODE	LINE	
0277	56E9	A9 00	CLEAR	LDA #000 ;CLEAR ALL DATA STORAGES.
0278	56EA	99 46 50		STA ARY11,Y
0279	56ED	99 0E 51		STA ARY22,Y
0280	56F0	99 06 51		STA ARY33,Y
0281	56F3	C8		INY
0282	56F4	C8 C8		CPY #200
0283	56F6	D0 F0		BNE CLEAR
0284	56F8	A0 00		LDY #000 ;SET Y AS POINT COUNTER.
0285	56FA	A9 0F	DATA	LDA #0FF ;SET PRD AS OUTPUT.
0286	56FC	8D 02 AC		STA PRD ;FOR LAMP PULSING.
0287	56FF	A9 00		LDA #000
0288	5701	8D 03 AB		STA DDRA ;DATA PORT INPUT.
0289	5704	A9 FF		LDA #0FF
0290	5706	8D 02 AB		STA DDRB ;CONTROL PORT OUTPUT.
0291	5709	AD 18 50	LUP	LDA LAP ;SAVE # OF LAPS/POINT.
0292	570C	8D 1F 50		STA LOP
0293	570F	AD 01 50	LUMP	LDA LAMP ;SAVE # OF LAMPS AT LOMP.
0294	5712	8D 20 50		STA LOMP ;LAMP COUNTER.
0295	5715	AD 07 50		LDA CURL1
0296	5718	8D 1B 50		STA DACL
0297	571B	AD 06 50		LDA CURH1
0298	571E	8D 1C 50		STA DACH
0299	5721	20 63 56		JSR DAK
0300	5724	A9 00		LDA #000
0301	5726	8D 00 AC		STA PRD
0302	5729	20 B9 58		JSR TIMOF
0303	572C	A9 01		LDA #001 ;CLEAR THE COUNTERS.
0304	572E	8D 00 AB		STA DRB
0305	5731	A9 02		LDA #002 ;OPEN THE GATE & COUNT DOWN.
0306	5733	8D 00 AB		STA DRB
0307	5736	20 E3 58		JSR CLOK ;CONTINUE COUNTING.
0308	5739	A9 00		LDA #000 ;STOP COUNTING.
0309	573B	8D 00 AB		STA DRB
0310	573E	A9 01		LDA #001 ;LAMP #1 ON.
0311	5740	8D 00 AC		STA PRD
0312	5743	20 CD 58		JSR DELAY ;WAIT FOR TIME CONSTANT.
0313	5746	A9 12		LDA #012 ;OPEN THE GATE & COUNT UP.
0314	5748	8D 00 AB		STA DRB
0315	574B	20 E3 58		JSR CLOK
0316	574E	A9 04		LDA #004 ;TRANSFER LOW BYTE DATA.
0317	5750	8D 00 AB		STA DRB
0318	5753	18		CLC ;CLEAR CARRY.
0319	5754	AD 01 AB		LDA DRB ;LOAD LOW 8 BITS.
0320	5757	79 46 50		ADC ARY11,Y ;ADD TO FIRST ARY.
0321	575A	99 46 50		STA ARY11,Y ;SAVE IT IN FIRST ARY.
0322	575D	A9 08		LDA #008 ;TRANSFER HIGH BYTE DATA.
0323	575F	8D 00 AB		STA DRB

```

0324 5762 AD 01 A8      LDA DRA          ;LOAD HIGH 8 BITS.
0325 5765 79 78 50      ADC ARY12,Y      ;ADD TO SECOND ARY.
0326 5768 99 78 50      STA ARY12,Y      ;SAVE IT IN SECOND ARY.
0327 576B A9 00          LDA #00
0328 576D 79 AA 50      ADC ARY13,Y      ;USE THIRD ARY FOR OVERFLOW.
0329 5770 99 AA 50      STA ARY13,Y
0330 5773 CE 20 50      NXT1 DEC LAMP     ;CHECK # OF LAMPS.
0331 5776 D0 03          BNE JMP1        ;NOT LAST ONE, GO TO NEXT.

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LINE #	LOC	CODE	LINE
0332	5778	4C A5 58	JMP OUT
0333	577B	AD 09 58	JMP1 LDA CURL2
0334	577E	8D 18 58	STA DACL
0335	5781	AD 08 58	LDA CURH2
0336	5784	8D 1C 58	STA DACH
0337	5787	20 63 56	JSR DAK
0338	578A	A9 00	LDA #00
0339	578C	8D 00 AC	STA FBD
0340	578F	20 B9 58	JSR TIMOF
0341	5792	A9 01	LDA #01
0342	5794	8D 00 A8	STA DRB
0343	5797	A9 02	LDA #02
0344	5799	8D 00 A8	STA DRB
0345	579C	20 E3 58	JSR CLOK
0346	579F	A9 00	LDA #00
0347	57A1	8D 00 A8	STA DRB
0348	57A4	A9 02	LDA #02 ;LAMP #2 ON
0349	57A6	8D 00 AC	STA FBD
0350	57A9	20 CD 58	JSR DELAY
0351	57AC	A9 12	LDA #12
0352	57AE	8D 00 A8	STA DRB
0353	57B1	20 E3 58	JSR CLOK
0354	57B4	A9 04	LDA #04
0355	57B6	8D 00 A8	STA DRB
0356	57B9	18	CLC
0357	57BA	AD 01 A8	LDA DRA
0358	57BD	79 DC 50	ADC ARY21,Y
0359	57C0	99 DC 50	STA ARY21,Y
0360	57C3	A9 08	LDA #08
0361	57C5	8D 00 A8	STA DRB
0362	57C8	AD 01 A8	LDA DRA
0363	57CB	79 0E 51	ADC ARY22,Y
0364	57CE	99 0E 51	STA ARY22,Y
0365	57D1	A9 00	LDA #00
0366	57D3	79 40 51	ADC ARY23,Y
0367	57D6	99 40 51	STA ARY23,Y
0368	57D9	CE 20 50	NXT2 DEC LAMP
0369	57DC	D0 03	BNE JMP2

0370	57DE	4C A5 58	JMP CUT	
0371	57E1	AD 0E 50	JMP2 LDA CURL3	
0372	57E4	8D 1B 50	STA IACL	
0373	57E7	AD 0A 50	LDA CURH3	
0374	57EA	8D 1C 50	STA IACH	
0375	57ED	20 63 56	JSR IAK	
0376	57F0	A9 00	LDA #00	
0377	57F2	8D 00 AC	STA PBD	
0378	57F5	20 B9 58	JSR TIMOF	
0379	57F8	A9 01	LDA #01	
0380	57FA	8D 00 AB	STA DRB	
0381	57FD	A9 02	LDA #02	
0382	57FF	8D 00 AB	STA DRB	
0383	5802	20 E3 58	JSR CLOK	
0384	5805	A9 00	LDA #00	
0385	5807	8D 00 AB	STA DRB	
0386	580A	A9 04	LDA #04	;LAMP #3 DN.

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LINE #	LOC	CODE	LINE
0387	580C	8D 00 AC	STA PBD
0388	580F	20 CD 58	JSR DELAY
0389	5812	A9 12	LDA #12
0390	5814	8D 00 AB	STA DRB
0391	5817	20 E3 58	JSR CLOK
0392	581A	A9 04	LDA #04
0393	581C	8D 00 AB	STA DRB
0394	581F	18	CLC
0395	5820	AD 01 AB	LDA DRA
0396	5823	79 72 51	ADC ARY31,Y
0397	5826	99 72 51	STA ARY31,Y
0398	5829	A9 08	LDA #08
0399	582B	8D 00 AB	STA DRB
0400	582E	AD 01 AB	LDA DRA
0401	5831	79 A4 51	ADC ARY32,Y
0402	5834	99 A4 51	STA ARY32,Y
0403	5837	A9 00	LDA #00
0404	5839	79 D6 51	ADC ARY33,Y
0405	583C	99 D6 51	STA ARY33,Y
0406	583F	CE 20 50	NXT3 DEC LAMP
0407	5842	D0 03	BNE JMP3
0408	5844	4C A5 58	JMP CUT
0409	5847	AD 0D 50	JMP3 LDA CURL4
0410	584A	8D 1B 50	STA IACL
0411	584D	AD 0C 50	LDA CURH4
0412	5850	8D 1C 50	STA IACH
0413	5853	20 63 56	JSR IAK
0414	5856	A9 00	LDA #00
0415	5858	8D 00 AC	STA PBD
0416	585B	20 B9 58	JSR TIMOF

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0417 585E A9 01      LDA #01
0418 5860 8D 00 A8   STA DRB
0419 5863 A9 02      LDA #02
0420 5865 8D 00 A8   STA DRB
0421 5868 20 E3 58   JSR CLOK
0422 586B A9 00      LDA #00
0423 586D 8D 00 A8   STA DRB
0424 5870 A9 08      LDA #08      ;LAMP #4 ON
0425 5872 8D 00 AC   STA FRD
0426 5875 20 CD 58   JSR DELAY
0427 5878 A9 12      LDA #12
0428 587A 8D 00 A8   STA DRB
0429 587D 20 E3 58   JSR CLOK
0430 5880 A9 04      LDA #04
0431 5882 8D 00 A8   STA DRB
0432 5885 18          CLC
0433 5886 AD 01 A8      LDA DRA
0434 5889 79 08 52   ADC ARY41,Y
0435 588C 99 08 52   STA ARY41,Y
0436 588F A9 08      LDA #08
0437 5891 8D 00 A8   STA DRB
0438 5894 AD 01 A8      LDA DRA
0439 5897 79 3A 52   ADC ARY42,Y
0440 589A 99 3A 52   STA ARY42,Y
0441 589D A9 00      LDA #00

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LINE #	LOC	CODE	LINE	
0442	589F	79 6C 52	ADC ARY43,Y	
0443	58A2	99 6C 52	STA ARY43,Y	
0444	58A5	CE 1F 50	OUT DEC LOP	;ALL LAPS DONE?
0445	58A8	F0 03	BEQ GETOT	;YES, GO FOR NEXT POINT.
0446	58AA	4C 0F 57	JMP LUMP	;NO, START AGAIN.
0447	58AD	08	GETOT INY	
0448	58AE	CC 19 50	CPY POINT	;ALL THE POINTS COLLECTED!
0449	58B1	F0 03	BEQ OUT	;YES, GO OUT.
0450	58B3	4C 09 57	JMP LUP	;NO, DO THE NEXT.
0451	58B6	4C 2A 56	OUT JMP PULS	
0452	58B9	AE 04 50	TIMOF LOX TIMLOP	;# OF TIME LOOP(1 OR 5)
0453	58BC	F0 0F	DOIT BEQ DELAY	
0454	58BE	AD 05 50	LDA OFF	
0455	58C1	8D 17 A4	STA SR	
0456	58C4	2C 17 A4	VAIT BIT SR	
0457	58C7	10 FB	RPL VAIT	
0458	58C9	CA	DEX	
0459	58CA	4C BC 58	JMP DOIT	
0460	58CD	AD 24 50	DELAY LDA TM	
0461	58D0	8D 25 50	STA HT	
0462	58D3	A9 32	DLAY LDA #50	;DELAY TIME FOR TIME CONSTANT


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0463 58D5 8D 14 A4          STA PW
0464 58D8 2C 17 A4      WAIT BIT SR
0465 58DB 10 FB          BPL WAIT
0466 58DD 0E 25 50          DEC MT
0467 58E0 D0 F1          RNE DLAY
0468 58E2 60              RTS
0469 58E3 AE 21 50      CLOK LDY REED
0470 58E6 F0 0F      WATCH BEQ STUP
0471 58E8 AD 1A 50          LDA RD
0472 58EB 8D 14 A4          STA PW
0473 58EE 2C 17 A4      LOOP BIT SR
0474 58F1 10 FB          BPL LOOP
0475 58F3 CA              DEX
0476 58F4 4C E6 58          JMP WATCH
0477 58F7 60              STUP RTS
0478 58F8                .END

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SYMBOL TABLE

SYMBOL VALUE

ACR	AC0B	ADCH	501E	ADCL	501D	ADK	56B4
ARY11	5046	ARY12	5078	ARY13	50AA	ARY21	50DC
ARY22	510E	ARY23	5140	ARY31	5172	ARY32	51A4
ARY33	51D6	ARY41	5208	ARY42	523A	ARY43	526C
AVCRH	500E	AVCRL	500F	BACK	56AE	CLEAR	56E8
CLOCK	5022	CLOK	58E3	CORH1	5011	CORH2	5013
CORH3	5015	CORH4	5017	CORL1	5010	CORL2	5012
CORL3	5014	CORL4	5016	CRLF	834D	CURH1	5006
CURH2	5008	CURH3	500A	CURH4	500C	CURL1	5007
CURL2	5009	CURL3	500B	CURL4	500D	CUT	58A5
CUT1	5690	CUT2	56B1	DACH	501C	DACL	501B
DAK	5663	DARK	5002	DATA	56FA	DDRA	A003
DDRB	A002	DELAY	58CD	DLAY	58D3	DDIT	58BC
DRA	A001	DRB	A000	FOUR	55EF	GETOT	58AD
GO	56D9	HOLDER	00F6	JMP1	577B	JMP2	57E1
JMP3	5847	KLOK	567B	LAMP	5001	LAP	5018
LMP1	5534	LMP2	5571	LMP3	55AC	LMP4	55E7
LOMP	5020	LOOK	5696	LOOP	58EE	LOP	501F
LUMP	570F	LUP	5709	MT	5025	NXT1	5773
NXT2	57D9	NXT3	583F	OFF	5005	ON	5000
ORB	A402	OUT	58B6	PAD	AC01	FADD	AC03
PRD	AC00	PRDD	AC02	POINT	5019	PULS	562A
PW	A414	RAD	A001	RADD	A003	RBI	A000
RBDD	A002	RD	501A	RED1	5559	RED2	5594
RED3	55CF	RED4	560E	REED	5021	SR	A417
STUP	58F7	T1CH	AC05	TILL	AC04	TEST	56C1
THREE	55B4	TINLOP	5004	TINOF	58B9	TIMOFF	5693
TLOOP	5003	TM	5024	TWO	5579	WAIT	58C4
VEET	569E	WAIT	58DB	WATCH	58E6	WEET	5681

END OF ASSEMBLY

MULTI-AD

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5 REM THIS PROG TAKES DATA FROM MEMORY, COMPUTES AVR., STD DIV & S/N
10 PRINT
15 DIM L1(35),L2(35),L3(35),L4(35),M1(20),M2(20),M3(20),M4(20),M5(20)
20 PRINT
25 PRINT "HC #1"
30 PRINT "HC #2"
35 PRINT "HC #3"
40 PRINT "HC #4"
45 REM TO START PULSING LAMPS.
50 PRINT
55 PRINT" TIME ON"
60 INPUT" T1=";T1
65 POKE 20480,T1
70 PRINT
75 PRINT" XTIME ON"
80 INPUT" PC=";PC
85 PRINT
90 PRINT" # OF LAMP"
95 INPUT" LM=";LM
100 POKE 20481,LM
105 PRINT
110 REM RESISTOR USED FOR POWER TRANSISTOR (EMIT-GND)
115 PRINT" RESISTOR VALUE"
120 INPUT" R=";R
125 PRINT
130 T2=T1*(((100/(PC*LM))-1)
135 POKE 20483,01
140 IF T2<255 THEN A=T2: GOTO 155
145 A=INT((T2/5)+.5)
150 POKE 20483,05
155 POKE 20482,A
160 IF T1>T2 THEN PRINT"LARGE XTIME ON": GOTO 50
165 CK=(T1*1000/2)-2
170 A=INT(CK/256)
175 POKE 20515,A
180 B=CK-(A*256)
185 POKE 20514,B
190 OF=T2-T1
195 POKE 20484,01
200 IF OF<255 THEN A=OF: GOTO 215
205 A=INT((OF/5)+.5)
210 POKE 20484,05
215 POKE 20485,A
220 ML=LM
225 PRINT"H.C. AVE. MAMP CURRENTS"

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```
230 PRINT
235 C1=0
240 C2=0
245 C3=0
250 C4=0
255 PRINT" H.C.#1 CURRENT"
260 INPUT" C1=";C1
265 PRINT
270 REM CURRENT CORRECTION FOR RESISTOR VALUE.
275 H=(10-R)*PC/2.5
280 V1=(C1*4.2*R)-(H/C1)
285 REM LAMPS' CURRENT CORRECTION FOR PC NOT EQUAL TO 12.5%
290 MA=(V1*12.5)/PC
295 A=INT(MA/256)
300 IF A<=15 THEN 315
305 PRINT" NOT ACCEPTABLE, CHANGE C1 OR R VALUE": GOTO 50
310 PRINT
315 POKE 20486,A
320 B=MA-(A*256)
325 POKE 20487,B
330 IF ML-1=0 THEN 525
335 PRINT" H.C.# 2 CURRENT"
340 INPUT" C2=";C2
345 PRINT
350 V2=(C2*4.2*R)-(H/C2)
355 MA=(V2*12.5)/PC
360 A=INT(MA/256)
365 IF A<=15 THEN 380
370 PRINT" NOT ACCEPTABLE, CHANGE C2 OR R VALUE": GOTO 50
375 PRINT
380 POKE 20488,A
385 B=MA-(A*256)
390 POKE 20489,B
395 IF ML-2=0 THEN 525
400 PRINT" H.C.#3 CURRENT"
405 INPUT" C3=";C3
410 PRINT
415 V3=(C3*4.2*R)-(H/C3)
420 MA=(V3*12.5)/PC
425 A=INT(MA/256)
430 IF A<=15 THEN 445
435 PRINT" NOT ACCEPTABLE, CHANGE C3 OR R VALUE": GOTO 50
440 PRINT
445 POKE 20490,A
450 B=MA-(A*256)
455 POKE 20491,B
460 IF ML-3=0 THEN 525
465 PRINT" H.C.#4 CURRENT"
470 INPUT" C4=";C4
475 PRINT
480 V4=(C4*4.2*R)-(H/C4)
```

```

485 MA=(V4*12.5)/PC
490 A=INT(MA/256)
495 IF A<=15 THEN 510
500 PRINT" NOT ACCEPTABLE, CHANGE C4 OR R VALUE": GOTO 50
505 PRINT
510 POKE 20492,A
515 B=MA-(A*256)
520 POKE 20493,B
525 AV=(C1+C2+C3+C4)/LM
530 AV=(AV*4.2*R)-(H/AV)
535 A=INT(AV/256)
540 POKE 20494,A
545 B=AV-(A*256)
550 POKE 20495,B
555 PRINT
560 PRINT" T1=";T1,"PC=";PC,"LM=";LM,"R=";R
565 PRINT" C1=";C1,"C2=";C2,"C3=";C3,"C4=";C4
570 PRINT
575 PRINT" ARE THESE VALUES CORRECT? YES=1,NO=0"
580 INPUT" ANS=";Y
585 IF Y=0 THEN 50
590 PRINT
595 PRINT" READY TO READ CURRENT! PUSH (CR). "
600 Z=USR(8"4500",00)
605 REM CURRENT READING BY A/D ACROSS ABOVE RESISTOR
610 A=PEEK(20496)
615 B=PEEK(20497)
620 C=((B*256)+A)*10000/(4095*R)
625 D=INT(C+.5)
630 PRINT
635 PRINT" PEAK TO PEAK CURRENTS"
640 PRINT
645 PRINT" H.C.#1 CURRENT=";D;" MAMP"
650 A=PEEK(20498)
655 B=PEEK(20499)
660 C=((B*256)+A)*10000/(4095*R)
665 D=INT(C+.5)
670 PRINT" H.C.#2 CURRENT=";D;" MAMP"
675 A=PEEK(20500)
680 B=PEEK(20501)
685 C=((B*256)+A)*10000/(4095*R)
690 D=INT(C+.5)
695 PRINT" H.C.#3 CURRENT=";D;" MAMP"
700 A=PEEK(20502)
705 B=PEEK(20503)
710 C=((B*256)+A)*10000/(4095*R)
715 D=INT(C+.5)
720 PRINT" H.C.#4 CURRENT=";D;" MAMP"
725 PRINT
730 PRINT" READ MORE YES=1,NO=0"
735 INPUT" ANS=";Y

```

```

740 IF Y=0 THEN 775
745 PRINT
750 PRINT" ANY CHANGE YES=1,NO=0"
755 INPUT" ANS=";Y
760 PRINT
765 IF Y>0 THEN 220
770 IF Y=0 THEN 590
775 PRINT
780 PRINT" # OF LAPS"
785 INPUT" LP=";LP
790 POKE 20504,LP
795 PRINT
800 PRINT" # OF POINT"
805 INPUT" FT=";PT
810 POKE 20505,PT
815 PRINT
820 PRINT" RF VALUE (N-OHM)"
825 INPUT" RF=";RF
830 PRINT
835 PRINT" CF VALUE (P-F)"
840 INPUT" CF=";CF
845 TM=INT((5*RF*CF/50)+.5)
850 DT=TM*.05
855 POKE 20516,TM
860 OF=T2-T1
865 POKE 16388,01
870 IF OF<255 THEN A=OF: GOTO 885
875 A=INT((OF/5)+.5)
880 POKE 16388,05
885 POKE 16389,A
890 RD=INT(((T1-DT)/.2)+.5)
895 POKE 20506,RD
900 PRINT
905 PRINT" # OF RUNS"
910 INPUT" RN=";RN
915 PRINT
920 PRINT" PMT VOLTAGE"
925 INPUT" PM=";PM
930 PRINT
935 IF PM=400 THEN GM=2.75E03
940 IF PM=500 THEN GM=1.5E04
945 IF PM=600 THEN GM=6.8E04
950 IF PM=700 THEN GM=2.25E05
955 IF PM=800 THEN GM=6.8E05
960 IF PM=900 THEN GM=1.9E06
965 IF PM=1000 THEN GM=5E06
970 REM NOISE EQUIVALENT BANDPASS 1/S.
975 DF=1000/(2*(T1-DT)*LP)
980 G=(LOG(GM)/LOG(10))/9
985 GA=104G
990 KK=2*1.6E-19*DF*(1+1/(GA-1))

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```
995 ZA=GH*RF*KK*(1E06)
1000 PRINT" CALIBRATION CURVE YES=1, NO=0."
1005 INPUT" ANS=";CC
1010 IF CC=1 THEN 2565
1015 PRINT
1020 REM ABOVE SECTION INITIALIZES USER DEFINED VARIABLES.
1025 REM THE NEXT SECTION COLLECTS BLANK DATA FROM MEMORY.
1030 Q=0
1035 REM FOR FIRST RUN
1040 PRINT
1045 POKE 44033,00
1050 REM TO START SAMPLER FOR BLANK.
1055 PRINT" DO YOU WANT DARK DATA? YES=1,NO=0"
1060 INPUT" DK=";DK
1065 IF DK=0 THEN 1125
1070 PRINT
1075 PRINT" COVER ENTRANCE SLIT & PUSH (CR)."
```

```

1250 POKE 44033,00
1255 GOSUB 1855
1260 IF CC=0 THEN 1270
1265 RETURN
1270 GOSUB 2215
1275 Q=Q+1
1280 IF Q<RN THEN 1040
1285 PRINT "EXTRA RUN YES=1 NO=0"
1290 INPUT "ANS=";Y
1295 IF Y=0 THEN 3020
1300 PRINT
1305 PRINT "CHANGE VARIABLES: UPPER SEC.=2, LOWER SEC.=1, NO=0"
1310 INPUT "ANS=";Y
1315 IF Y=0 THEN 1040
1320 IF Y=1 THEN 775
1325 IF Y=2 THEN 50
1330 PRINT
1335 REM THIS SUB TAKES DATA FROM MEMORY FOR EACH LAMP.
1340 N=PT-1
1345 FOR J=0 TO N
1350 A=PEEK(20550+J)
1355 B=PEEK(20600+J)
1360 C=PEEK(20650+J)
1365 REM A,B,C THREE BYTES WHICH CONTAIN THE JTH
1370 REM DATA POINT A THE LEAST SIG FIG. & C MOST SIG FIG.
1375 D=(C*256)+B
1380 C=(D*256)+A
1385 A=PEEK(20700+J)
1390 B=PEEK(20750+J)
1395 D=PEEK(20800+J)
1400 E=(D*256)+B
1405 D=(E*256)+A
1410 L1(J)=(10000*(C-D))/(RD*4095)
1415 A=PEEK(20850+J)
1420 B=PEEK(20900+J)
1425 C=PEEK(20950+J)
1430 D=(C*256)+B
1435 C=(D*256)+A
1440 A=PEEK(21000+J)
1445 B=PEEK(21050+J)
1450 D=PEEK(21100+J)
1455 E=(D*256)+B
1460 D=(E*256)+A
1465 L2(J)=(10000*(C-D))/(RD*4095)
1470 A=PEEK(21150+J)
1475 B=PEEK(21200+J)
1480 C=PEEK(21250+J)
1485 D=(C*256)+B
1490 C=(D*256)+A
1495 A=PEEK(21300+J)
1500 B=PEEK(21350+J)

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```
1505 D=PEEK(21400+J)
1510 E=(D*256)+B
1515 D=(E*256)+A
1520 L3(J)=(10000*(C-D))/(RD*4095)
1525 A=PEEK(21450+J)
1530 B=PEEK(21500+J)
1535 C=PEEK(21550+J)
1540 D=(C*256)+B
1545 C=(D*256)+A
1550 A=PEEK(21600+J)
1555 B=PEEK(21650+J)
1560 D=PEEK(21700+J)
1565 E=(D*256)+B
1570 D=(E*256)+A
1575 L4(J)=(10000*(C-D))/(RD*4095)
1580 NEXT J
1585 RETURN
1590 REM THIS SUB. FINDS MEANS AND STD DIV. IN BLANK & DARK.
1595 K1=0
1600 K2=0
1605 K3=0
1610 K4=0
1615 N=PT-1
1620 FOR J=0 TO N
1625 K1= K1+L1(J)
1630 K2= K2+L2(J)
1635 K3= K3+L3(J)
1640 K4= K4+L4(J)
1645 NEXT J
1650 K1=K1/PT
1655 K2=K2/PT
1660 K3=K3/PT
1665 K4=K4/PT
1670 PRINT INT(K1+.5),INT(K2+.5),INT(K3+.5),INT(K4+.5)
1675 F1=0
1680 F2=0
1685 F3=0
1690 F4=0
1695 G1=0
1700 G2=0
1705 G3=0
1710 G4=0
1715 FOR J=0 TO N
1720 F1= L1(J)-K1
1725 G1=(F1*F1)+G1
1730 F2= L2(J)-K2
1735 G2=(F2*F2)+G2
1740 F3= L3(J)-K3
1745 G3=(F3*F3)+G3
1750 F4= L4(J)-K4
1755 G4=(F4*F4)+G4
```



```

1760 NEXT J
1765 S1= SQR(G1/N)
1770 S2= SQR(G2/N)
1775 S3= SQR(G3/N)
1780 S4= SQR(G4/N)
1785 A=INT(S1*100+.5)/100
1790 B=INT(S2*100+.5)/100
1795 C=INT(S3*100+.5)/100
1800 D=INT(S4*100+.5)/100
1805 PRINT A,B,C,D
1810 PRINT
1815 PRINT"PRINT DATA YES=1,NO=0"
1820 INPUT" ANS=";Y
1825 PRINT
1830 IF Y=0 THEN 1850
1835 FOR J=0 TO N
1840 PRINT INT(L1(J)+.5),INT(L2(J)+.5),INT(L3(J)+.5),INT(L4(J)+.5)
1845 NEXT J
1850 RETURN
1855 REM THIS SUB. FINDS MEAN & STD DIV. OF TOTAL SIGNAL.
1860 T1=0
1865 T2=0
1870 T3=0
1875 T4=0
1880 N=PT-1
1885 FOR J=0 TO N
1890 T1=L1(J)+T1
1895 T2=L2(J)+T2
1900 T3=L3(J)+T3
1905 T4=L4(J)+T4
1910 NEXT J
1915 T1=T1/PT
1920 T2=T2/PT
1925 T3=T3/PT
1930 T4=T4/PT
1935 PRINT INT(T1+.5),INT(T2+.5),INT(T3+.5),INT(T4+.5)
1940 Z1=ZA*T1/1000
1945 Z2=ZA*T2/1000
1950 Z3=ZA*T3/1000
1955 Z4=ZA*T4/1000
1960 IF Z1<0 THEN ZA=0: GOTO 1970
1965 ZA=SQR(Z1)
1970 IF Z2<0 THEN ZB=0: GOTO 1980
1975 ZB=SQR(Z2)
1980 IF Z3<0 THEN ZC=0: GOTO 1990
1985 ZC=SQR(Z3)
1990 IF Z4<0 THEN ZD=0: GOTO 2000
1995 ZD=SQR(Z4)
2000 H1=0
2005 H1=0
2010 H2=0

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```
2015 N2=0
2020 H3=0
2025 N3=0
2030 H4=0
2035 N4=0
2040 FOR J=0 TO N
2045 H1=L1(J)-T1
2050 N1=(H1*H1)+N1
2055 H2=L2(J)-T2
2060 N2=(H2*H2)+N2
2065 H3=L3(J)-T3
2070 N3=(H3*H3)+N3
2075 H4=L4(J)-T4
2080 N4=(H4*H4)+N4
2085 NEXT J
2090 V1=SQR(N1/N)
2095 V2=SQR(N2/N)
2100 V3=SQR(N3/N)
2105 V4=SQR(N4/N)
2110 A=INT(V1*100+.5)/100
2115 B=INT(V2*100+.5)/100
2120 C=INT(V3*100+.5)/100
2125 D=INT(V4*100+.5)/100
2130 PRINT A,B,C,D
2135 GOSUB 1810
2140 PRINT
2145 PRINT" RMS SHOT NOISE (VOLTAGE)"
2150 PRINT
2155 PRINT ZA,ZB,ZC,ZD
2160 PRINT
2165 PRINT "NET SIGNAL"
2170 PRINT
2175 REM THIS SUBROUTINE FINDS THE NET SIGNAL.
2180 X1=T1-K1
2185 X2=T2-K2
2190 X3=T3-K3
2195 X4=T4-K4
2200 PRINT INT(X1+.5),INT(X2+.5),INT(X3+.5),INT(X4+.5)
2205 PRINT
2210 RETURN
2215 PRINT" NET SIGNAL/BLANK STD DIV."
2220 REM THIS SUBROUTINE FINDS RATIO OF NET SIGNAL TO
2225 REM BLANK NOISE & NET SIGNAL TO TOTAL NOISE.
2230 IF S1<=0 THEN 2240
2235 P1=X1/S1
2240 IF S2<=0 THEN 2250
2245 P2=X2/S2
2250 IF S3<=0 THEN 2260
2255 P3=X3/S3
2260 IF S4<=0 THEN 2270
2265 P4=X4/S4
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2270 PRINT
2275 A=INT(P1*10+.5)/10
2280 B=INT(P2*10+.5)/10
2285 C=INT(P3*10+.5)/10
2290 D=INT(P4*10+.5)/10
2295 PRINT A,B,C,D
2300 PRINT
2305 PRINT" NET SIGNAL/TOTAL NOISE"
2310 Q1=SQR((S1+S1)+(V1*V1))
2315 Q2=SQR((S2+S2)+(V2*V2))
2320 Q3=SQR((S3+S3)+(V3*V3))
2325 Q4=SQR((S4+S4)+(V4*V4))
2330 IF Q1=0 THEN 2340
2335 W1=X1/Q1
2340 IF Q2=0 THEN 2350
2345 W2=X2/Q2
2350 IF Q3=0 THEN 2360
2355 W3=X3/Q3
2360 IF Q4=0 THEN 2370
2365 W4=X4/Q4
2370 PRINT
2375 A=INT(W1*10+.5)/10
2380 B=INT(W2*10+.5)/10
2385 C=INT(W3*10+.5)/10
2390 D=INT(W4*10+.5)/10
2395 PRINT A,B,C,D
2400 PRINT
2405 PRINT" CONC. OF SOLN. #1 (PPM)"
2410 INPUT" G1=";G1
2415 PRINT
2420 IF ML-1=0 THEN 2480
2425 PRINT" CONC. OF SOLN. #2 (PPM)"
2430 INPUT" G2=";G2
2435 PRINT
2440 IF ML-2=0 THEN 2480
2445 PRINT" CONC. OF SOLN. #3 (PPM)"
2450 INPUT" G3=";G3
2455 PRINT
2460 IF ML-3=0 THEN 2480
2465 PRINT" CONC. OF SOLN. #4 (PPM)"
2470 INPUT" G4=";G4
2475 PRINT
2480 IF P1=0 THEN Y1=0: GOTO 2495
2485 D1=2*G1/P1
2490 Y1=INT((D1*1000)+.5)/1000
2495 IF P2=0 THEN Y2=0: GOTO 2510
2500 D2=2*G2/P2
2505 Y2=INT((D2*1000)+.5)/1000
2510 IF P3=0 THEN Y3=0: GOTO 2525
2515 D3=2*G3/P3
2520 Y3=INT((D3*1000)+.5)/1000
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2525 IF P4=0 THEN Y4=0: GOTO 2540
2530 D4=2*G4/P4
2535 Y4=INT((D4*1000)+.5)/1000
2540 PRINT" DETECTION LIMITS (PPM)"
2545 PRINT"-----"
2550 PRINT Y1,Y2,Y3,Y4
2555 PRINT
2560 RETURN
2565 REM THIS SUB. IS FOR CALIB. CURVE & UNK. CALCULATIONS.
2570 PRINT
2575 PRINT" # OF STANDARDS"
2580 INPUT" SD=";SD
2585 PRINT
2590 PRINT" INTER THE CONCENTRATION OF STANDARDS."
2595 PRINT
2600 F=SD-1
2605 FOR I=0 TO F
2610 PRINT I+1;
2615 INPUT J
2620 PRINT
2625 M5(I)=J
2630 NEXT I
2635 PRINT
2640 PRINT" # OF RUNS PER SAMPLE"
2645 INPUT" RN=";RN
2650 PRINT
2655 PRINT" CALIBRATION CURVE DATA."
2660 PRINT"-----"
2665 FOR H=0 TO F
2670 A1=0:A2=0:A3=0:A4=0
2675 K=RN-1
2680 FOR I=0 TO K
2685 GOSUB 1015
2690 A1=A1+X1
2695 A2=A2+X2
2700 A3=A3+X3
2705 A4=A4+X4
2710 NEXT I
2715 M1(H)=A1/RN
2720 M2(H)=A2/RN
2725 M3(H)=A3/RN
2730 M4(H)=A4/RN
2735 NEXT H
2740 PRINT" CONC.          NET AVE. SIGNAL."
2745 FOR H=0 TO F
2750 PRINT
2755 PRINT M5(H),INT(M1(H)),INT(M2(H)),INT(M3(H)),INT(M4(H))
2760 NEXT H
2765 PRINT
2770 L=0
2775 PRINT" WHAT ARE THE 1ST & 2ND POINTS FOR THE SLOPE CALC."
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2780 INPUT " 1ST=";N
2785 INPUT " 2ND=";K
2790 S1=0:S2=0:S3=0:S4=0
2795 N=N-1
2800 K=K-2
2805 FOR J=N TO K
2810 W=M5(J+1)-M5(J)
2815 S1=(M1(J+1)-M1(J))/W+S1
2820 S2=(M2(J+1)-M2(J))/W+S2
2825 S3=(M3(J+1)-M3(J))/W+S3
2830 S4=(M4(J+1)-M4(J))/W+S4
2835 NEXT J
2840 PRINT
2845 PRINT " SLOPES OF CALIB. CURVES"
2850 PRINT
2855 PRINT INT(S1+.5),INT(S2+.5),INT(S3+.5),INT(S4+.5)
2860 PRINT
2865 IF L=1 THEN 2955
2870 PRINT "DO YOU RUN UNKNOWN YES=1, NO=0"
2875 INPUT " ANS=";Y
2880 IF Y=0 THEN 2995
2885 A1=0:A2=0:A3=0:A4=0
2890 K=RN-1
2895 FOR H=0 TO K
2900 GOSUB 1015
2905 A1=A1+(X1/RN)
2910 A2=A2+(X2/RN)
2915 A3=A3+(X3/RN)
2920 A4=A4+(X4/RN)
2925 NEXT H
2930 PRINT
2935 PRINT " NET UNK. SIGNAL."
2940 PRINT
2945 PRINT INT(A1+.5),INT(A2+.5),INT(A3+.5),INT(A4+.5)
2950 PRINT
2955 PRINT " CONCENTRATION OF UNK."
2960 PRINT
2965 IF S1=0 THEN A1/S1=0
2970 IF S2=0 THEN A2/S2=0
2975 IF S3=0 THEN A3/S3=0
2980 IF S4=0 THEN A4/S4=0
2985 PRINT A1/S1,A2/S2,A3/S3,A4/S4
2990 PRINT
2995 PRINT " CALCULATE THE SLOPE AGAIN YES=1, NO=0"
3000 INPUT " ANS=";L
3005 PRINT
3010 IF L=1 THEN 2775
3015 GOTO 1285
3020 END

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OK

2B

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LINE #	LOC	CODE	LINE
0002	0000		: THIS PROGRAM IS A PART OF A BASIC PROGRAM
0003	0000		: WHICH RUNS TMS INSTRUMENT & COLLECT DATA.
0004	0000		:***** I/O PORTS *****
0005	0000		;
0006	0000	RBD=\$A000	;DAC'S STB. & 4 HIGH BITS.
0007	0000	RBD=\$A002	
0008	0000	RAD=\$A001	;DAC'S 8 LOW BITS.
0009	0000	RADD=\$A003	
0010	0000	DRB=\$A402	
0011	0000	DRB=\$A800	;ADC'S CONTROL BITS.
0012	0000	DDR=\$A802	
0013	0000	DRA=\$A801	;ADC'S DATA BITS.
0014	0000	DDRA=\$A803	
0015	0000	PBD=\$AC00	;H.C. LAMP PULSING & CLOCK.
0016	0000	PBD=\$AC02	
0017	0000	PAD=\$AC01	;SAMPLER CONTROL.
0018	0000	PAD=\$AC03	
0019	0000	TILL=\$AC04	;LOW-ORDER LATCH TIMER-1.
0020	0000	TICH=\$AC05	;HIGH-ORDER COUNTER.
0021	0000	ACR=\$AC0B	;AUXILIARY CONTROL REGISTER.
0022	0000	PW=\$A414	;1T (1 USEC)
0023	0000	SR=\$A417	;1024T (1 MSEC)
0024	0000	CRLF=\$834D	
0025	0000		;
0026	0000		;***RESERVED MEMORY LOCATIONS FOR VARIABLES***.
0027	0000		*\$5000
0028	5000	ON	*==+1
0029	5001	LAMP	*==+1
0030	5002	DARK	*==+1
0031	5003	TLOOP	*==+1
0032	5004	TIMLOP	*==+1
0033	5005	OFF	*==+1
0034	5006	CURH1	*==+1
0035	5007	CURL1	*==+1
0036	5008	CURH2	*==+1
0037	5009	CURL2	*==+1
0038	500A	CURH3	*==+1
0039	500B	CURL3	*==+1
0040	500C	CURH4	*==+1
0041	500D	CURL4	*==+1
0042	500E	AVCRH	*==+1

0043	500F	AVCRL	*==+1
0044	5010	CORL1	*==+1
0045	5011	CORH1	*==+1
0046	5012	CORL2	*==+1
0047	5013	CORH2	*==+1
0048	5014	CORL3	*==+1
0049	5015	CORH3	*==+1
0050	5016	CORL4	*==+1
0051	5017	CORH4	*==+1
0052	5018	LAP	*==+1
0053	5019	POINT	*==+1
0054	501A	READ	*==+1
0055	501B	DIACL	*==+1
0056	501C	DACH	*==+1

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LINE #	LOC	CODE	LINE
0057	501D	ADCL	*==+1
0058	501E	ADCH	*==+1
0059	501F	LOP	*==+1
0060	5020	LOMP	*==+1
0061	5021	REED	*==+1
0062	5022	CLOCK	*==+2
0063	5024	TM	*==+1
0064	5025	MT	*==+1
0065	5026		*=\$00F6
0066	00F6	HOLDER	*==+2
0067	00F8		;
0068	00F8		;**** MEMORY LOCATIONS RESERVED FOR DATA STORAGE ****
0069	00F8		;
0070	00F8		ARY11=\$5046
0071	00F8		ARY12=\$507B
0072	00F8		ARY13=\$50AA
0073	00F8		ARY1A=\$50DC
0074	00F8		ARY1B=\$510E
0075	00F8		ARY1C=\$5140
0076	00F8		ARY21=\$5172
0077	00F8		ARY22=\$51A4
0078	00F8		ARY23=\$51D6
0079	00F8		ARY2A=\$5208
0080	00F8		ARY2B=\$523A
0081	00F8		ARY2C=\$526C
0082	00F8		ARY31=\$529E
0083	00F8		ARY32=\$52D0
0084	00F8		ARY33=\$5302
0085	00F8		ARY3A=\$5334
0086	00F8		ARY3B=\$5366
0087	00F8		ARY3C=\$5398
0088	00F8		ARY41=\$53CA

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0089 00F8      ARY42=$53FC
0090 00F8      ARY43=$542E
0091 00F8      ARY4A=$5460
0092 00F8      ARY4B=$5492
0093 00F8      ARY4C=$54C4
0094 00F8      ;*** INITIALIZATION OF DATA DIRECTION ***
0095 00F8      ;
0096 00F8      ;
0097 5500 A9 FF      LDA #$FF      ;OUTPUT PORT FOR DAC
0098 5502 8D 03 A0    STA RADD
0099 5505 8D 02 A0    STA RBDD
0100 5508 A9 0F      LDA #$0F      ;LAMP PULSING I/O PORT
0101 550A 8D 02 AC    STA PBDD
0102 550D 8D 03 AC    STA PADD      ;SAMPLER I/O PORT
0103 5510 A9 00      LDA #$00      ;ADC DATA INPUT
0104 5512 8D 03 AB    STA DDRA
0105 5515 A9 3F      LDA #$3F      ;ADC CONTROL PORT
0106 5517 8D 02 AB    STA DDRB
0107 551A      ;
0108 551A      ;***** H.C. LAMP,S CURRENT READING *****
0109 551A      ;
0110 551A A9 00      LDA #$00      ;CLEAR ALL FOLLOWING LOC.
0111 551C 8D 10 50    STA CORL1

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LINE #	LOC	CODE	LINE	
0112	551F	8D 11 50		STA CORH1
0113	5522	8D 12 50		STA CORL2
0114	5525	8D 13 50		STA CORH2
0115	5528	8D 14 50		STA CORL3
0116	552B	8D 15 50		STA CORH3
0117	552E	8D 16 50		STA CORL4
0118	5531	8D 17 50		STA CORH4
0119	5534	A9 59	LMP1	LDA #<RED1 ;LOAD LOW BYTE OF RED1 ADDR.
0120	5536	85 F6		STA HOLDER
0121	5538	A9 55		LDA #>RED1 ;LOAD HIGH BYTE OF ADDR.
0122	553A	85 F7		STA HOLDER+1
0123	553C	AD 01 50		LDA LAMP
0124	553F	8D 20 50		STA LOMP
0125	5542	AD 07 50		LDA CURL1 ;LOAD THE CURRENT FOR #1
0126	5545	8D 1B 50		STA DACL
0127	5548	AD 06 50		LDA CURH1
0128	554B	8D 1C 50		STA DACH
0129	554E	20 5D 56		JSR DAK ;CONVERT TO ANALOGE.
0130	5551	A9 01		LDA #\$01 ;TURN LAMP #1 ON.
0131	5553	8D 00 AC		STA PBD
0132	5556	4C 75 56		JMP KLOK
0133	5559	AD 1D 50	RED1	LDA ADCL ;LOAD CURRENT READING BY A/D.
0134	555C	8D 10 50		STA CORL1
0135	555F	AD 1E 50		LDA ADCH

0136	5562	8D 11 50		STA CORH1	
0137	5565	A9 00		LDA #00	;TURN OFF THE LAMP.
0138	5567	8D 00 AC		STA PRD	
0139	556A	A9 71		LDA #LMP2	
0140	556C	85 F6		STA HOLDER	;SAVE RETURNE ADDR.
0141	556E	4C 8D 56		JMP TIMOFF	
0142	5571	CE 20 50	LMP2	DEC LOMP	
0143	5574	00 03		RNE TWO	
0144	5576	4C 34 55		JMP LMP1	
0145	5579	AD 09 50	TWO	LDA CURL2	
0146	557C	8D 1B 50		STA DACL	
0147	557F	AD 08 50		LDA CURH2	
0148	5582	8D 1C 50		STA DACH	
0149	5585	20 5D 56		JSR DAK	
0150	5588	A9 02		LDA #02	;TURN LAMP #2 ON.
0151	558A	8D 00 AC		STA PRD	
0152	558D	A9 94		LDA #RED2	
0153	558F	85 F6		STA HOLDER	
0154	5591	4C 75 56		JMP KLOK	
0155	5594	AD 1D 50	RED2	LDA ADCL	
0156	5597	8D 12 50		STA CORL2	
0157	559A	AD 1E 50		LDA ADCH	
0158	559D	8D 13 50		STA CORH2	
0159	55A0	A9 00		LDA #00	
0160	55A2	8D 00 AC		STA PRD	
0161	55A5	A9 AC		LDA #LMP3	
0162	55A7	85 F6		STA HOLDER	
0163	55A9	4C 8D 56		JMP TIMOFF	
0164	55AC	CE 20 50	LMP3	DEC LOMP	
0165	55AF	00 03		RNE THREE	
0166	55B1	4C 34 55		JMP LMP1	

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LINE #	LOC	CODE	LINE		
0167	55B4	AD 0B 50	THREE	LDA CURL3	
0168	55B7	8D 1B 50		STA DACL	
0169	55BA	AD 0A 50		LDA CURH3	
0170	55BD	8D 1C 50		STA DACH	
0171	55C0	20 5D 56		JSR DAK	
0172	55C3	A9 04		LDA #04	;TURN LAMP #3 ON.
0173	55C5	8D 00 AC		STA PRD	
0174	55C8	A9 CF		LDA #RED3	
0175	55CA	85 F6		STA HOLDER	
0176	55CC	4C 75 56		JMP KLOK	
0177	55CF	AD 1D 50	RED3	LDA ADCL	
0178	55D2	8D 14 50		STA CORL3	
0179	55D5	AD 1E 50		LDA ADCH	
0180	55D8	8D 15 50		STA CORH3	
0181	55DB	A9 00		LDA #00	

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0182 55D0 8D 00 AC      STA PRD
0183 55E0 A9 E7        LDA #KCLMP4
0184 55E2 B5 F6        STA HOLDER
0185 55E4 4C 8D 56      JMP TIMOFF
0186 55E7 CE 20 50      LMP4 DEC LOMP
0187 55EA D0 03        BNE FOUR
0188 55EC 4C 34 55      JMP LMP1
0189 55EF AD 0D 50      FOUR LDA CURL4
0190 55F2 8D 1B 50      STA DACL
0191 55F5 AD 0C 50      LDA CURH4
0192 55F8 BD 1C 50      STA DACH
0193 55FB 20 5D 56      JSR DAK
0194 55FE A9 08        LDA #*08      ;TURN LAMP #4 ON.
0195 5600 8D 00 AC      STA PRD
0196 5603 A9 0E        LDA #KRED4
0197 5605 B5 F6        STA HOLDER
0198 5607 A9 56        LDA #>RED4
0199 5609 B5 F7        STA HOLDER+1
0200 560B 4C 75 56      JMP KLOK
0201 560E AD 1D 50      RED4 LDA ADCL
0202 5611 8D 16 50      STA CORL4
0203 5614 AD 1E 50      LDA ADCH
0204 5617 BD 17 50      STA CORH4
0205 561A A9 00        LDA #*00
0206 561C 8D 00 AC      STA PRD
0207 561F A9 34        LDA #KCLMP1
0208 5621 B5 F6        STA HOLDER
0209 5623 A9 55        LDA #>LMP1
0210 5625 B5 F7        STA HOLDER+1
0211 5627 4C 8D 56      JMP TIMOFF
0212 562A A9 00        PULS LDA #*00      ;TURN THE LAMP OFF.
0213 562C 8D 00 AC      STA PRD
0214 562F 20 4D 83      JSR CRLF
0215 5632 A9 F0        ;LAMP PULSING I/O PORT.
0216 5634 8D 02 AC      STA PRDD
0217 5637 A9 C0        ;SET REGISTER FOR TIMER-1.
0218 5639 8D 0B AC      STA ACR
0219 563C AD 22 50      LDA CLOCK    ;LOAD TIMER-1 LOW LATCH.
0220 563F 8D 04 AC      STA TILL
0221 5642 AD 23 50      LDA CLOCK+1  ;LOAD TIMER-1 HIGH COUNTER.

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LINE # LOC      CODE      LINE
0222 5645 8D 05 AC      STA TICH
0223 5648 AD 0E 50      LDA AVCRH    ;LOAD AVE. CURRENT.
0224 564B 8D 1C 50      STA DACH
0225 564E AD 0F 50      LDA AVCRL
0226 5651 8D 1B 50      STA DACL
0227 5654 20 5D 56      JSR DAK
0228 5657 A9 00        LDA #*00    ;START PULSING.

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0229	5659	8D 00 AC		STA RBD	
0230	565C	60		RTS	
0231	565D	AD 1E 50	DAR	LDA DACL	;LOAD LOW 8 BITS
0232	5660	49 FF		EDR #\$FF	;TWO'S COMPLEMENT
0233	5662	8D 01 A0		STA RAD	
0234	5665	AD 1C 50		LDA DACH	;LOAD HIGH 4 BITS
0235	5668	49 FF		EDR #\$FF	
0236	566A	0A		ASL A	;SHIFT LEFT FOR STROBE BIT
0237	566B	8D 00 A0		STA RBD	
0238	566E	EE 00 A0		INC RBD	;STROBE DAC
0239	5671	CE 00 A0		DEC RBD	
0240	5674	60		RTS	
0241	5675	AD 00 50	KLOK	LDA ON	;SET THE CLOCK.
0242	5678	8D 17 A4		STA SR	
0243	567B	A9 80	WEET	LDA #\$80	
0244	567D	2C 02 A4		BIT DRB	;TEST IF (CR) IS PUSHED.
0245	5680	D0 08		BNE CUT1	
0246	5682	2C 17 A4		BIT SR	;TEST IF IT IS DONE.
0247	5685	10 F4		BPL WEET	
0248	5687	4C AE 56		JMP ADK	
0249	568A	4C 2A 56	CUT1	JMP PULS	
0250	568D	AE 03 50	TIMOFF	LDX TLOOP	
0251	5690	F0 16	LOOK	BEQ BACK	
0252	5692	AD 02 50		LDA DARK	
0253	5695	8D 17 A4		STA SR	
0254	5698	A9 80	VEET	LDA #\$80	
0255	569A	2C 02 A4		BIT DRB	
0256	569D	D0 0C		BNE CUT2	
0257	569F	2C 17 A4		BIT SR	
0258	56A2	10 F4		BPL VEET	
0259	56A4	CA		DEX	
0260	56A5	4C 90 56		JMP LOOK	
0261	56A8	6C F6 00	BACK	JMP (HOLDER)	
0262	56AB	4C 2A 56	CUT2	JMP PULS	
0263	56AE	A9 C5	ADK	LDA #\$C5	;USE INPUT #1 OF A/D.
0264	56B0	8D 00 AB		STA DRB	
0265	56B3	CE 00 AB		DEC DRB	;START CONVERSION
0266	56B6	EE 00 AB		INC DRB	
0267	56B9	A9 40		LDA #\$40	
0268	56BB	2C 00 AB	TEST	BIT DRB	;TEST FOR END OF CONV.
0269	56BE	D0 FB		BNE TEST	
0270	56C0	AD 01 AB		LDA DRA	;READ 8 HIGH BITS
0271	56C3	8D 1E 50		STA ADCH	
0272	56C6	A9 C7		LDA #\$C7	;TRANSFER 4 LOW BITS
0273	56C8	8D 00 AB		STA DRB	
0274	56CB	AD 01 AB		LDA DRA	;READ 4 LOW BITS
0275	56CE	8D 1D 50		STA ADCL	
0276	56D1	A2 04		LDX #\$04	;REARRANGE DATA

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LINE #	LOC	CODE	LINE
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0277 56D3 18          GO      CLC
0278 56D4 4E 1E 50    LSR ADCH
0279 56D7 6E 1D 50    ROR ADCL
0280 56DA CA          DEY
0281 56DB D0 F6      RNE GO
0282 56DD 6C F6 00    JMP (HOLDER)
0283 56E0            ;
0284 56E0            ;***** THIS PORTION COLLECT & STORE DATA ****
0285 56E0            ;
0286 56E0 A0 00      LDY #00          ;SET Y AS COUNTER.
0287 56E2 A9 00      CLEAR LDA #00    ;CLEAR ALL DATA STORAGES.
0288 56E4 99 46 50    STA ARY11,Y
0289 56E7 99 0E 51    STA ARY1B,Y
0290 56EA 99 D6 51    STA ARY23,Y
0291 56ED 99 9E 52    STA ARY31,Y
0292 56F0 99 66 53    STA ARY3B,Y
0293 56F3 99 2E 54    STA ARY43,Y
0294 56F6 C8          INY
0295 56F7 C0 C8      CPY #200
0296 56F9 D0 E7      RNE CLEAR
0297 56FB A0 00      LDY #00          ;SET Y AS POINT COUNTER.
0298 56FD A9 0F      DATA LDA #0F     ;SET PBD AS OUTPUT.
0299 56FF 8D 02 AC    STA PBDD        ;FOR LAMP PULSING.
0300 5702 AD 18 50    LUP  LDA LAF     ;SAVE # OF LAPS/POINT.
0301 5705 8D 1F 50    STA LOP
0302 5708 AD 01 50    LUMP LDA LAMP     ;SAVE # OF LAMPS AT LOMP.
0303 570B 8D 20 50    STA LOMP        ;LAMP COUNTER.
0304 570E AD 1A 50    SOB1 LDA READ     ;SAVE # OF READING/PULSE.
0305 5711 8D 21 50    STA REED        ;READ COUNTER.
0306 5714 AD 07 50    LDA CURL1
0307 5717 8D 1B 50    STA DACL
0308 571A AD 06 50    LDA CURH1
0309 571D 8D 1C 50    STA DACH
0310 5720 20 5D 56    JSR DAK
0311 5723 A9 00      LDA #00
0312 5725 8D 00 AC    STA PBD
0313 5728 20 46 59    JSR TIMOF
0314 572B 20 16 59    AGAIN1 JSR ATDC
0315 572E 18          CLC
0316 572F AD 1D 50    LDA ADCL
0317 5732 79 DC 50    ADC ARY1A,Y
0318 5735 99 DC 50    STA ARY1A,Y
0319 5738 AD 1E 50    LDA ADCH
0320 573B 79 0E 51    ADC ARY1B,Y
0321 573E 99 0E 51    STA ARY1B,Y
0322 5741 A9 00      LDA #00
0323 5743 79 40 51    ADC ARY1C,Y
0324 5746 99 40 51    STA ARY1C,Y
0325 5749 CE 21 50    DEC REED
0326 574C F0 03      REO ADD1
0327 574E 4C 2B 57    JMP AGAIN1
0328 5751 AD 1A 50    ADD1 LDA READ
0329 5754 8D 21 50    STA REED

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0330 5757 A9 01          LDA #01
0331 5759 8D 00 AC      STA FBD

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LINE # LOC      CODE      LINE
0332 575C 20 5A 59          JSR DELAY          ;WAIT FOR TIME CONSTANT.
0333 575F 20 16 59      AGIN1 JSR ATDC
0334 5762 18              CLC                ;CLEAR CARRY.
0335 5763 AD 1D 50          LDA ADCL           ;LOAD LOW 8 BITS.
0336 5766 79 46 50          ADC ARY11,Y        ;ADD TO FIRST ARY.
0337 5769 99 46 50          STA ARY11,Y        ;SAVE IT IN FIRST ARY.
0338 576C AD 1E 50          LDA ADCH           ;LOAD HIGH 8 BITS.
0339 576F 79 78 50          ADC ARY12,Y        ;ADD TO SECOND ARY.
0340 5772 99 78 50          STA ARY12,Y        ;SAVE IT IN SECOND ARY.
0341 5775 A9 00              LDA #00
0342 5777 79 AA 50          ADC ARY13,Y        ;USE THIRD ARY FOR OVERFLOW.
0343 577A 99 AA 50          STA ARY13,Y
0344 577D CE 21 50          DEC REED
0345 5780 F0 03              BEQ NXT1           ;ALL DONE GO TO NEXT POSITION.
0346 5782 4C 5F 57          JMP AGIN1          ;NOT DONE, DO THE NEXT.
0347 5785 CE 20 50      NXT1  DEC LOMP          ;CHECK # OF LAMPS.
0348 5788 D0 03              BNE SOB2           ;NOT LAST ONE, GO TO NEXT.
0349 578A 4C 02 59          JMP CUT
0350 578D AD 1A 50      SOB2  LDA READ
0351 5790 8D 21 50          STA REED
0352 5793 AD 09 50          LDA CURL2
0353 5796 8D 1B 50          STA DACL
0354 5799 AD 08 50          LDA CURH2
0355 579C 8D 1C 50          STA DACH
0356 579F 20 5D 56          JSR DAK
0357 57A2 A9 00              LDA #00
0358 57A4 8D 00 AC          STA FBD
0359 57A7 20 46 59          JSR TIMOF
0360 57AA 20 16 59      AGAN2 JSR ATDC
0361 57AD 18              CLC
0362 57AE AD 1D 50          LDA ADCL
0363 57B1 79 08 52          ADC ARY2A,Y
0364 57B4 99 08 52          STA ARY2A,Y
0365 57B7 AD 1E 50          LDA ADCH
0366 57BA 79 3A 52          ADC ARY2B,Y
0367 57BD 99 3A 52          STA ARY2B,Y
0368 57C0 A9 00              LDA #00
0369 57C2 79 6C 52          ADC ARY2C,Y
0370 57C5 99 6C 52          STA ARY2C,Y
0371 57C8 CE 21 50          DEC REED
0372 57CB F0 03              BEQ ADD2
0373 57CD 4C AA 57          JMP AGAN2
0374 57D0 AD 1A 50      ADD2  LDA READ
0375 57D3 8D 21 50          STA REED

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0376 57E6 A9 02          LDA #02          ;LAMP #2 ON
0377 57E8 8D 00 AC      STA FRD
0378 57DB 20 5A 59      JSR DELAY
0379 57DE 20 16 59      AGIN2 JSR ATDC
0380 57E1 1B           CLC
0381 57E2 AD 1D 50      LDA ADCL
0382 57E5 79 72 51      ADC ARY21,Y
0383 57E8 99 72 51      STA ARY21,Y
0384 57EB AD 1E 50      LDA ADCH
0385 57EE 79 A4 51      ADC ARY22,Y
0386 57F1 99 A4 51      STA ARY22,Y

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LINE #	LOC	CODE	LINE
0387	57F4	A9 00	LDA #00
0388	57F6	79 D6 51	ADC ARY23,Y
0389	57F9	99 D6 51	STA ARY23,Y
0390	57FC	CE 21 50	DEC REED
0391	57FF	F0 03	BEQ NXT2
0392	5801	4C DE 57	JMP AGIN2
0393	5804	CE 20 50	NXT2 DEC LOMP
0394	5807	D0 03	BNE SOB3
0395	5809	4C 02 59	JMP CUT
0396	580C	AD 1A 50	SOB3 LDA READ
0397	580F	8D 21 50	STA REED
0398	5812	AD 0B 50	LDA CURL3
0399	5815	8D 1B 50	STA DACL
0400	5818	AD 0A 50	LDA CURH3
0401	581B	8D 1C 50	STA DACH
0402	581E	20 5D 56	JSR DAK
0403	5821	A9 00	LDA #00
0404	5823	8D 00 AC	STA FRD
0405	5826	20 46 59	JSR TIMOF
0406	5829	20 16 59	AGAN3 JSR ATDC
0407	582C	1B	CLC
0408	582D	AD 1D 50	LDA ADCL
0409	5830	79 34 53	ADC ARY3A,Y
0410	5833	99 34 53	STA ARY3A,Y
0411	5836	AD 1E 50	LDA ADCH
0412	5839	79 66 53	ADC ARY3B,Y
0413	583C	99 66 53	STA ARY3B,Y
0414	583F	A9 00	LDA #00
0415	5841	79 98 53	ADC ARY3C,Y
0416	5844	99 98 53	STA ARY3C,Y
0417	5847	CE 21 50	DEC REED
0418	584A	F0 03	BEQ ADD3
0419	584C	4C 29 58	JMP AGAN3
0420	584F	AD 1A 50	ADD3 LDA READ
0421	5852	8D 21 50	STA REED
0422	5855	A9 04	LDA #04 ;LAMP #3 ON.

0423	5857	8D 00 AC		STA PRD
0424	585A	20 5A 59		JSR DELAY
0425	585D	20 16 59	AGIN3	JSR ATIC
0426	5860	18		CLC
0427	5861	AD 1D 50		LDA ADCL
0428	5864	79 9E 52		ADC ARY31,Y
0429	5867	99 9E 52		STA ARY31,Y
0430	586A	AD 1E 50		LDA ADCH
0431	586D	79 D0 52		ADC ARY32,Y
0432	5870	99 D0 52		STA ARY32,Y
0433	5873	A9 00		LDA #00
0434	5875	79 02 53		ADC ARY33,Y
0435	5878	99 02 53		STA ARY33,Y
0436	587B	CE 21 50		DEC REED
0437	587E	F0 03		BEQ NXT3
0438	5880	4C 5D 56		JMP AGIN3
0439	5883	CE 20 50	NXT3	DEC LOMP
0440	5886	D0 03		BNE SOB4
0441	5888	4C 02 59		JMP CUT

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LINE #	LOC	CODE	LINE	
0442	588B	AD 1A 50	SOB4	LDA READ
0443	588E	8D 21 50		STA REED
0444	5891	AD 0D 50		LDA CURL4
0445	5894	8D 1B 50		STA DACL
0446	5897	AD 0C 50		LDA CURH4
0447	589A	8D 1C 50		STA DACH
0448	589D	20 5D 56		JSR DAK
0449	58A0	A9 00		LDA #00
0450	58A2	8D 00 AC		STA PRD
0451	58A5	20 46 59		JSR TIMDF
0452	58A8	20 16 59	AGAN4	JSR ATIC
0453	58AB	18		CLC
0454	58AC	AD 1D 50		LDA ADCL
0455	58AF	79 60 54		ADC ARY4A,Y
0456	58B2	99 60 54		STA ARY4A,Y
0457	58B5	AD 1E 50		LDA ADCH
0458	58B8	79 92 54		ADC ARY4B,Y
0459	58BB	99 92 54		STA ARY4B,Y
0460	58BE	A9 00		LDA #00
0461	58C0	79 04 54		ADC ARY4C,Y
0462	58C3	99 04 54		STA ARY4C,Y
0463	58C6	CE 21 50		DEC REED
0464	58C9	F0 03		BEQ SOB4
0465	58CB	4C A8 50		JMP AGAN4
0466	58CE	AD 1A 50	ADD4	LDA READ
0467	58D1	8D 21 50		STA REED
0468	58D4	A9 00		LDA #00
0469	58D6	8D 00 AC		STA PRD

;LAMP #4 ON

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0470 58D9 20 5A 59      JSR DELAY
0471 58DC 20 16 59      AGIN4 JSR ATDC
0472 58DF 18          CLC
0473 58E0 AD 1D 50      LDA ADCL
0474 58E3 79 CA 53      ADC ARY41,Y
0475 58E6 99 CA 53      STA ARY41,Y
0476 58E9 AD 1E 50      LDA ADCH
0477 58EC 79 FC 53      ADC ARY42,Y
0478 58EF 99 FC 53      STA ARY42,Y
0479 58F2 A9 00          LDA #00
0480 58F4 79 2E 54      ADC ARY43,Y
0481 58F7 99 2E 54      STA ARY43,Y
0482 58FA CE 21 50      DEC REED
0483 58FD F0 03          BEQ OUT
0484 58FF 4C DC 58      JMP AGIN4
0485 5902 CE 1F 50      CUT  DEC LOP          ;ALL LAPS DONE?
0486 5905 F0 03          BEQ GETOT          ;YES, GO FOR NEXT POINT.
0487 5907 4C 08 57      JMP LUMP          ;NO, START AGAIN.
0488 590A CB          GETOT INY
0489 590B CC 19 50      CPY POINT          ;ALL THE POINTS COLLECTED!
0490 590E F0 03          BEQ OUT          ;YES, GO OUT.
0491 5910 4C 02 57      JMP LUP          ;NO, DO THE NEXT.
0492 5913 4C 2A 56      OUT  JMP PULS
0493 5916 A9 E5          ATDC LDA #E5          ;USE INPUT #5 OF A/D.
0494 5918 8D 00 A8      STA DRB
0495 591B CE 00 A8      DEC DRB
0496 591E EE 00 A8      INC DRB

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LINE # LOC      CODE      LINE
0497 5921 A9 40          LDA #40
0498 5923 2C 00 AB      CHEK BIT DRB
0499 5926 D0 FB          BNE CHEK
0500 5928 AD 01 AB      LDA DRA
0501 592B 8D 1E 50      STA ADCH
0502 592E A9 E7          LDA #E7
0503 5930 8D 00 AB      STA DRB
0504 5933 AD 01 AB      LDA DRA
0505 5936 8D 1D 50      STA ADCL
0506 5939 A2 04          LDX #04
0507 593B 18          NXTGO CLC
0508 593C 4E 1E 50      LSR ADCH
0509 593F 6E 1D 50      ROR ADCL
0510 5942 CA          DEX
0511 5943 D0 F6          BNE NXTGO
0512 5945 60          RTS
0513 5946 AE 04 50      TIMOF LDX TIMLOP          ;# OF TIME LOOP (1 OR 5).
0514 5949 F0 0F      DOIT BEQ DELAY
0515 594B AD 05 50      LDA OFF
0516 594E 8D 17 A4      STA SR

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0517 5951 20 17 A4 WAIT BIT SR
0518 5954 10 FB BPL WAIT
0519 5956 CA DEX
0520 5957 40 49 59 JMP DOIT
0521 595A AD 24 50 DELAY LDA TM
0522 595D 8D 25 50 STA MT
0523 5960 A9 32 DELAY LDA #50 ;DELAY TIME FOR TIME CONSTANT.
0524 5962 8D 14 A4 STA PW
0525 5965 20 17 A4 WAIT BIT SR
0526 5968 10 FB BPL WAIT
0527 596A CE 25 50 DEC MT
0528 596D D0 F1 BNE DLAY
0529 596F 60 RTS
0530 5970 .END

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SYMBOL TABLE

SYMBOL VALUE

ACR	AC0B	ADCH	501E	ADCL	501D	ADD1	5751
ADD2	57D0	ADD3	584F	ADD4	58CE	ADK	56AE
AGAN1	572B	AGAN2	57AA	AGAN3	5829	AGAN4	58A9
AGIN1	575F	AGIN2	57DE	AGIN3	5B5D	AGIN4	58DC
ARY11	5046	ARY12	5078	ARY13	50AA	ARY1A	50DC
ARY1B	510E	ARY1C	5140	ARY21	5172	ARY22	51A4
ARY23	51D6	ARY2A	5208	ARY2B	523A	ARY2C	526C
ARY31	529E	ARY32	52D0	ARY33	5302	ARY3A	5334
ARY3B	5366	ARY3C	5398	ARY41	53CA	ARY42	53FC
ARY43	542E	ARY4A	5460	ARY4B	5492	ARY4C	54C4
ATDC	5916	AVCRH	500E	AVCRL	500F	BACK	56A9
CHEK	5923	CLEAR	56E2	CLOCK	5022	CDRH1	5011
CORH2	5013	CORH3	5015	CORH4	5017	CORL1	5010
CDRL2	5012	CORL3	5014	CORL4	5016	CRLF	034D
CURH1	5006	CURH2	5008	CURH3	500A	CURH4	500C
CURL1	5007	CURL2	5009	CURL3	500B	CURL4	500D
CUT	5902	CUT1	56BA	CUT2	56AB	DACH	501C
DACL	501B	DAK	565D	DARK	5002	DATA	56FD
DDRA	A803	DDR8	A802	DELAY	595A	DLAY	5960
DOIT	5949	DRA	A801	DR8	A800	FOUR	55EF
GETDT	590A	GD	56D3	HOLDER	00F6	KLOK	5675
LAMP	5001	LAP	5018	LMP1	5534	LMP2	5571
LMP3	55AC	LMP4	55E7	LOMP	5020	LOOK	5690
LDP	501F	LUMP	5708	LUP	5702	MT	5025
NXT1	57B5	NXT2	5804	NXT3	5B93	NXTG0	593B
OFF	5005	ON	5000	ORB	A402	OUT	5913
PAD	AC01	PADD	AC03	PBD	AC00	PRDD	AC02
POINT	5019	PULS	562A	PW	A414	RAD	A001
RADD	A003	RBD	A000	RBDD	A002	READ	501A
RED1	5559	RED2	5594	RED3	55CF	RED4	560E
REED	5021	SRB1	570E	SRB2	578D	SRB3	580C
SRB4	508B	SR	A417	T1CH	AC05	T1LL	AC04
TEST	56BB	THREE	55B4	TIMLOP	5004	TIMOF	5946
TIMOFF	568D	TLOOP	5003	TM	5024	TWO	5579
WAIT	5951	VEET	5698	WAIT	5965	WEET	567B